

# Organic semiconductors

# Inorganic vs organic

In inorganic semiconductors as Si or Ge, atoms are bonded together by very strong covalent bonds.

Electrons and holes can freely move within a periodic structure

$(m_{eff})$

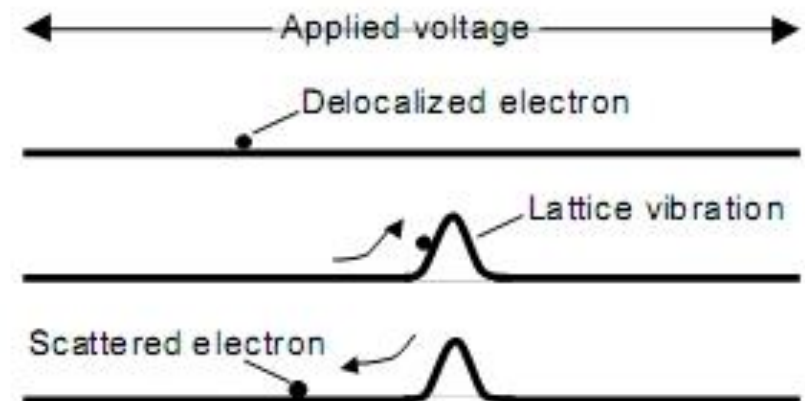
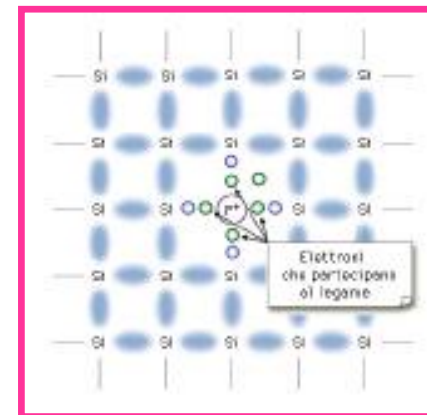
Charge carriers can be considered as delocalized planar waves  
very high mobility

- Perfect crystal structure
- continuous bands
- Scattering limited:

*Impurities*

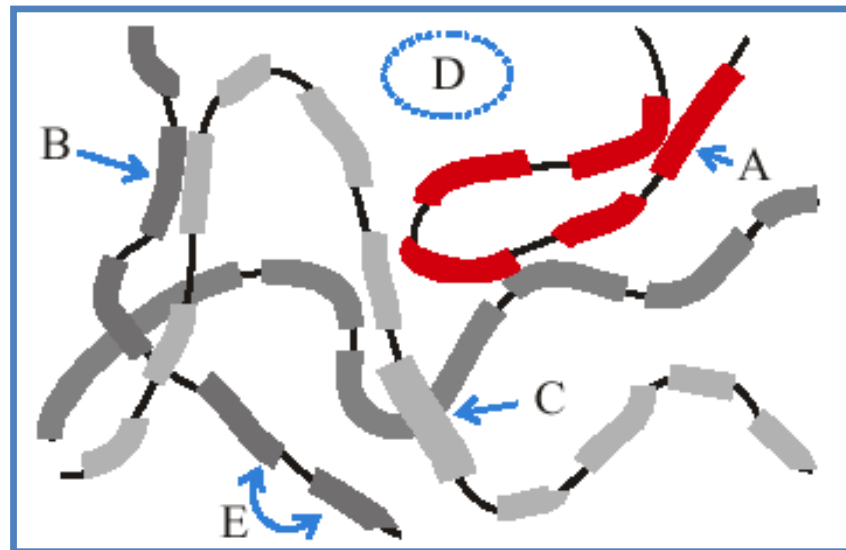
*Phonons*

- **Mobility decreases with Temperature**



# Organic semiconductors

- Very low molecular crystal degree: polycrystalline or amorphous films
- Randomly oriented molecules that interacts with very small forces (*Van Der Waals*)
- Charge carriers, free mean path could be smaller than interatomic distance!
- Worse delocalization, charge carriers moves through localized energetic states → **Hopping**

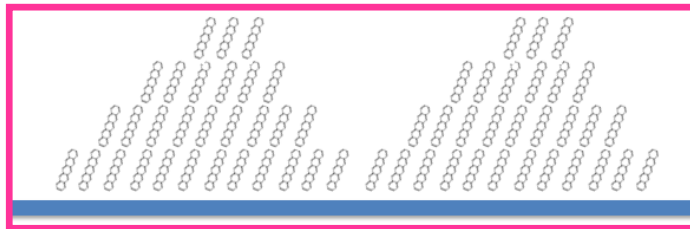
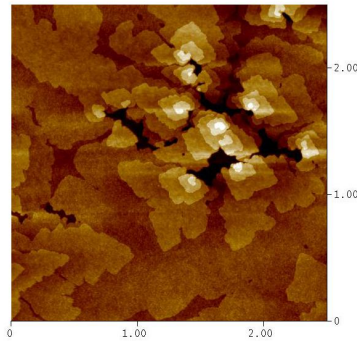


# The polaron

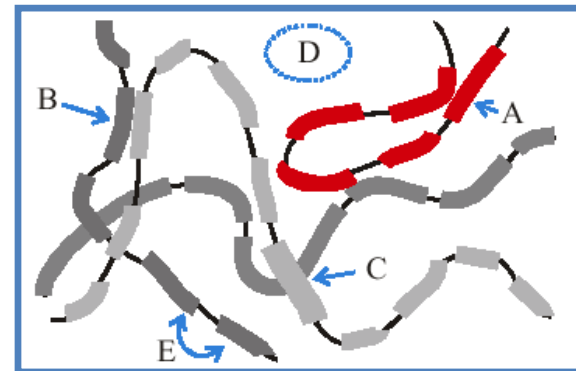
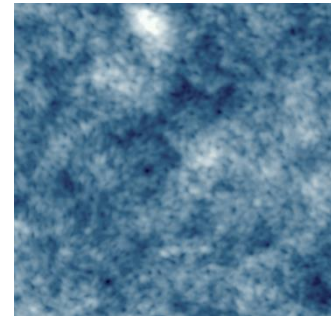
In a film we generally have

- Hopping transport when small polarons are present
- Band like transport when large polarons are present

## Oligomers



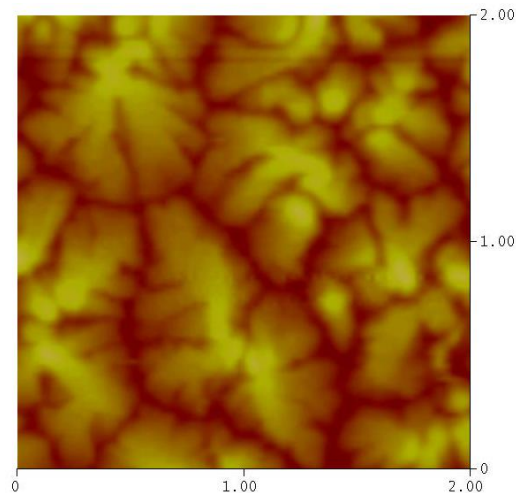
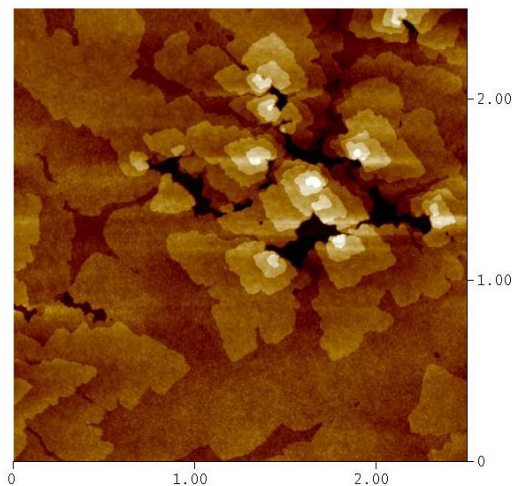
## Polymers





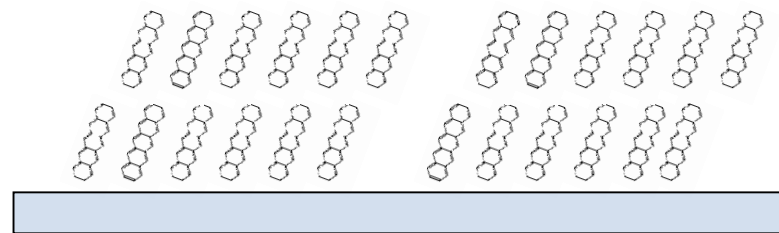
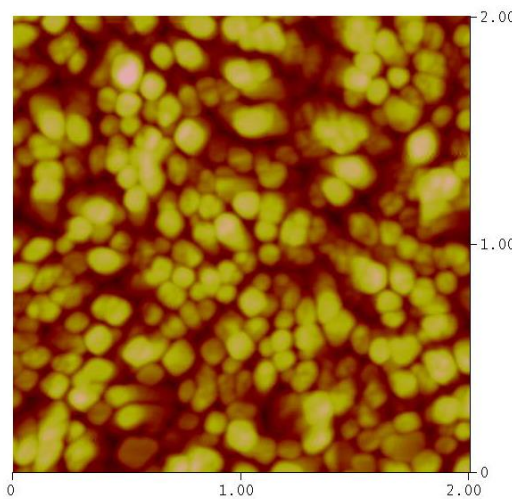
# Influence of morphology

Charge transport is strongly influenced by the film morphological/structural properties



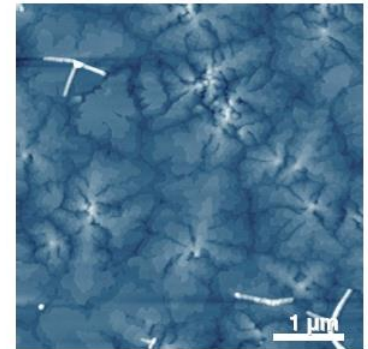
Polycrystalline films with domains containing randomly oriented molecules

When the molecule are better assembled  $\rightarrow$  terraces

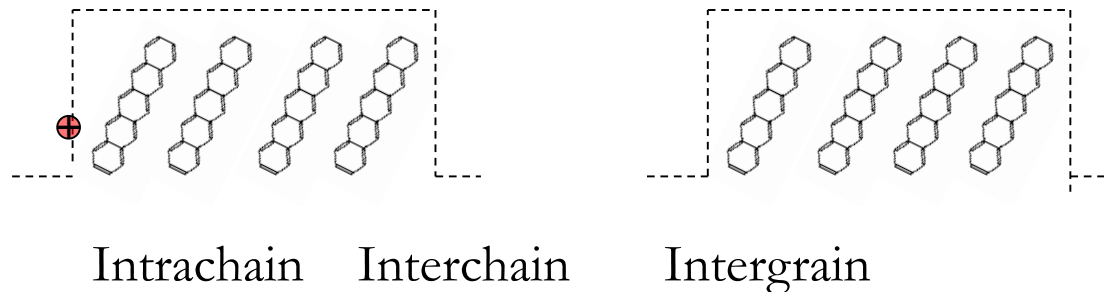


# Morphological/structural properties of the organic semiconductor thin film:

- Low crystallinity
- Hopping transport
- Phonon assisted  $\rightarrow$  thermal activation
- Transport through three different levels



Pentacene su SiO<sub>2</sub>



- 1) Molecular packing (pi-stacking)
- 2) Domains structure

## Thermal activation

From band-like transport to hopping

$$\mu = \mu_0 \exp \left[ -(T_0/T)^{1/\alpha} \right]$$

## Huge dependance of mobility on the applied field

(> 10<sup>5</sup>V/cm)

$$\mu(E) = \mu(0) \exp \left[ \frac{q}{kT} \beta \sqrt{E} \right]$$

Gate voltage dependance of mobility in organic transistors

# Molecular packaging (pi-stacking)

Rodlike molecules (pentacene, oligomeri del thiophene)

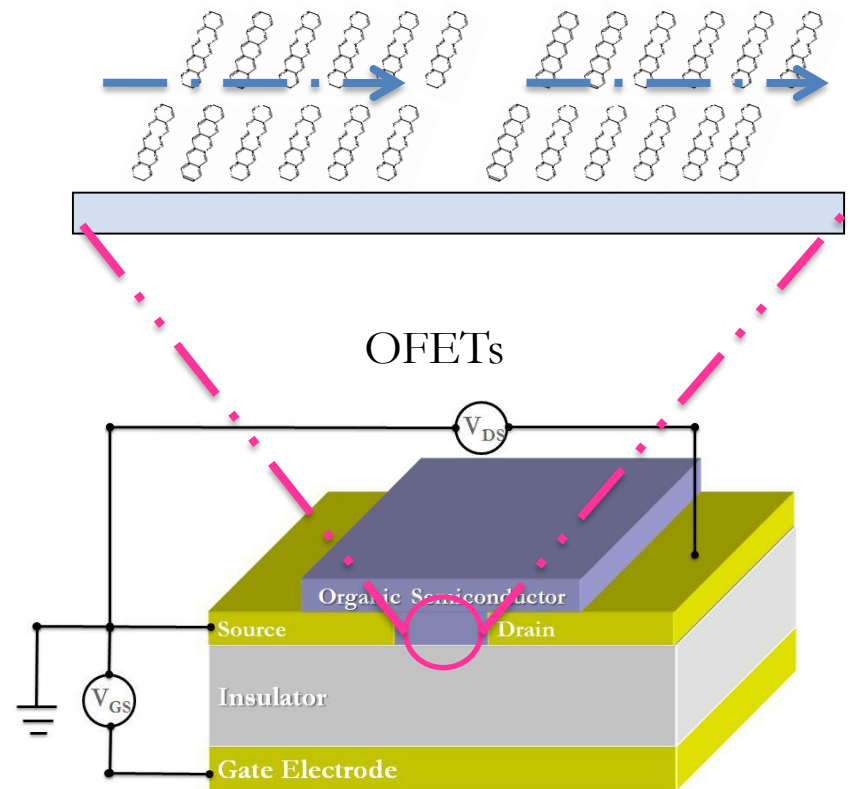
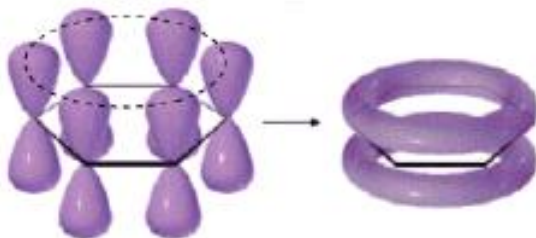
Preferential direction

Higher degree of crystallinity

Less grain boundaries

Higher  $\pi$  orbitals overlapping

Pi-stacking between molecules

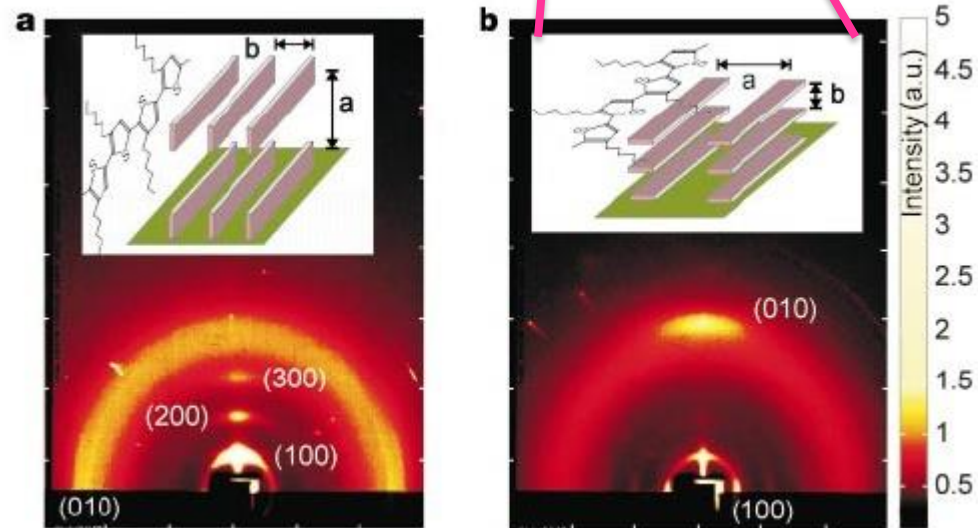
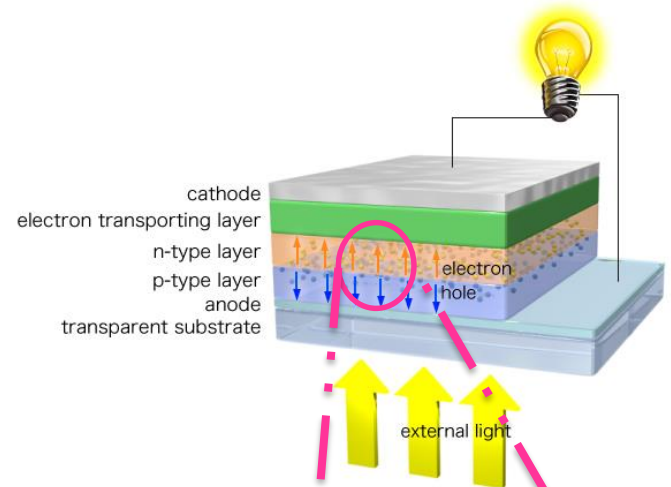


# Molecular packaging(pi-stacking)

## OSCs e OLEDs

Conduction must be improved vertically!!!

Molecules should be forced to pack themselves perpendicularly in order to maximize charge transport



## Inorganic semiconductors

- Crystal structure
- Continuous bands
- Scattering limited:  
*Impurities*  
*Phononi*
- Mobility decreases with temperature

## Organic semiconductors

- No crystal structure
- Discrete energetic levels
- Phonon assisted transport
- Mobility increases with temperature, thermal activation

# Doping in conjugated molecules

# Doping in conjugated molecules

Generally the conductivity in these molecules is small, but can be improved by doping

There are different doping approaches:

- Chemical doping
- Electrochemical doping
- Photo-induced doping
- Charge injection doping

The first two methods are the most employed ones

Both p and n type doping

Oxidation leads to p type doping



# Doping in conjugated molecules

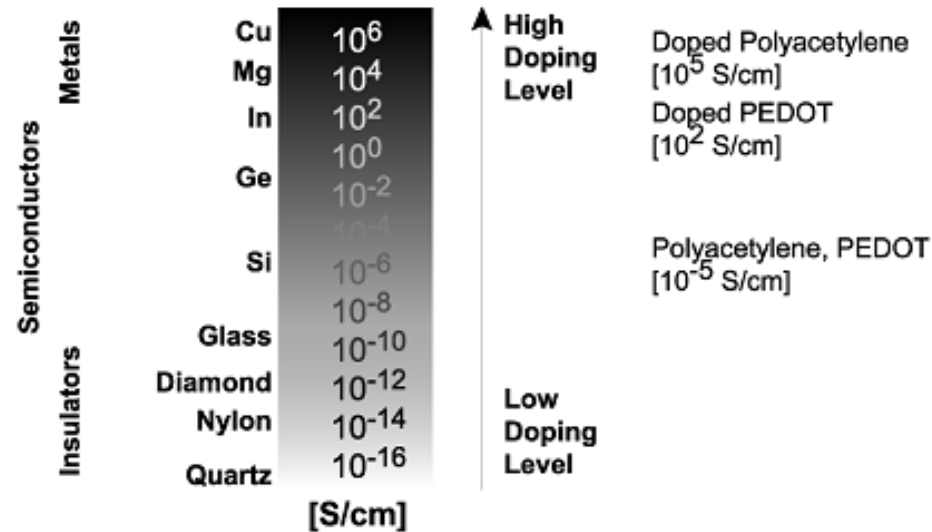
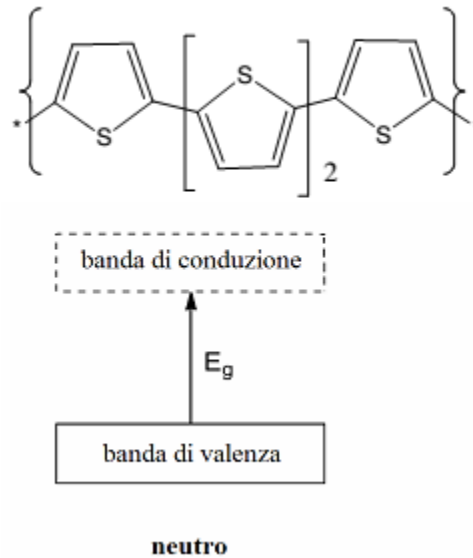


Figure 2. Conductivity levels of polyacetylene and PEDOT. In comparison, conductivity of some other materials is given, from very good insulators to metallic conductors.

The chemical doping in this molecules is completely different than what happens in inorganic crystal structures

Reversible oxidation-reduction process

# Doping in conjugated molecules



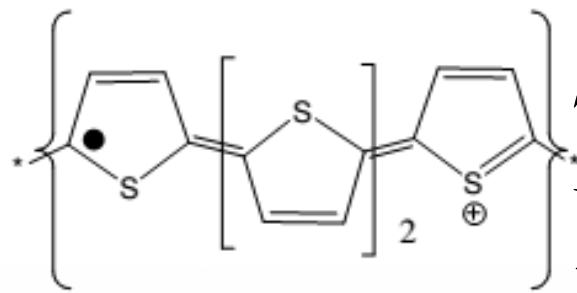
A conjugated polymer is neutral  $\rightarrow$  to promote one electron from the valence band up to the conduction band an energy larger than the band gap has to be spent

# Doping in conjugated molecules

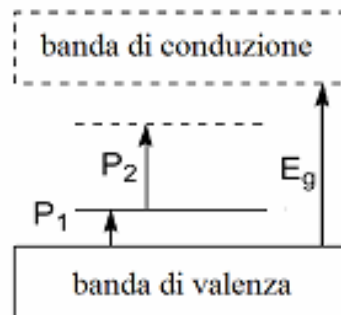
When a polymer gets oxidized, an electron is removed out of the molecule, as a consequence, a positive charge, hole, is created.

Actually, a couple radical-cation is created

This charge interacts with the the molecule, locally changing its bond geometry, thus creating the so called **POLARON**, which leads to a new energetic level within the band gap



The withdrawing of a  $\pi$  electron from the valence band creates polaronic states in the band gap



bassa ossidazione

**New energetic states → new absorption spectrum**

- Higher conductivity
- Electrochromic effect

# Doping in conjugated molecules

As a consequence, this doping leads to an increase of free charges, thus increasing the conductivity

$$\sigma = ne\mu$$

n number of charges, e electron charge,  $\mu$  mobility

There exist also a different effect, that we will not consider in this course, if the number of polarons is very high, they can interact within each other, leading, above a certain level of doping, to a decrease of conductivity.

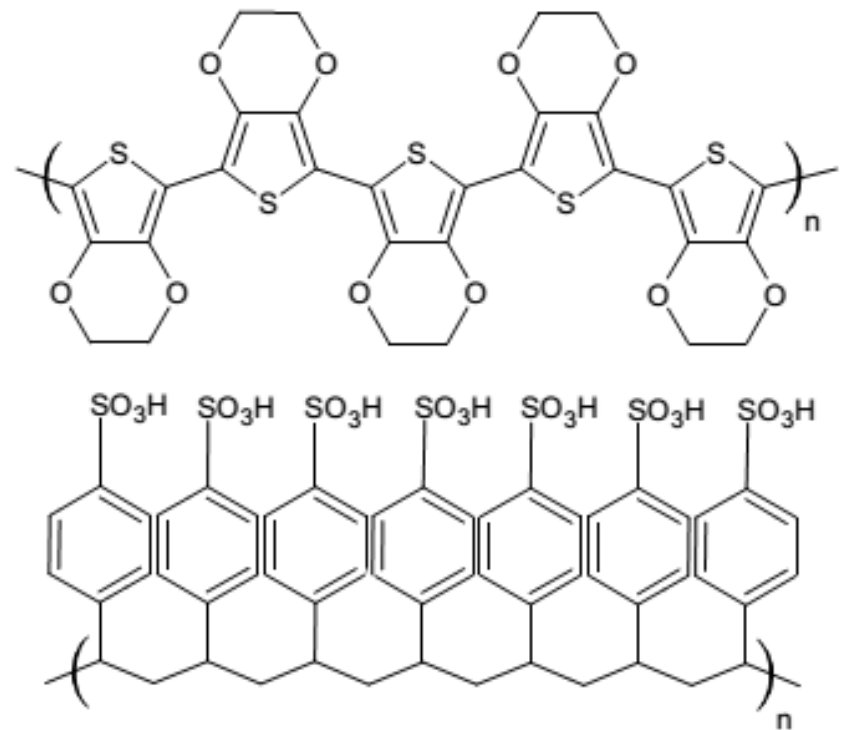
In any case, for the most of conjugated polymer there exist a huge window to work in, therefore, we have a big chance to significantly increase their electrical conductivity by doping

# Doping in conjugated molecules

Doping can be performed also chemically. For instance, it is possible to intentionally include in the molecule some functional groups which are electro-donors or electron-acceptors

**PEDOT** is an organic semiconductor,

**PSS** allows doping it and significantly increase its conductivity



# Conductive polymers

PEDOT:PSS is formed by two different molecules, PEDOT and PSS

PEDOT is polythiophene conjugated polymer

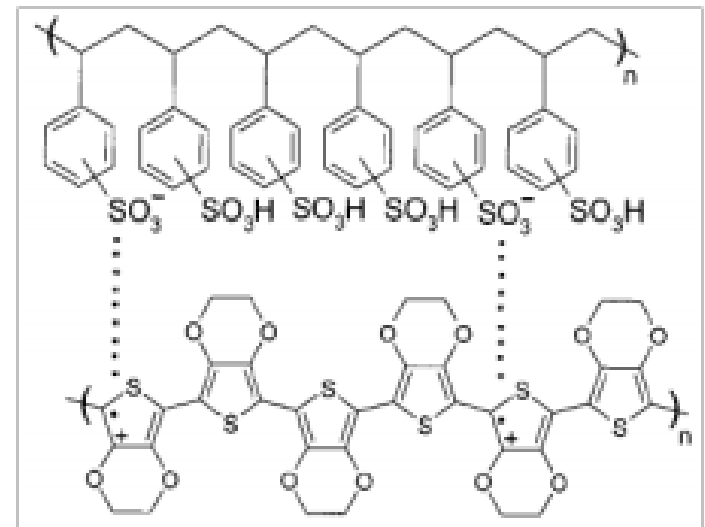
It is a semiconductor, and it is not soluble

PSS is a water soluble electrolyte, it oxidized the PEDOT, removing an electron from its backbone

Therefore, PEDOT is positively charged, whereas PSS is negatively charged

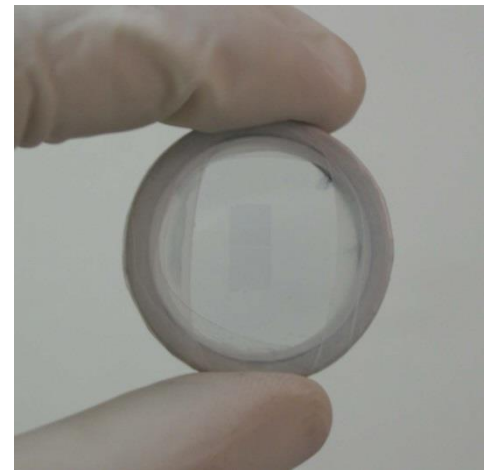
Creation of a polar blend (solution) between the two molecules

PEDOT<sup>+</sup>:PSS<sup>-</sup>



# PEDOT:PSS

- It PEDOT:PSS soluble, generally in water solution
- Depending on the ration between PEDOT and PSS its conductivity can be tuned
- Highest conductivity 1000 S/cm
- Can be deposited from solution in very thin films:
- Spin coating, inkjet printing, microcontact printing etc...
- Fabrication of large area devices at low costs
- When deposited in thin films it is transparent



# Conductive polymers

In tohe words, **PSS acts as a dopant**, leading to significantly increase the number of holes in the PEDOT backbone

However PSS is an insulator!

This means that depending on the way the PSS is finally deposited on the film dramatically influences the charge transport within the film

PSS for instance can create insulating islands surrounding the PEDOT molecules, thus not allowing the created charge carrirs to move freely → bad percolation

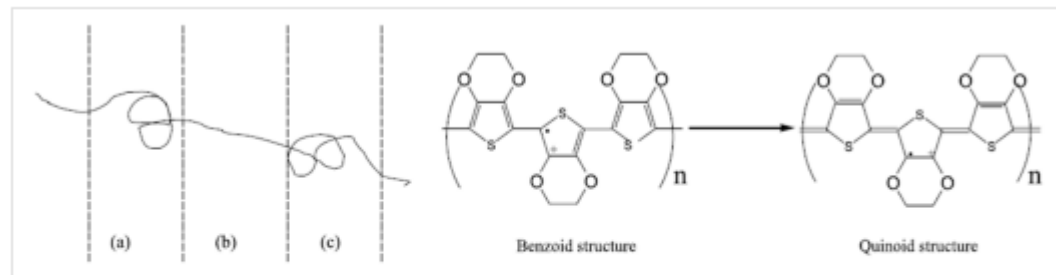
This issue can be significantly overcome by using post treatment processes, i.e. using some additives and thermal treatment to re-create the film morphology



# Conductive polymers

Among the many additives:

- methyl sulfoxide (DMSO),
- N,Ndimethyl formamide (DMF)
- Glycerol
- Sorbitol
- Ethylene Glycole



**Figure 2.18:** (Left) Schematic of untreated PEDOT chain coil conformation((a) and (c)) and EG-treated PEDOT chain linear conformation. (Right) Scheme of transformation of the PEDOT chain from the benzoid to the quinoid structure. [13]

# Conductive polymers

## Ethylene Glycole

Allows increasing conductivity

Gives the film a better stability in water

*Why?*

## Morphological changes in the film

- Reduction of PSS islands dimensions, highest probability for hopping
- Defolding of PEDOT molecules (less pronounced spaghetti configuration), reduction of selftrapping within the molecule

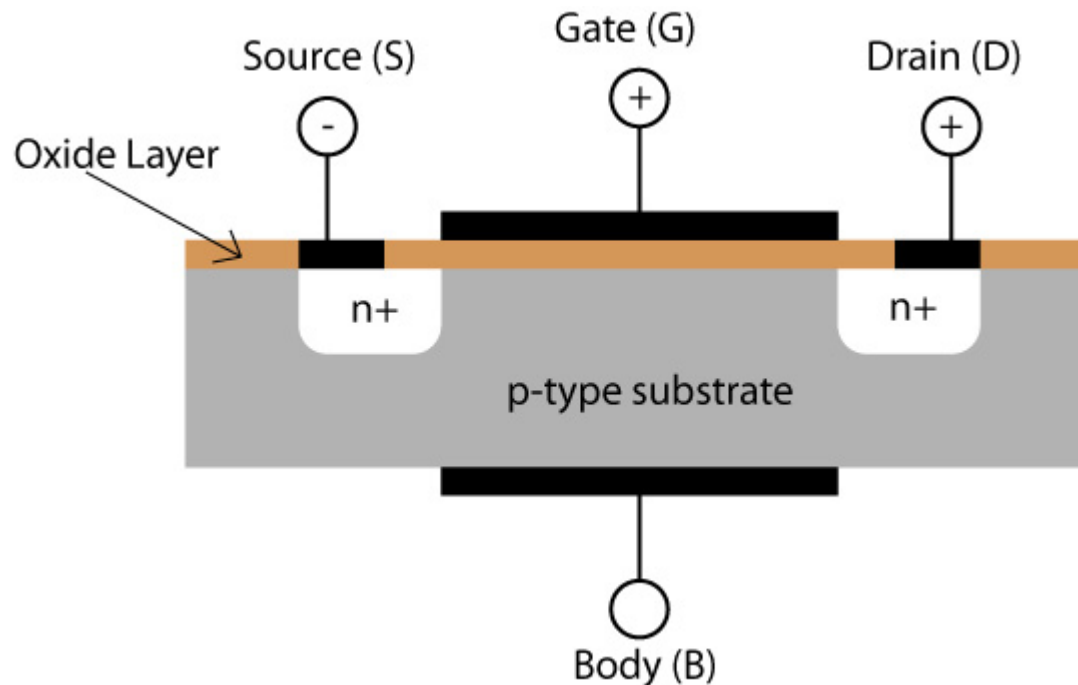
# Organic Field Effect Transistors

# MOSFET

The MOSFET is a FET in which the conductive channel is obtained by the inversion region of a MOS structure

The gate electrode is the the metal film of the MOS structure. It is insulated with the rest of the device through the gate oxide

In the MOSFET there are two more electrodes, SOURCE e DRAIN, and sometimes also the body electrode could be employed



# Organic Field Effect Transistor

Low mobility semiconductors  
Thin Film Transistors (TFT)

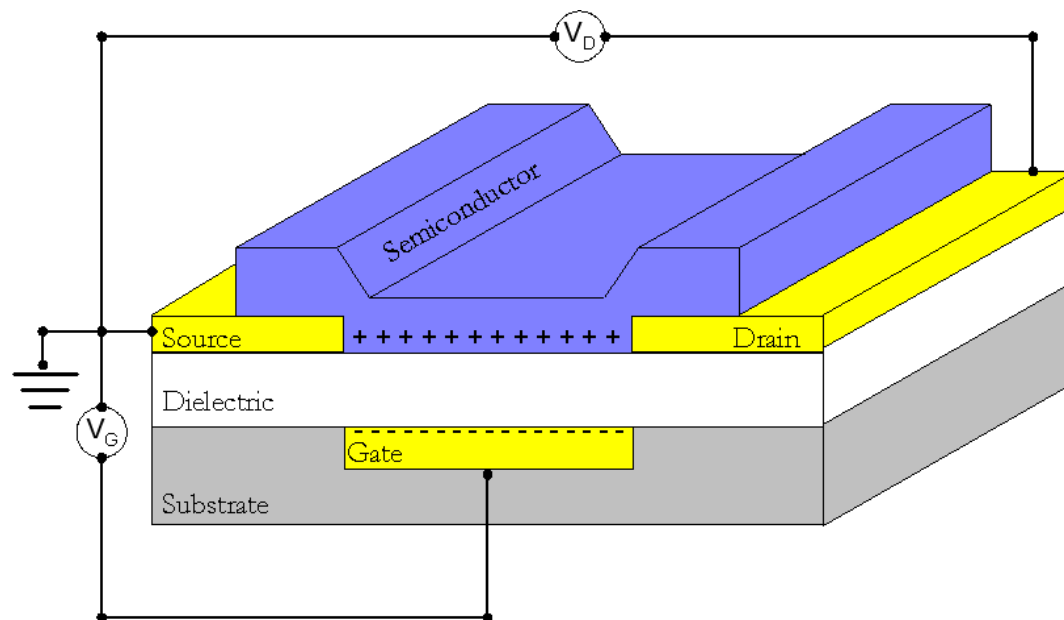
First examples

Substrate highly doped silicon  $\rightarrow$  Gate

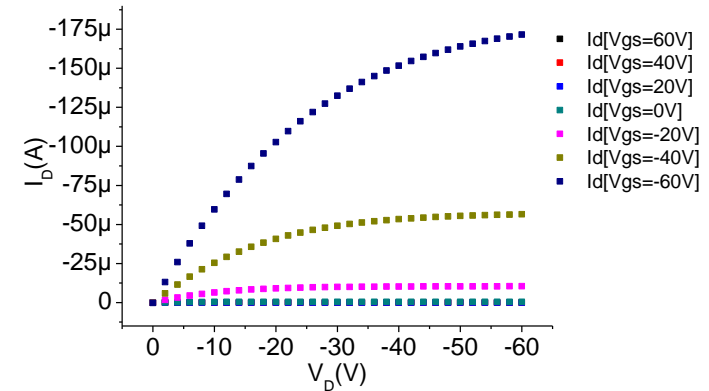
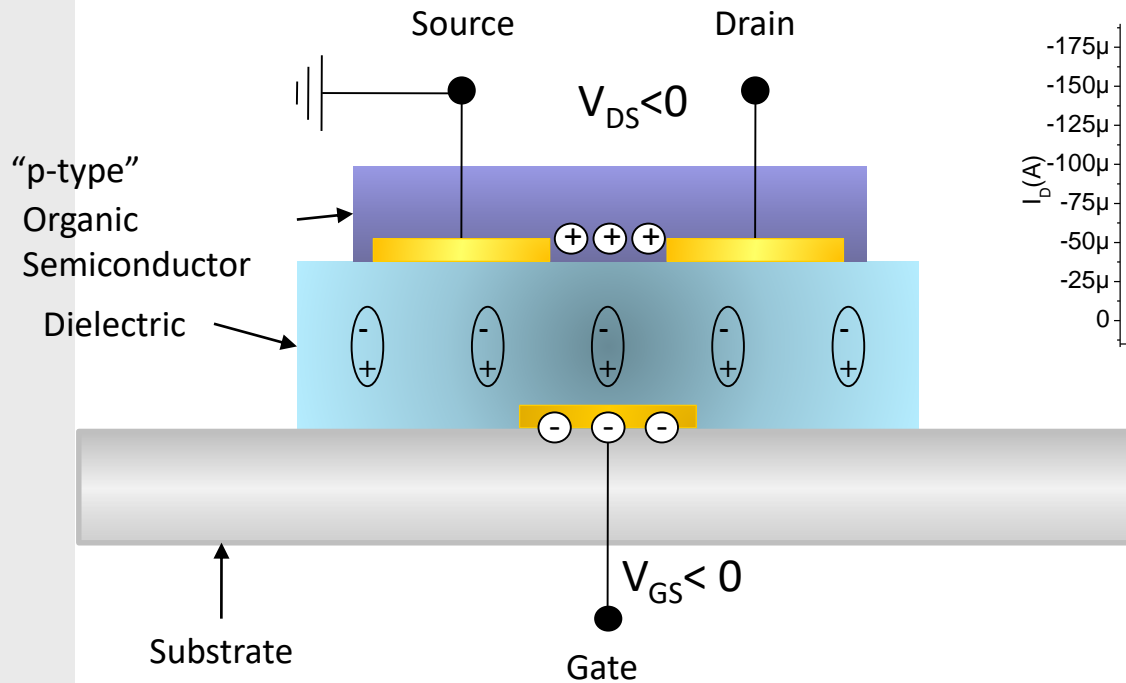
$\text{SiO}_2 \rightarrow$  gate oxide

Gold  $\rightarrow$  Source and Drain

Organic semiconductors  $\rightarrow$  Active layer forming the channel

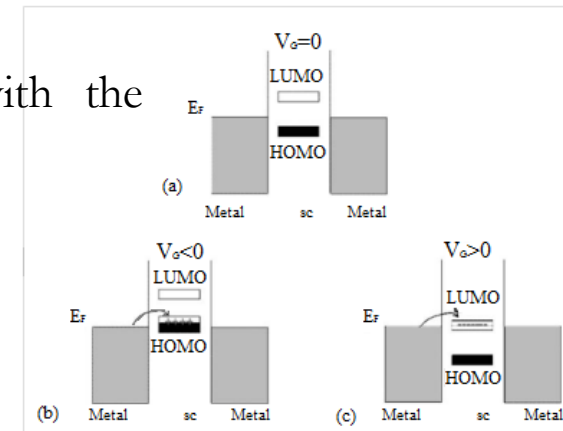


# Organic Thin Film Transistor (OTFT)

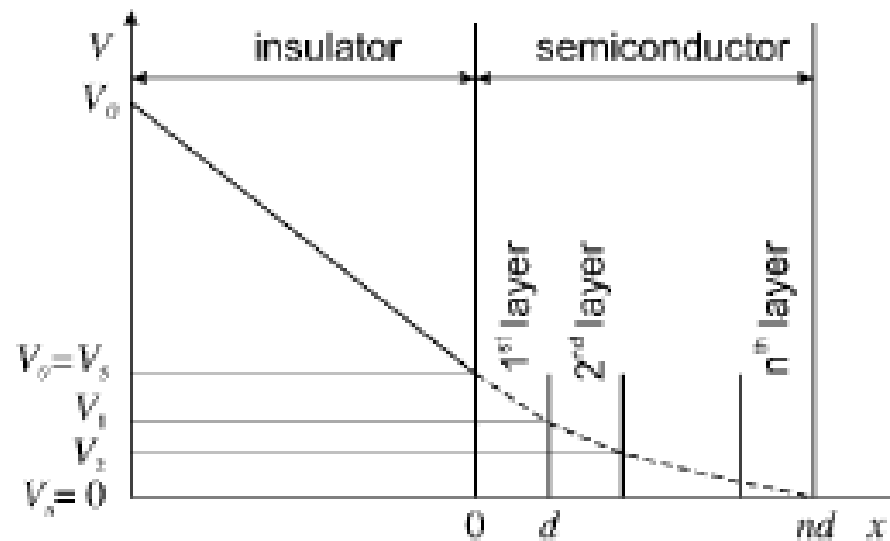


- The channel is already present, but, being the conductivity of the organic semiconductor very small, a low current flows
- P type semiconductor
- $V_{GS} < 0$ : holes accumulation at the interface with the dielectric
- $V_{DS} < 0$ : when channel is formed, current flows

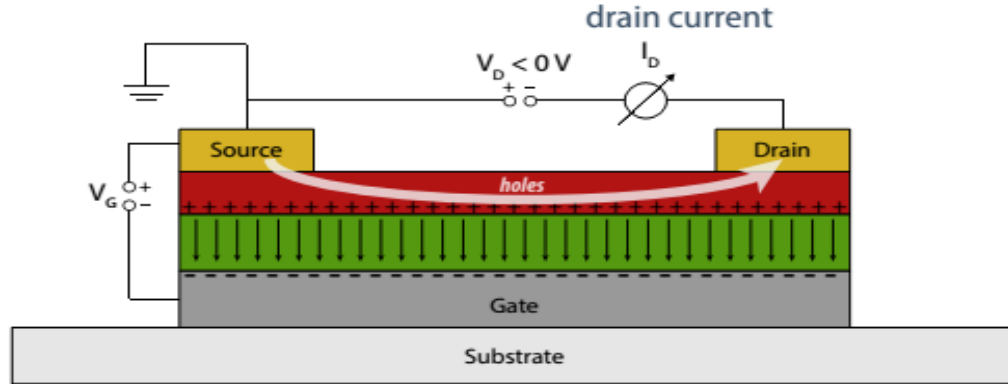
**The device works in ACCUMULATION**  
**N.B. MOSFET INVERSION**



- The channel is formed at the very interface with the insulating layer, only the first few monolayers are involved in charge conduction!!



# Linear Region



Imagine we have a small element of the channel  $dx$ . Its resistance  $dR$  is given by:

$$dR = \frac{dx}{Z\mu|Q(x)|} \quad (1)$$

Where  $Q(x)$  is the superficial charge along the x axes



# Linear Region

In an OFET charge contributions are: the **accumulation layer**  $Q_s$  and the **charge in the neutral region (bulk)**  $Q_0$

The latter has the following expression

$$Q_0 = \pm qn_0d_s \quad (2)$$

Where  $q$  is the electron charge,  $d_s$  is the organic semiconductor layer thickness and  $n_0$  is the free charges density

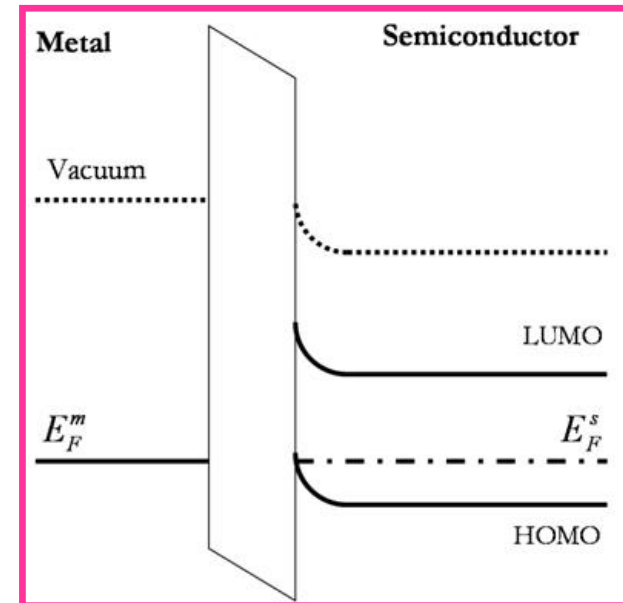
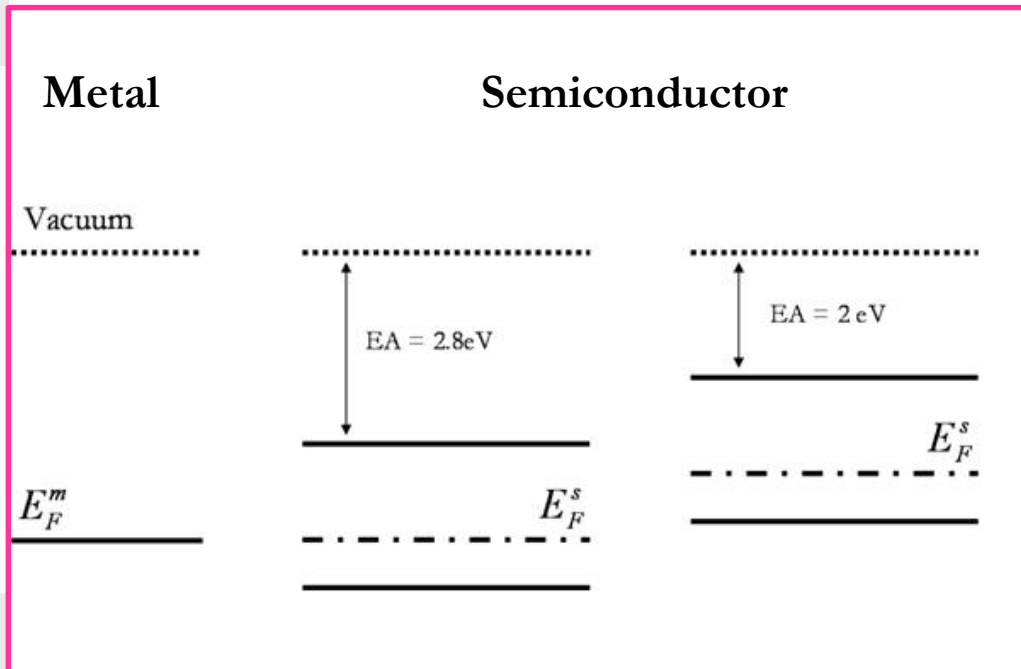
$$Q_s(x) = -C_i[V_g - V_{fb} - V_s(x) - V(x)] \quad (3)$$

$V_s(x)$  is the ohmic drop in the semiconductor which can be neglected

$V(x)$  voltage in the channel as function of position  $x$

## V<sub>fb</sub> is the flat band voltage

Different work functions between OS and Gate electrode, charges into the insulating layer



**V(x)**

*Gradual channel approximation  $L \gg d_s$*

When the transversal field ( $\mathbf{E}_y$  perpendicular with respect to current flow) in the channel is much larger than the longitudinal one ( $\mathbf{E}_x$  across the channel, parallel to current)

**V(x) only depends on drain voltage and linearly increases from 0 to  $V_d$  moving from the source to the drain**

$$dR = \frac{dx}{Z\mu|Q(x)|}$$

$$dV = I_d dR = \frac{I_d dx}{Z\mu|Q_s(x) + Q_0|} \quad (4)$$

Considering the previous expressions and making the integral function across the channel,  $x=0$ ,  $V=0$  at the source, whereas at the drain  $x=L$ ,  $V=V_d$  we obtain

$$I_d \int_0^L dx = \int_0^{V_d} Z\mu [C_i (V_g - V_{fb} - V) \pm qn_0 d_s] dV \quad (5)$$

Solving, considering the mobility constant

$$I_d = \frac{Z}{L} \mu C_i \left[ (V_g - V_0) V_d - \frac{V_d^2}{2} \right] \quad (6)$$

where:

$$V_0 = \pm \frac{qn_0 d_s}{C_i} + V_{FB} \quad (7)$$

A not negligible current could also flow when  $V_{gs}=0$  V

When a gate **voltage larger than the threshold** one is applied, if the voltage applied between source and **drain ( $V_{DS}$ ) is small** ( $V_G < V_{DS} < (V_G - V_T)$ ), the induced **electrical field is uniformly distributed** in the whole channel where we have an extended accumulation layer.

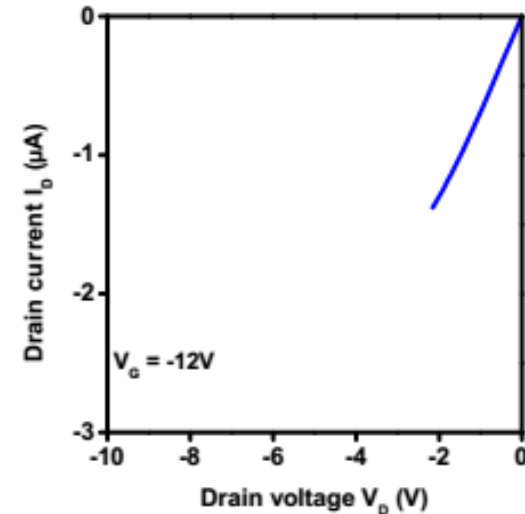
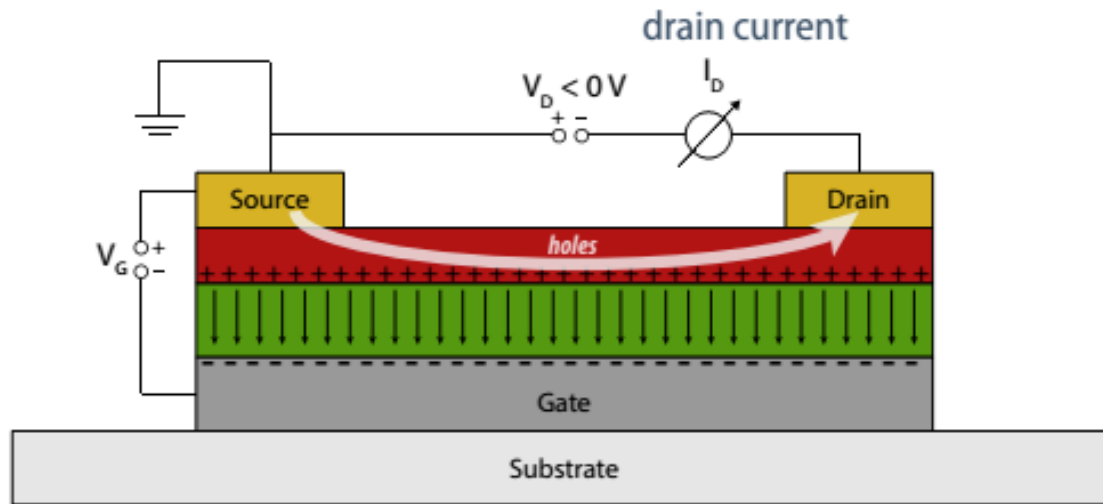
$$I_d = \frac{Z}{L} \mu C_i \left[ (V_g - V_t) V_d - \frac{V_d^2}{2} \right]$$

Z channel width, L channel length,  $C_i$  insulator capacitance  $\mu$  is carrier mobility in the channel

For small  $V_{DS}$ , ( $V_{DS} \ll V_{GS} - V_T$ ) charges are uniformly distributed into the channel

The channel behaves as a resistor

Linear Region

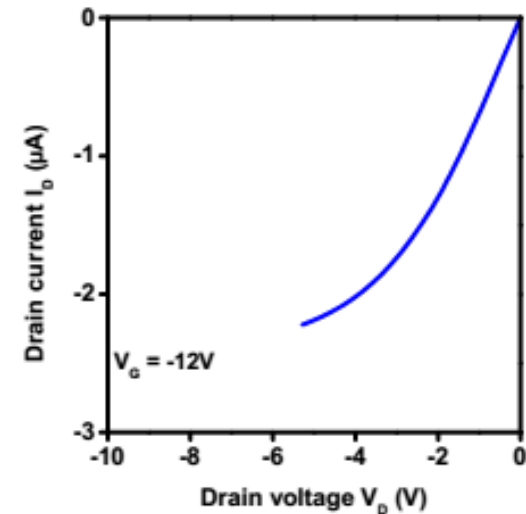
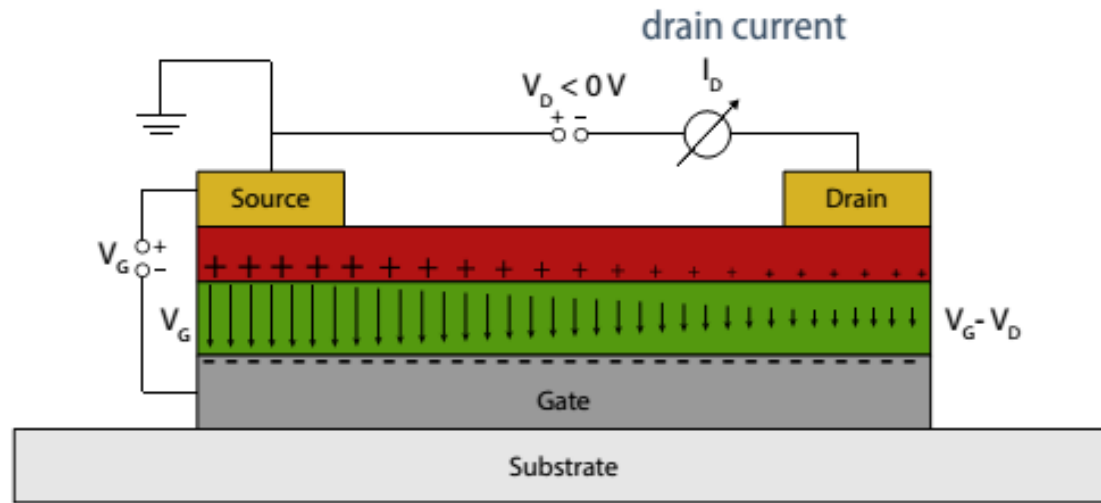


$$I_d = \frac{Z}{L} \mu C_i \left[ (V_g - V_t) V_d - \frac{V_d^2}{2} \right]$$

$$I_d = \frac{Z}{L} \mu C_i \cdot (V_g - V_t) V_d$$

When  $V_{DS}$  increases ( $V_{DS} \leq V_{GS} - V_T$ ) charge distribution is no longer uniform

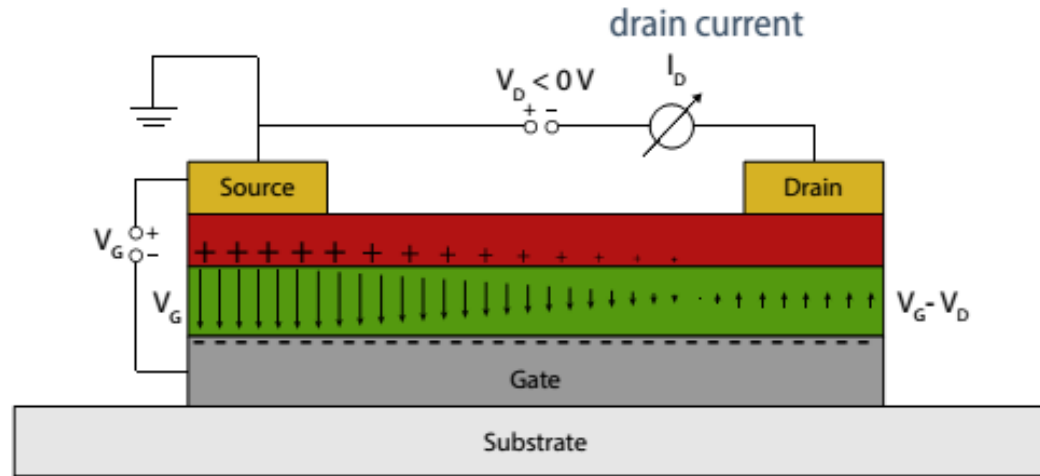
Current increases as a quadratic function



$$I_d = \frac{Z}{L} \mu C_i \left[ (V_g - V_t) V_d - \frac{V_d^2}{2} \right]$$

# Saturation Region

If  $V_{DS}$  keeps increasing the **channel becomes asymmetric** and thinner in the proximity of the drain



$V_{GD} = V_{GS} - V_{DS}$ , when  $V_{DS}$  increases,  $V_{GD}$  decreases

The vertical potential drops close to the drain ( $V_{DS} > 0$ )

Carrier concentration decreases

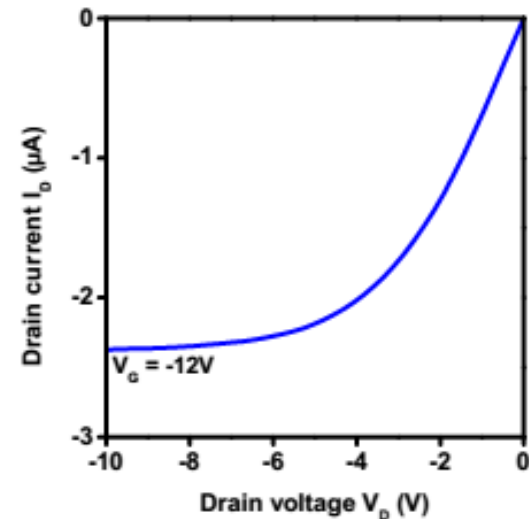
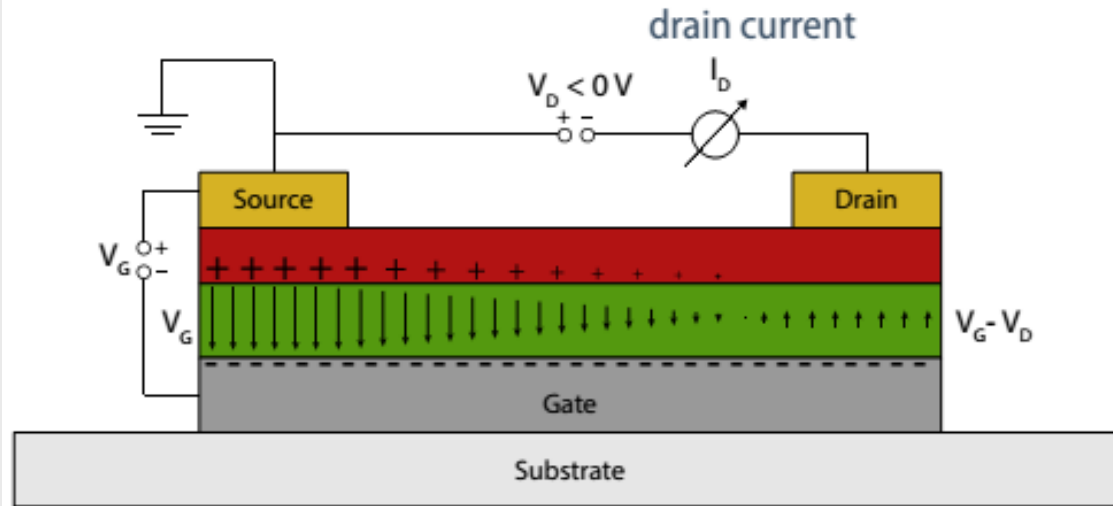
when  $V_{GD} = V_T$  pinch-off ( $V_T$  limit value below it the channel is fully depleted!)



# Saturation Region

Let's call  $V_{Dsat}$  the  $V_{DS}$  value leading to  $V_{GD} = V_T$

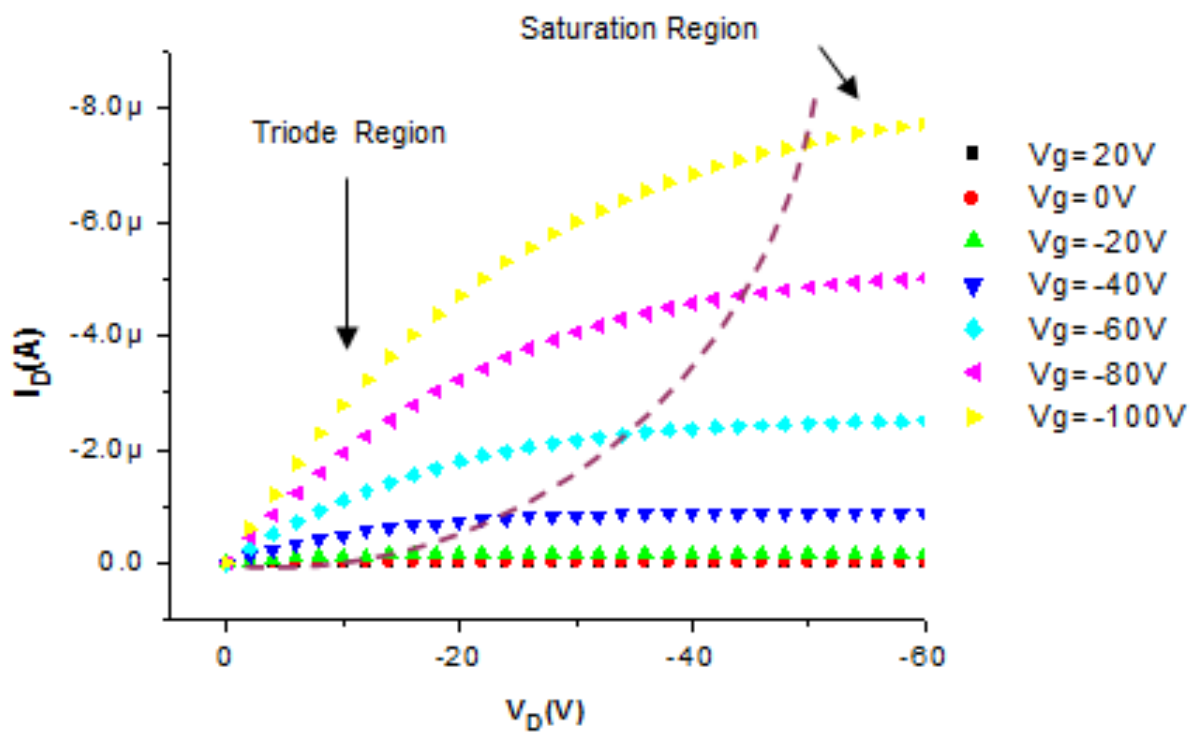
$$V_{GD} = V_T \rightarrow V_{GS} - V_{DS} = V_T \rightarrow V_{Dsat} = V_{GS} - V_T$$



$$I_d = \frac{Z}{L} \mu C_i \left[ (V_g - V_t) V_d - \frac{V_d^2}{2} \right]$$

$$V_{dsat} = (V_g - V_t)$$

$$I_{dsat} = \frac{Z}{2L} \mu C_i (V_g - V_t)^2$$



## How can we obtain such parameters from the electrical characteristics?

- Output Characteristics [ $I_d V_d$ ]
- Transfer Characteristics

*in linear and saturation regions*

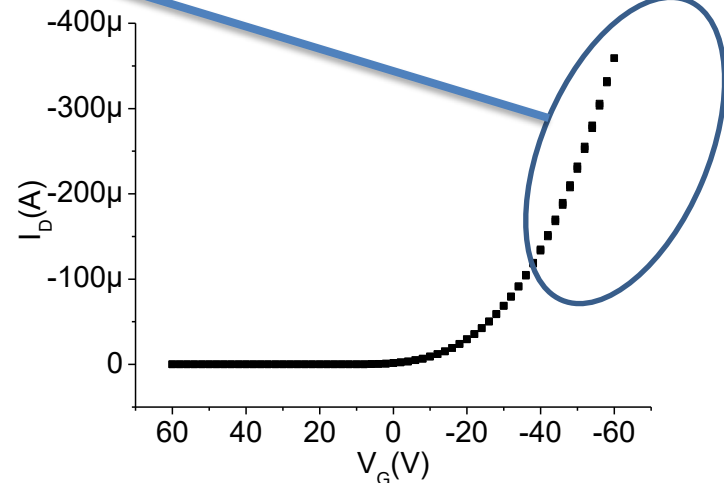
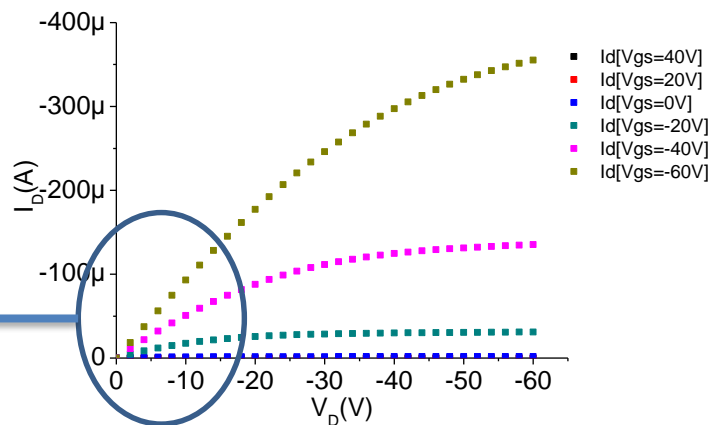
# Conductance and transconductance in the linear region

$$I_d = \frac{Z}{L} \mu C_i [(V_g - V_t) V_d]$$

$$g_d = \left. \frac{\partial I_D}{\partial V_D} \right|_{V_G = \text{const}} = \frac{Z}{L} \mu C_i (V_G - V_T) \quad (15)$$

$$g_m = \left. \frac{\partial I_D}{\partial V_G} \right|_{V_D = \text{const}} = \frac{Z}{L} \mu C_i V_D \quad (16)$$

$V_D$  small enough to be in linear region!

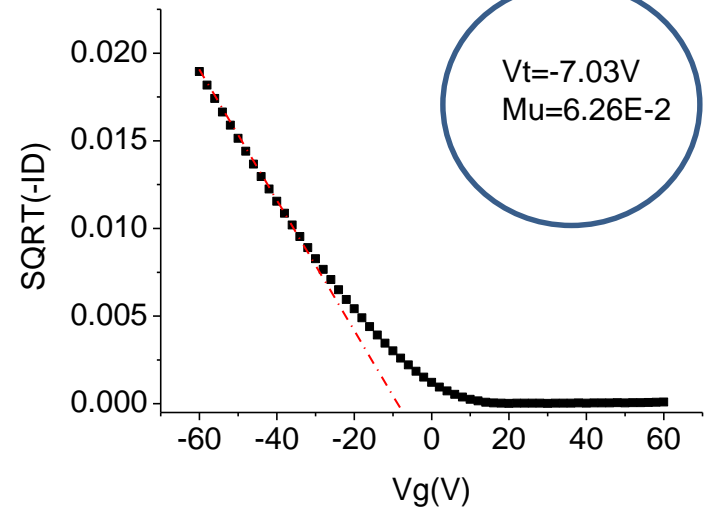
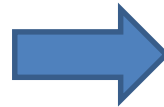
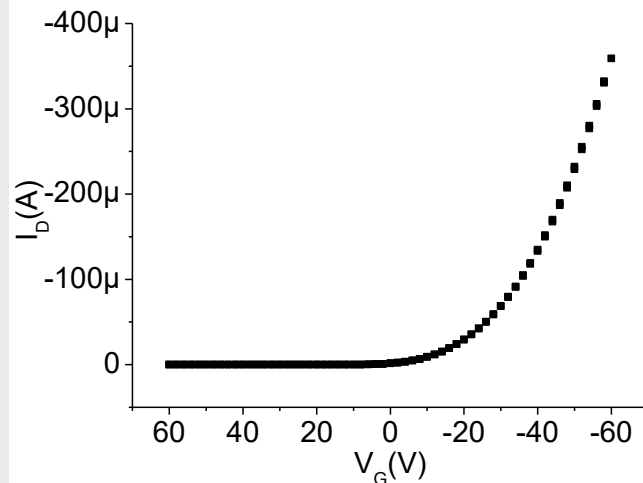


## Transconductance in saturation region

$$I_{dsat} = \frac{Z}{2L} \mu C_i (V_g - V_t)^2$$

$$g_m = \left. \frac{\partial I_D}{\partial V_G} \right|_{V_D = \text{const}} = \frac{Z}{L} \mu C_i (V_G - V_T) \quad (17)$$

$V_D$  high enough to be in saturation region!



How do I measure them?

$V_t = -7.03\text{V}$   
 $\mu = 6.26\text{E-}2$

# Typical OFETs electrical parameters

## Mobility

*Average values  $[10^{-1} - 10^{-2} \text{ cm}^2 / \text{Vs}]$*

## Off current and $I_{on}/I_{off}$

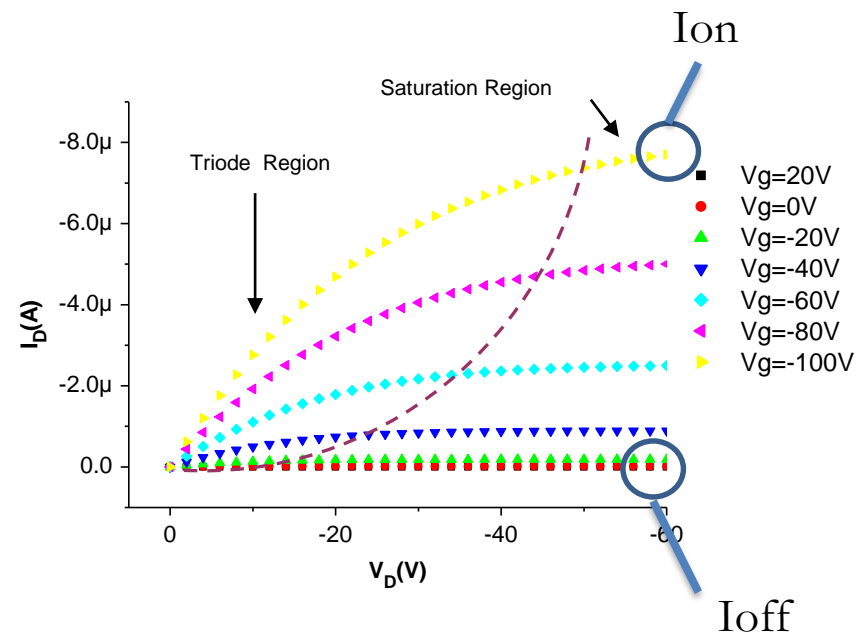
Off current is the current obtained when the device is off

*typical  $I_{on}/I_{off}$  values  $10^5 - 10^6$*

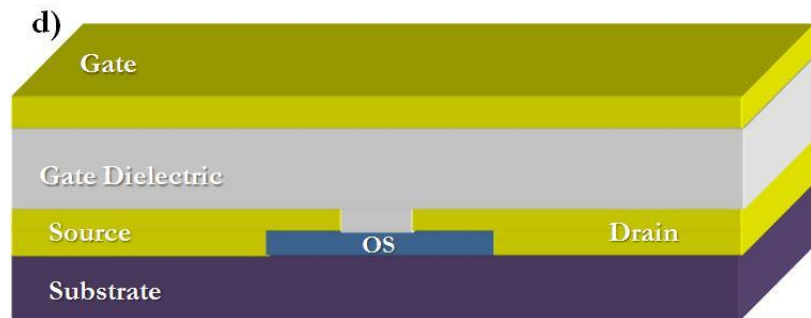
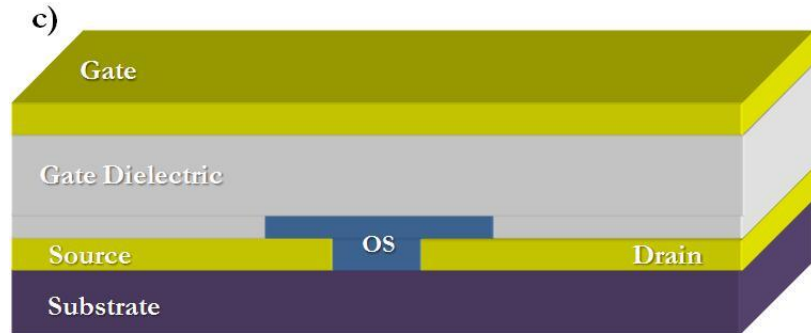
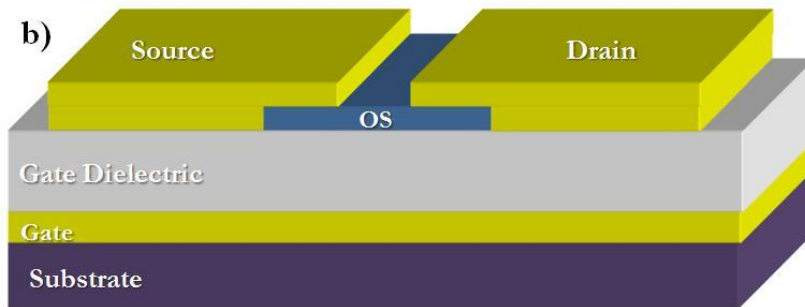
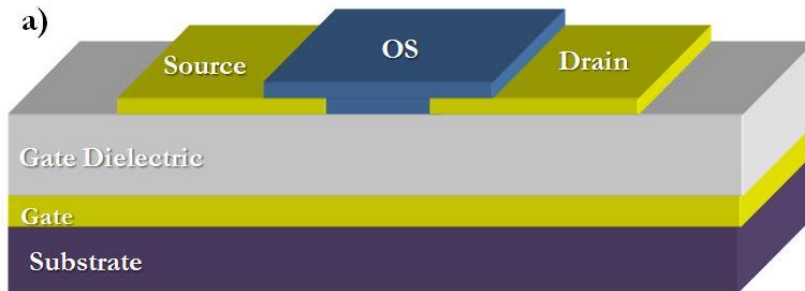
## Threshold voltage

*Typical values  $[+10\text{V}; -10\text{V}]$*

*N.B. ideally  $V_t=0\text{V}$*

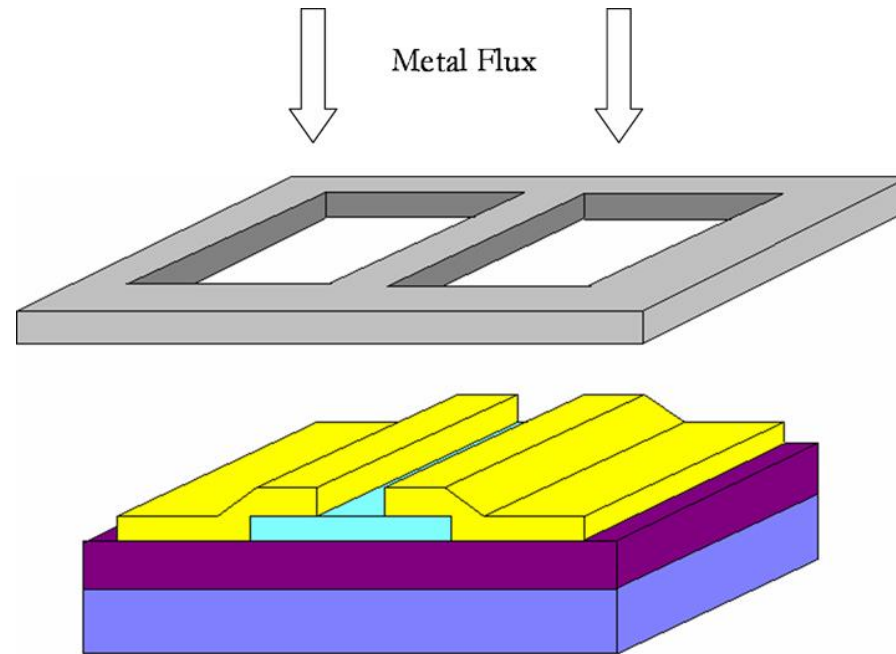


# OFETs structures



- a) Bottom gate, Bottom Contact
- b) Bottom gate, Top Contact
- c) Top Gate, Bottom Contact
- d) Top Gate, Top Contact

# Patterning : Shadow Mask



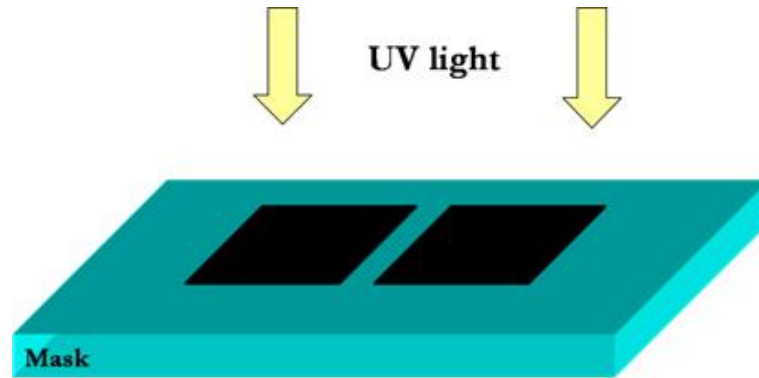
**Gate electrode**

**Source e drain electrodes**

- Low resolution ( $100\ \mu\text{m}$ )
- not suitable for large area
- Top Contact  $\rightarrow$  possible defects in the channel



# Patterning : Photolithography



- High resolution
- Only Bottom Contact
- No low cost

Photoresist development



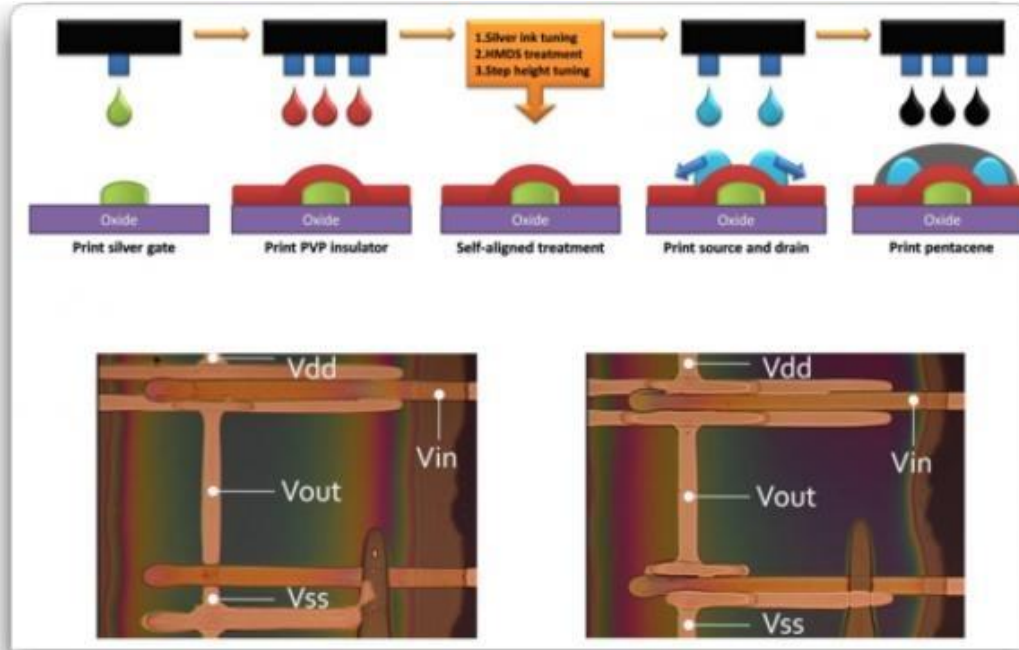
Metal etching



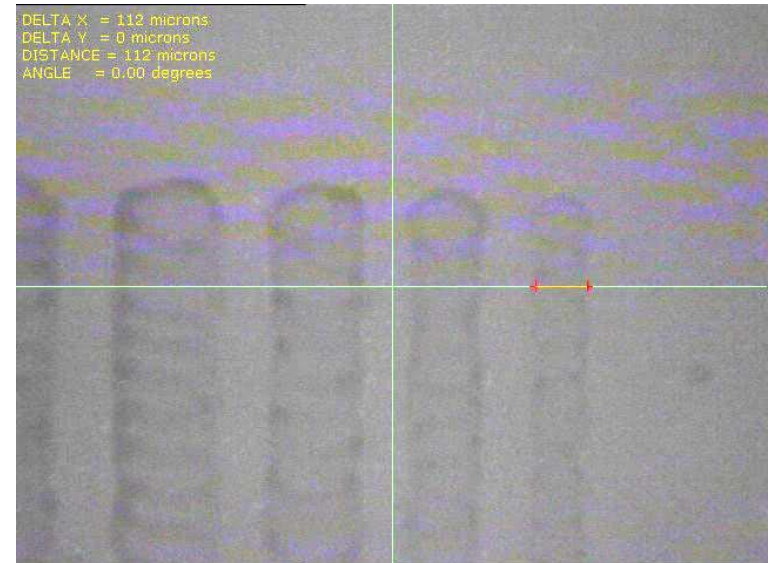
Photoresist Remotion



# Patterning : inkjet printing



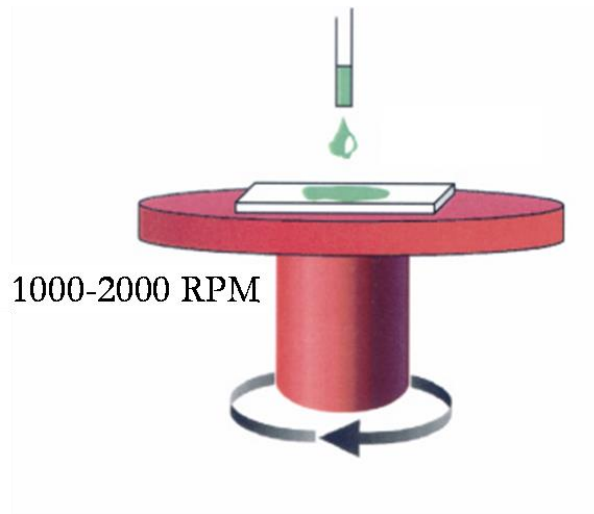
- Low risoluzione (constantly increasing)
- Bottom Contact
- Suitable for large area
- Low cost



# Organic Semiconductor and insulator

**Solution processable**

*Spin coating o drop casting*



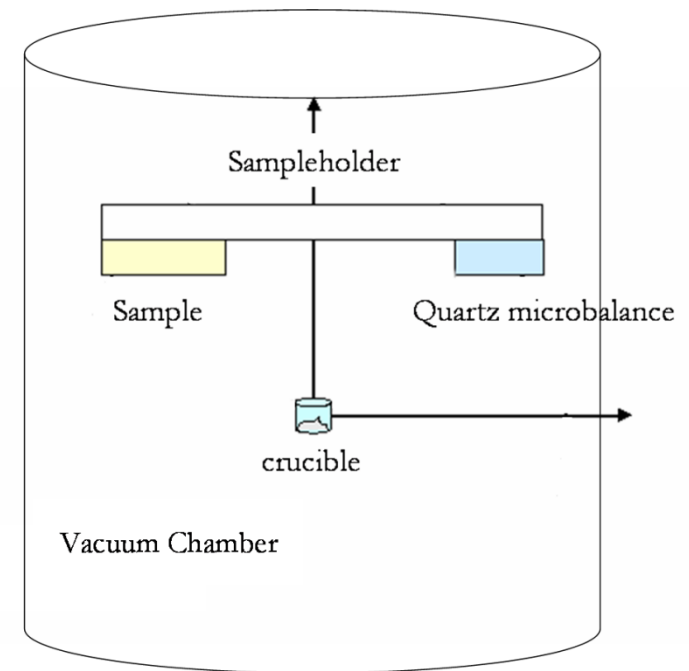
**Inkjet printing**

*Spin coating o drop casting*



**Small molecule not soluble**

*Vapor phase*



## non idealities

- **Metal/Semiconductor interface**

*charge injection* → *Series resistance*

- **insulator/semiconductor interface**

charge trapping

$V_t$  shift

hysteresis

gate voltage dependance of mobility

- **Metal/Semiconductor interface**

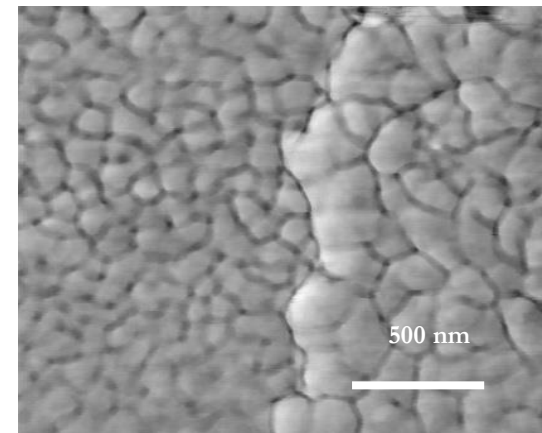
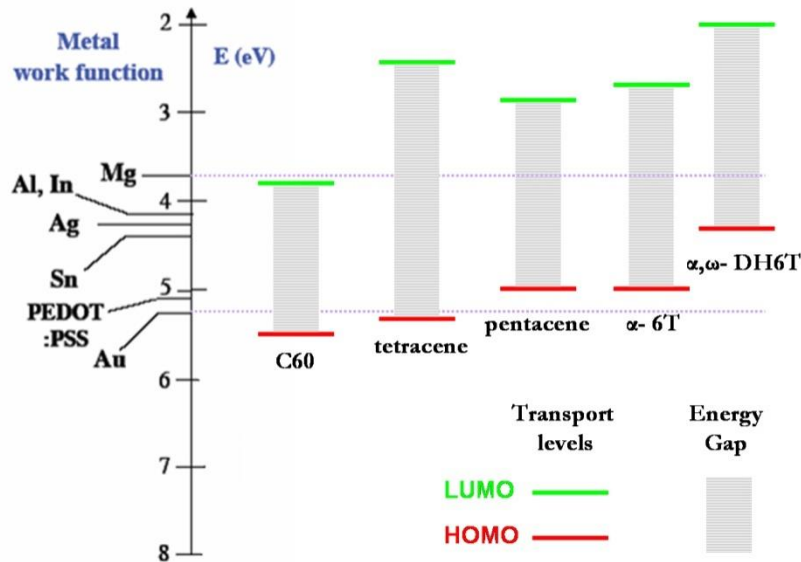
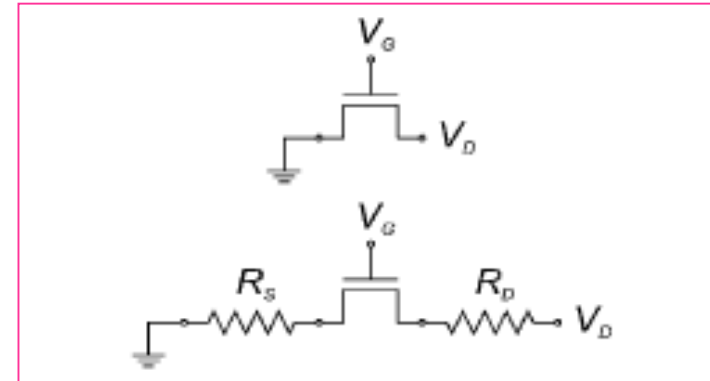
*charge injection* → *Series Resistance*

- **Metal/Semiconductor interface**

*charge injection*  $\rightarrow$  *Series Resistance*

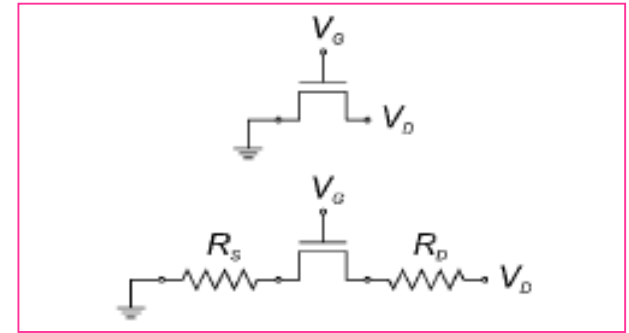
**Causes:**

- *structural defects due to processing*
- *energetic levels alignment*



## Series resistance

All resistive effects that do not scale down with channel length are called series resistance effects



$$I_D = Z / L \mu C_{ins} (V_G - V_{th}) V_D$$

$$I_D = Z / L \mu C_{ins} (V_G - V_{th}) (V_D - R_S I_D) \quad (18)$$

$$g_D = \left( \frac{1}{\mu(Z/L)C_{ins}(V_{GS} - V_T)} + R_S \right)^{-1} \quad (19)$$

$$R_S = R_{Total} - \frac{L}{Z \mu C_{ins} | (V_{GS} - V_T) |} \quad (20)$$

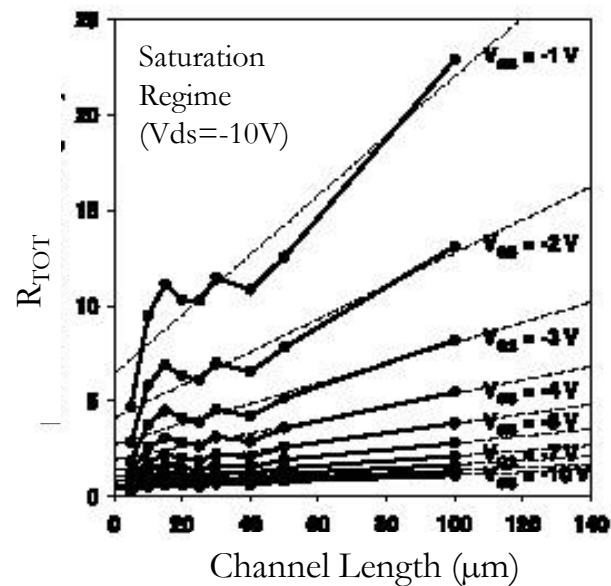
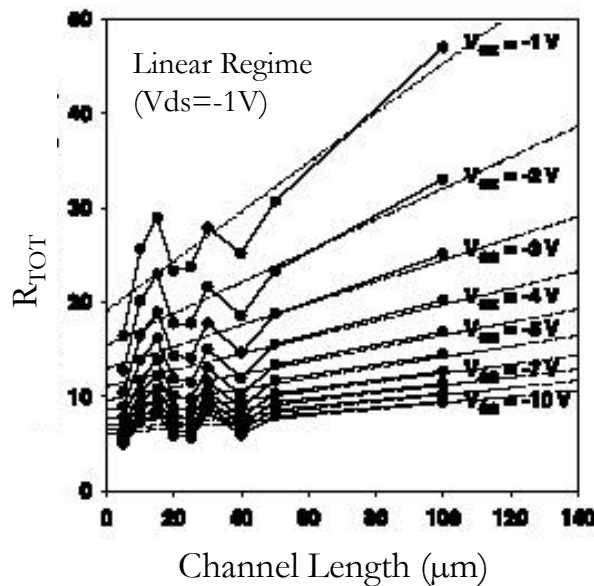
Using such model it is possible to estimate  $R_s$   
 $R_{tot}$  from the output characteristics, the second term is known

## Series resistance– Transfer line method

$$R_T = R_S + R_{Ch} \quad (24)$$

$R_c$  can be estimated by plotting the inverse conductance as function of the channel length

$R_s \rightarrow L=0$





## Let's giv it a try

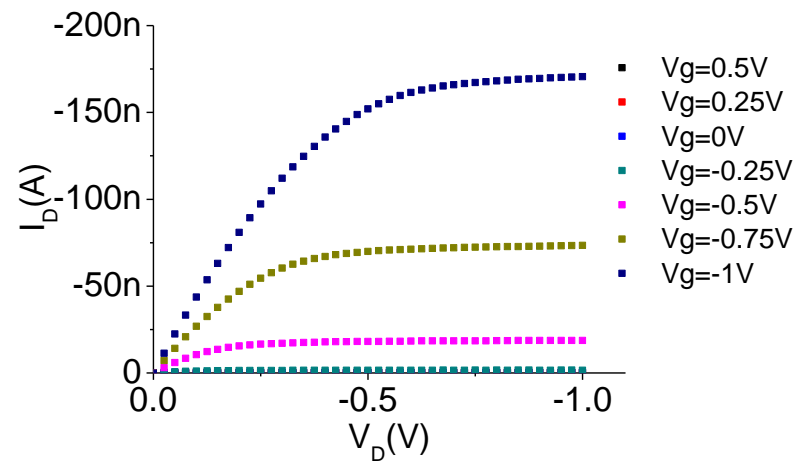
We have three different OTFTs with the following channel lengths, and the following output curves

$L = 20 \text{ } \mu\text{m}$

$L = 50 \text{ } \mu\text{m}$

$L = 100 \text{ } \mu\text{m}$

$R_{\text{tot}}$ ?



## Series resistance

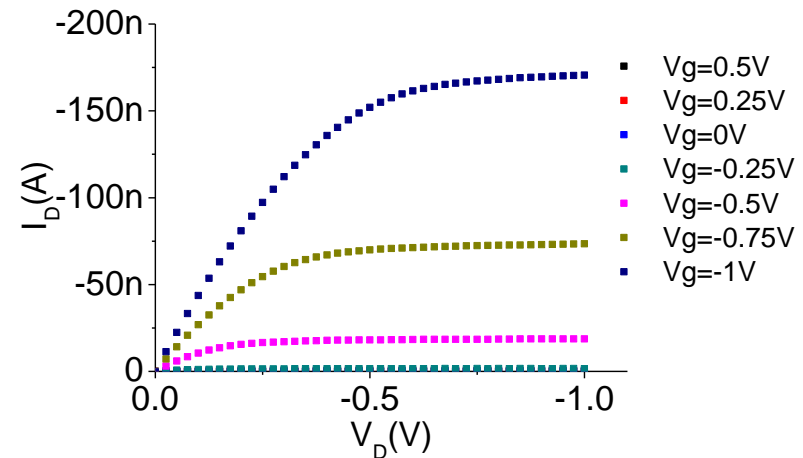
We have three different OTFTs with the following channel lengths, and the following output curves

$L = 20 \text{ } \mu\text{m}$

$L = 50 \text{ } \mu\text{m}$

$L = 100 \text{ } \mu\text{m}$

$R_{\text{tot}}$ ?



	$V_g = -3\text{V}$	$V_g = -2\text{V}$	$V_g = -1\text{V}$	$V_g = 0\text{V}$
<b>20 <math>\mu\text{m}</math></b>	500 k $\Omega$	700 k $\Omega$	1 M $\Omega$	1,5 M $\Omega$
<b>50 <math>\mu\text{m}</math></b>	1 M $\Omega$	1,3 M $\Omega$	2 M $\Omega$	2,8 M $\Omega$
<b>100 <math>\mu\text{m}</math></b>	1,5 M $\Omega$	1,8 M $\Omega$	2,7 M $\Omega$	4,2 M $\Omega$

# Fattori di non idealità

- **Interfaccia Metallo/Semiconduttore**

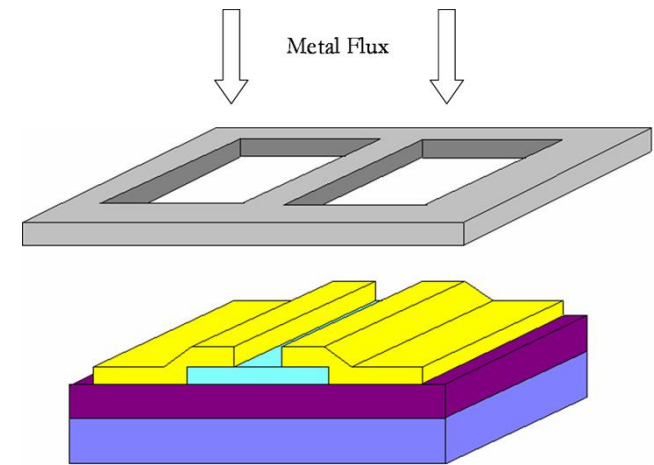
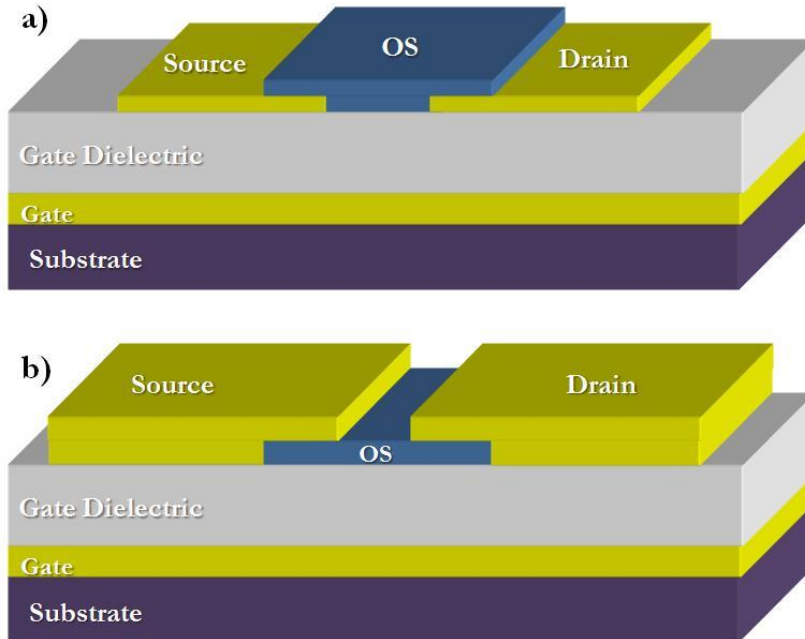
*Iniezione di carica → Resistenza serie*

**Cause:**

***Difetti strutturali dovuti al processing***

*Allineamento dei livelli energetici*

# Rs – Difetti strutturali



## Top Contact

I contatti di Source e Drain vengono realizzati su un film di semiconduttore organico precedentemente depositato → gli atomi del metallo possono diffondere dentro il film organico

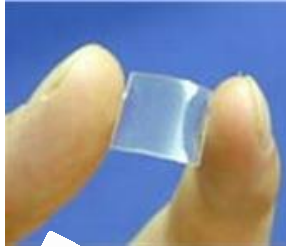
## Bottom Contact

Il semiconduttore organico viene depositato su un substrato già patternato → disomogeneità nella crescita all'interfaccia metallo/semiconduttore

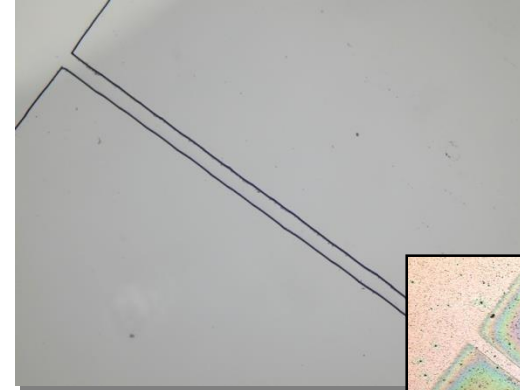
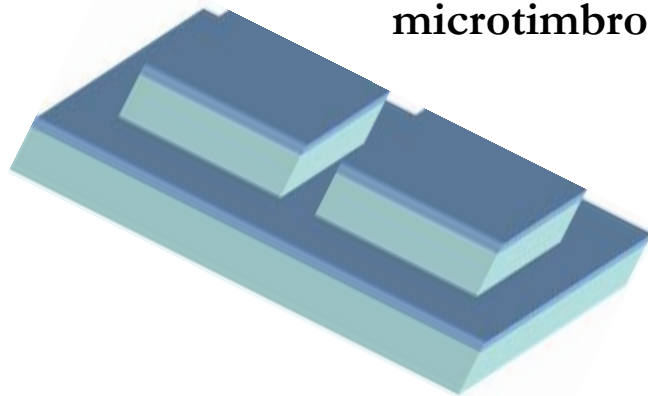
# Introduzione

## Soft Lithography:

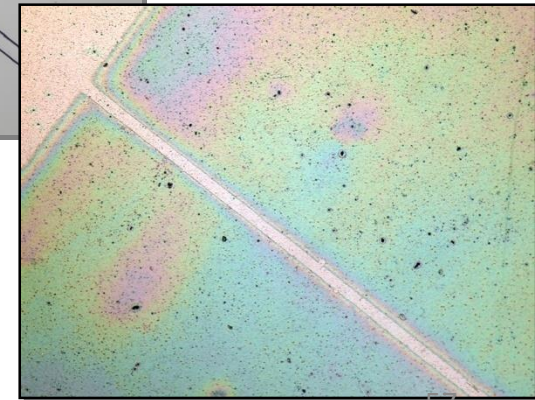
- I microtimbri dovranno riprodurre esattamente il disegno che si intende trasferire su una data superficie
- Inchiostro differente a seconda delle applicazioni



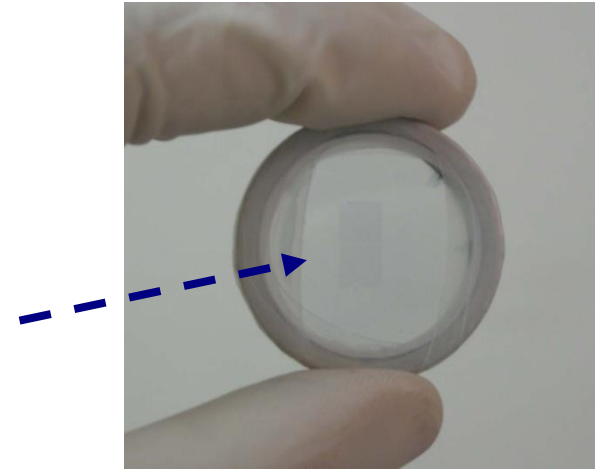
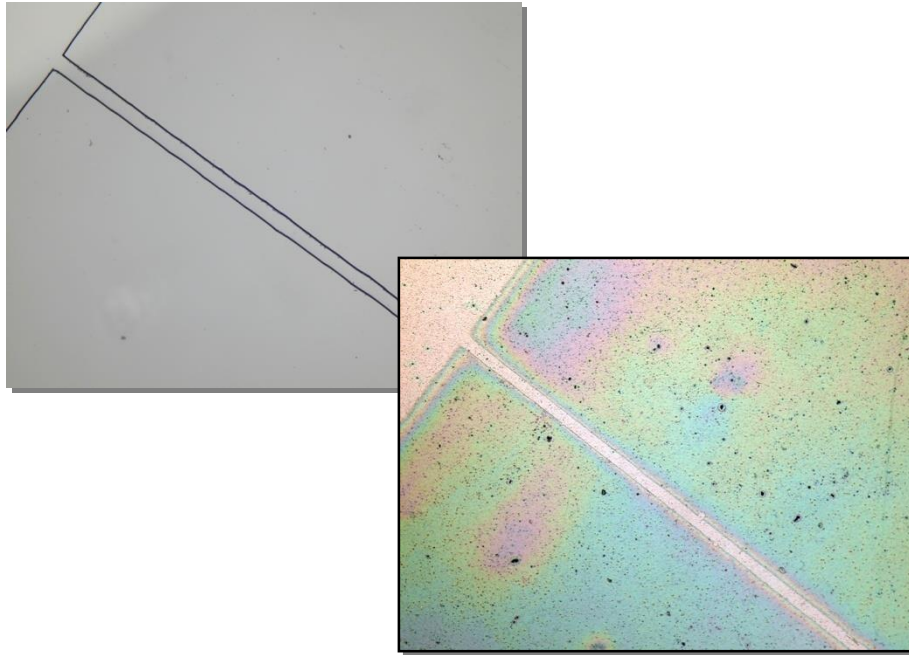
microtimbro



Disegno stampato



# Organic Field Effect Transistors (OFETs)



## Bottom Contact

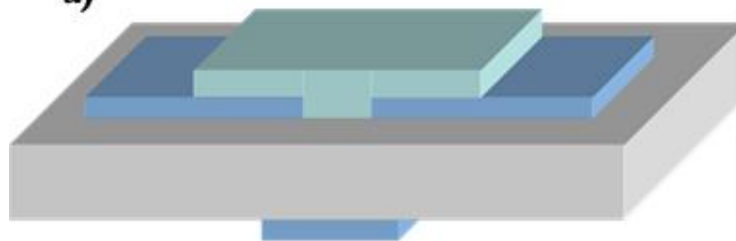


Pentacene



Mylar®

a)

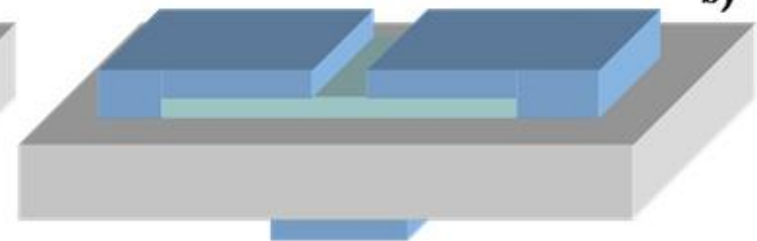


## Top Contact

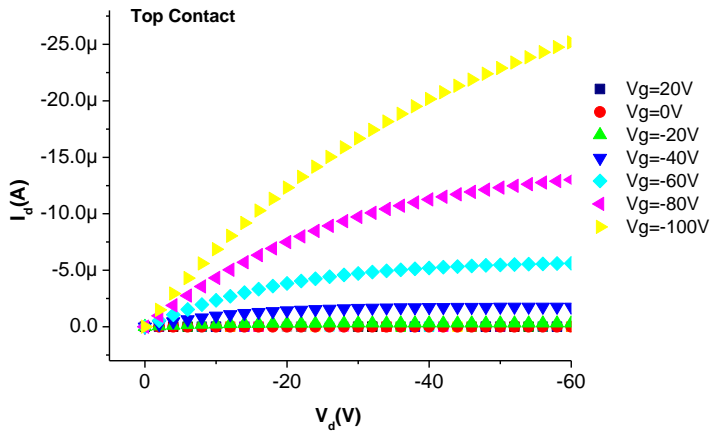


PEDOT:PSS

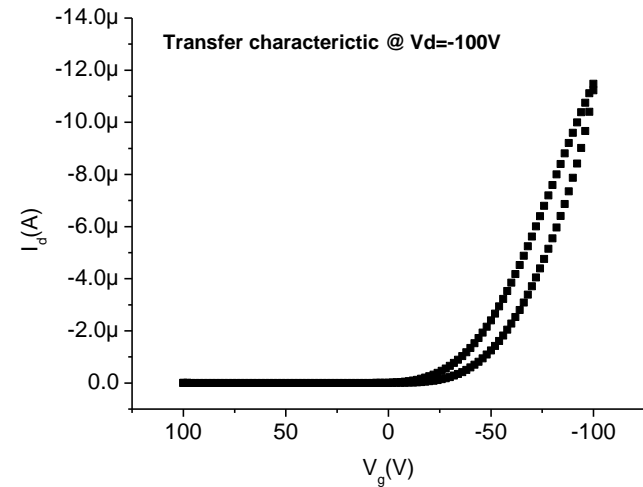
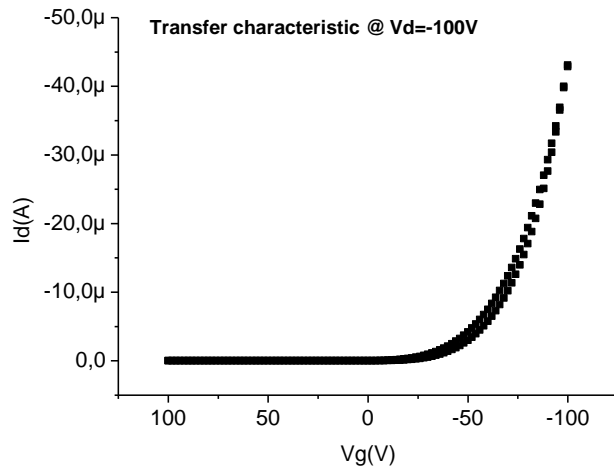
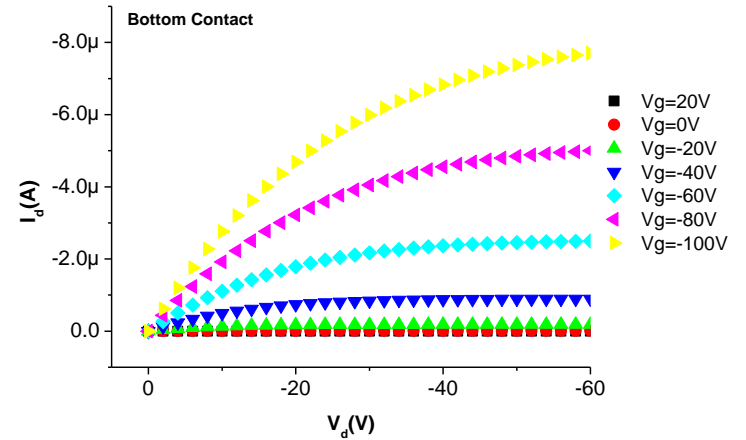
b)



## Top Contact



## Bottom Contact



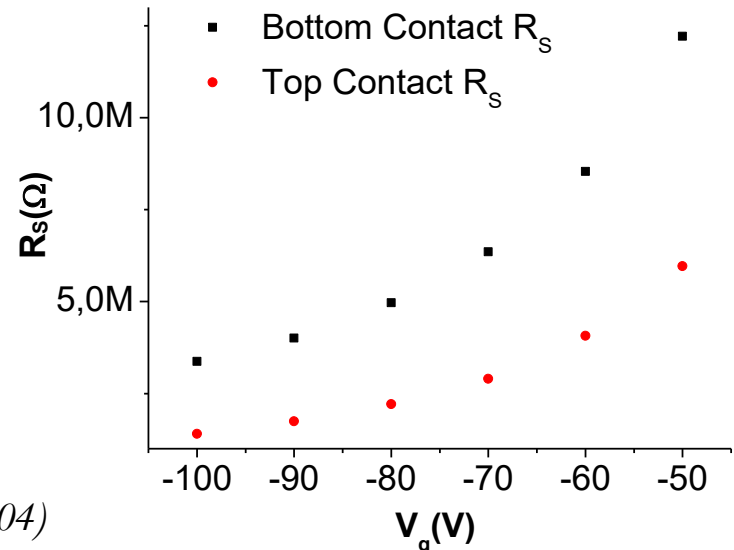
# Rs – Difetti strutturali

## Contact Resistance

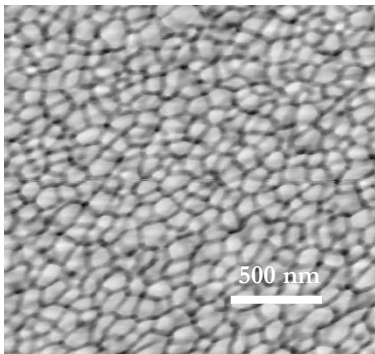
$$I_D = Z / L \mu C_{ins} (V_G - V_{th})(V_D - R_S I_D)$$

$$R_{total} = R_s + \frac{L}{W \mu C_{ins} | (V_G - V_{th}) |}$$

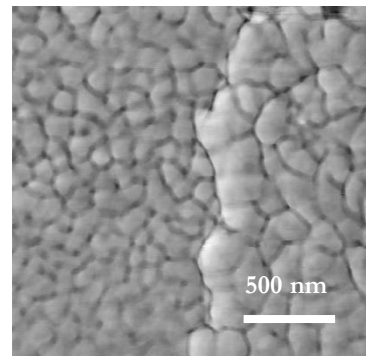
G. Horowitz *et al. Adv. Funct. Mater.* 14, 1069 (2004)



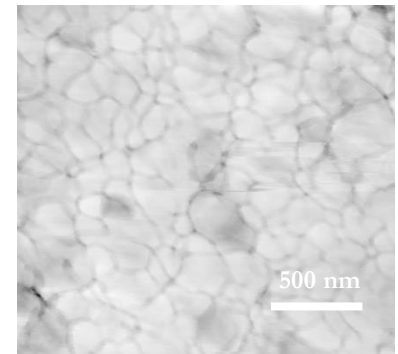
## Pentacene in the channel



## Pentacene at the channel/electrode interface



## Pentacene over the electrodes





- **Metal/Semiconductor Interface**

*Charge injection → Series Resistance*

**Causes:**

*structural defects due to processing*

***Energy levels alignment***

# $R_s$ – Energy levels alignment

The concentration of intrinsic charge carriers in the bulk is very low, therefore, **the most of the charge carriers forming the channel are injected by the source electrode**

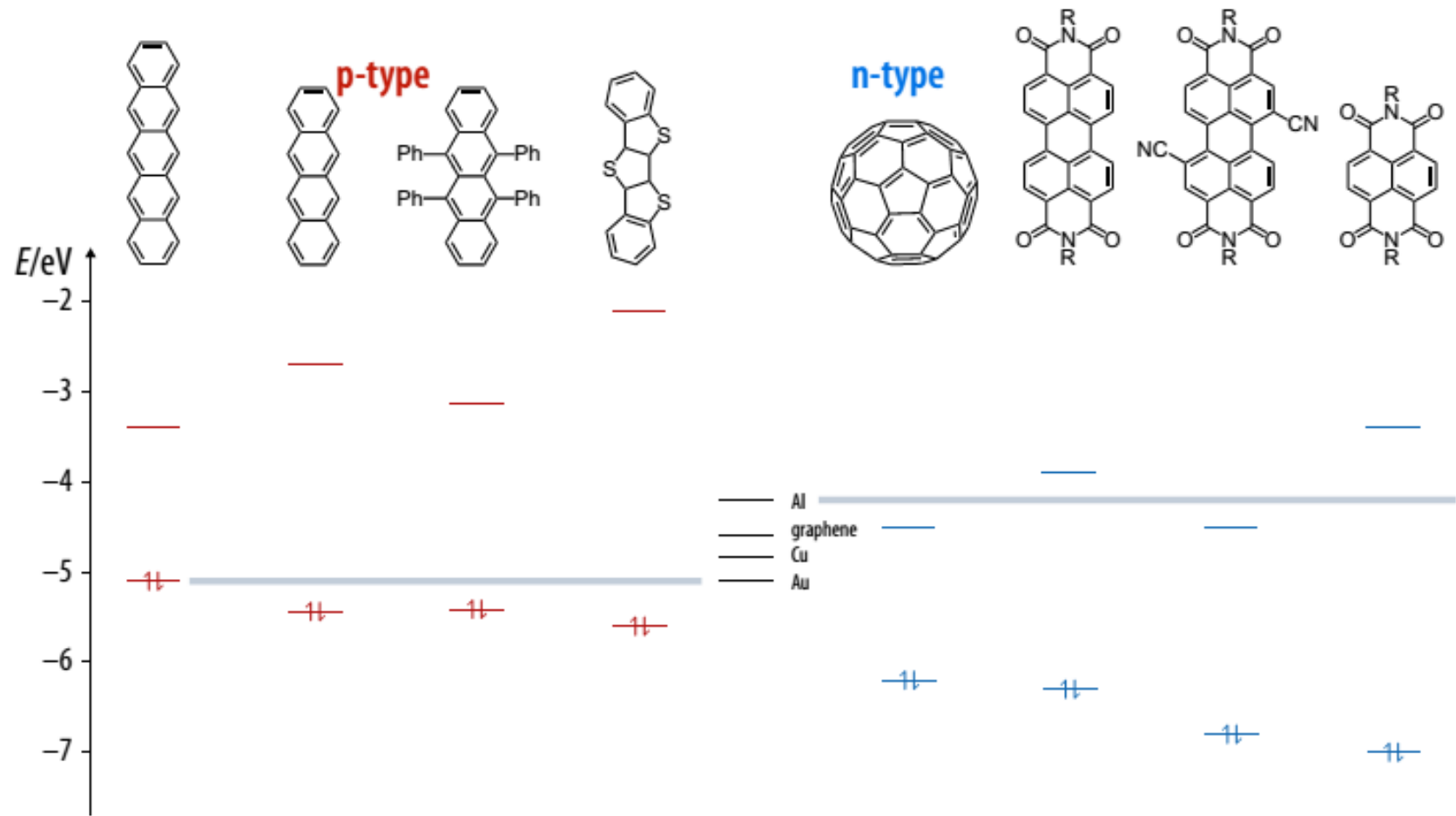
The metal/semiconductor interface plays a fundamental role in determining the final electrical behavior of the organic electronic devices

Also for organic materials, in principle we can use the Schottky-Mott theory to give a first idea of what could happen at the interface, however, we will see that such rule is rarely confirmed

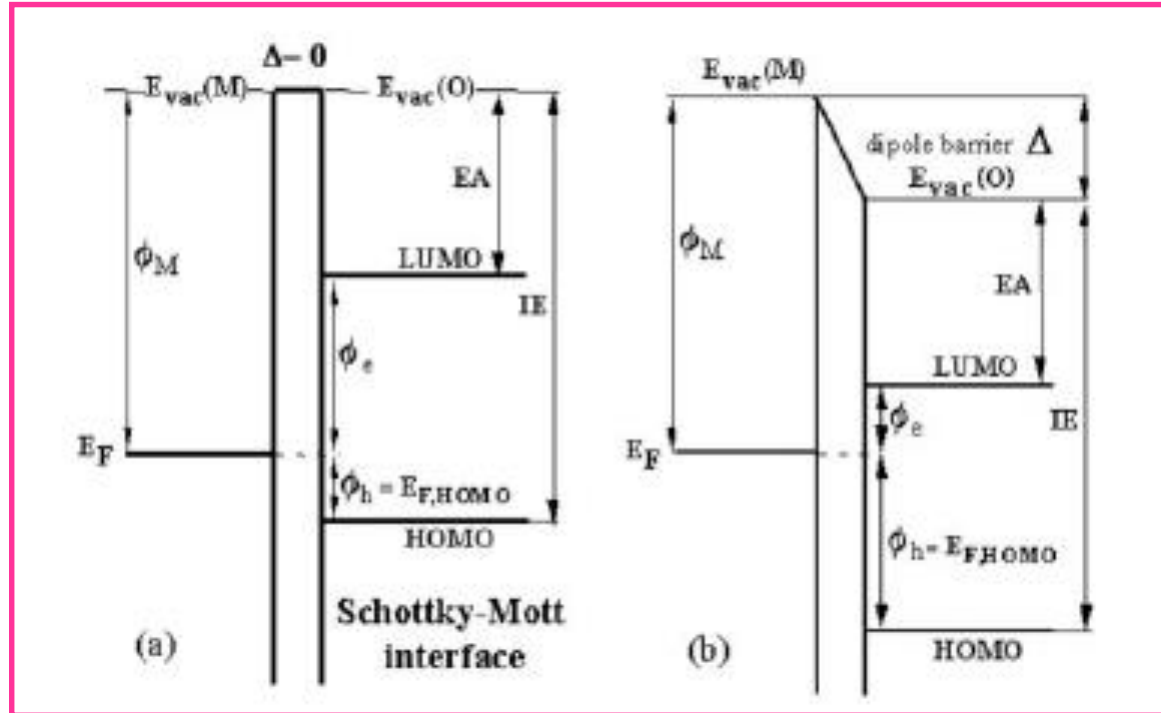
Vacuum level of metal and semiconductor should align, as a result, the hole and electron injection barriers, (HIB and EIB respectively) will depend on the HOMO and LUMO energy with respect to the metal Fermi level.

**In principle, HIB (Hole Injection Barrier) is defined as the difference between the semiconductor ionization energy and the metal Fermi Energy e MFL (Metal Fermi Level).**

**Viceversa EIB is the difference between MFL and electron affinity.**



## Schottky-Mott model



In the most of the cases Schottky – Mott model do not apply to organic devices

Injection barriers could differ from theoretical ones by even more than 1 eV!!!

Physical/chemical phenomena taking place at the interface

When the pressure is not sufficiently low, Ultra High Vacuum the metal surface is not perfectly clean, but contaminated by the absorption of water, oxygen and other organic molecules, therefore its work function could be very different!

The work function is given by the work we have to spend to extract one electron from the metal

Metal work function is generally measured in UHV,  $10^{-9}$  Torr

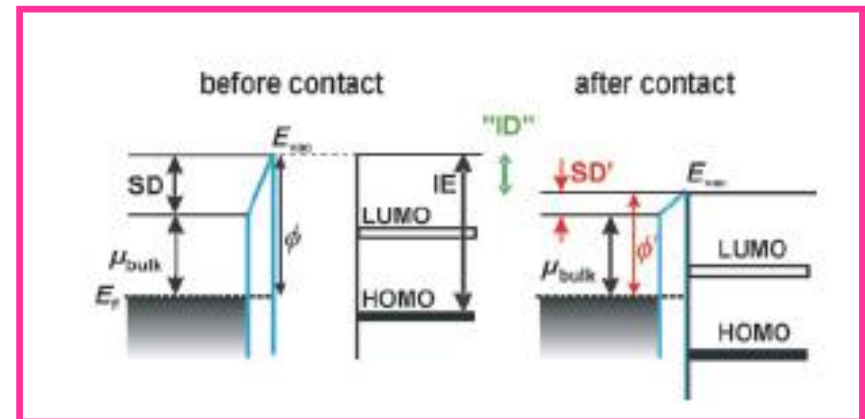
We should consider that in a metal we have the bulk potential, but also surface potential due to superficial electrons spilling out in the vacuum, and leaving behind a positive charge

- Surface dipole

**Work function is given by two contributions:**

- Bulk potential
- Surface dipole

*(depends on electronic surface density)*

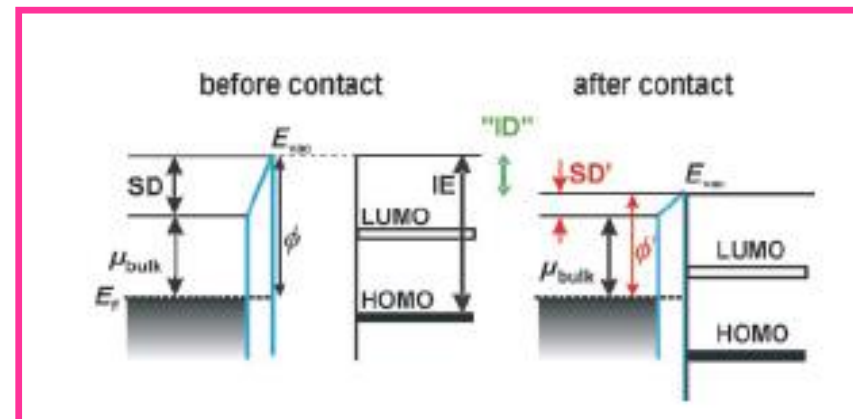


The absorption at the interface of whatever kind of molecule leads to a change in the surface electronic density  $\rightarrow$  change in the metal work function

Such adsorbed molecules push the dipoles back towards the bulk of the metal (*Push Back Effect*) leading to the reduction of the metal work function

Surface dipole decreases  
 Re-organization of surface electronic density

$$ID = SD - SD^I$$

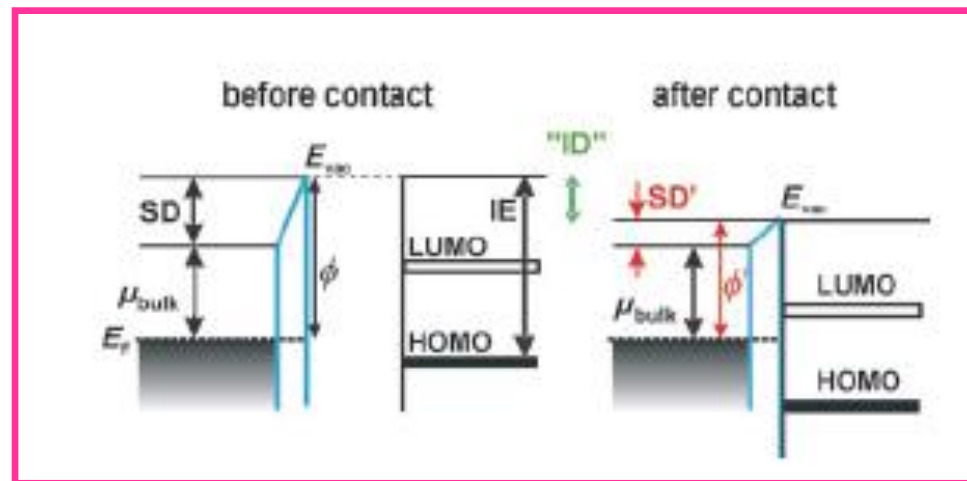




How the charge injection is affected by this phenomenon?

HIB increases

EIB decreases



$\Delta SD$  value depends on the metal, on the adsorbed molecule and also of the type of interaction, physical, chemical, charge transfer etc.

Consider that simply by moving from  $10^{-9}$  Torr to  $10^{-6}$  Torr a significant  $\Delta\text{SD}$  is induced (Au: from 5.1-5.4 eV to 4.5-4.9 eV)

Moreover, there exist some molecules with an intrinsic dipole moment inducing a further shift of the work function that could be estimated by:

$$\Delta\phi = \frac{q \cdot N \cdot p}{\epsilon_0 \cdot \epsilon_r}$$

Helmholtz Equation

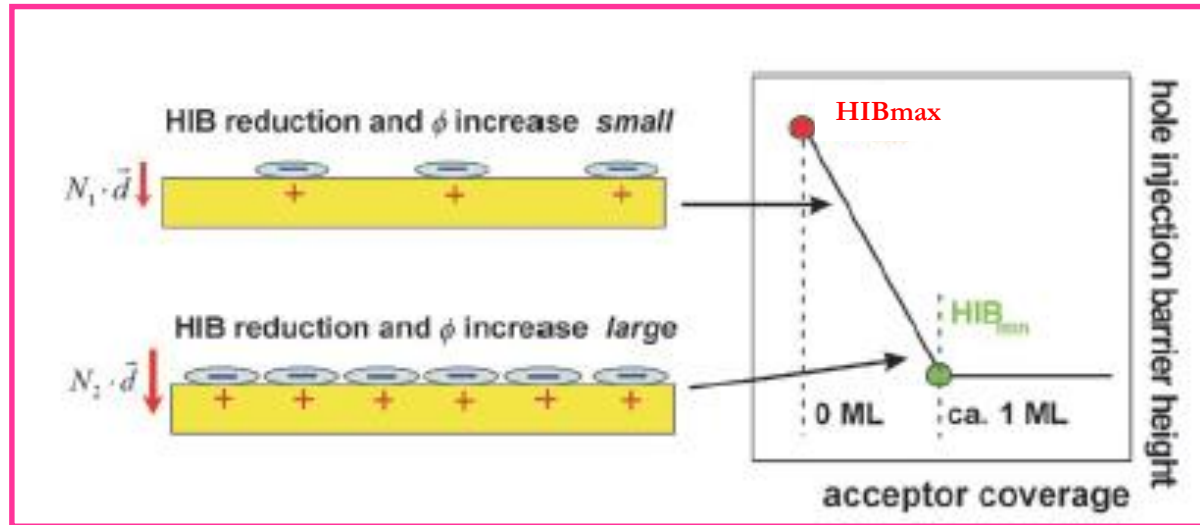
$q$  electron charge,  $N$  surface dipole density,  $p$  dipole moment perpendicular to the surface,  $\epsilon_0$

Such shift can be tuned depending on the employed molecules

## Strong electron acceptor

- electron transfer from the metal to the molecule
- Surface dipole with the negative side towards the molecule
- Opposite Shift and increase of the metal work function
- Decrease of HIB

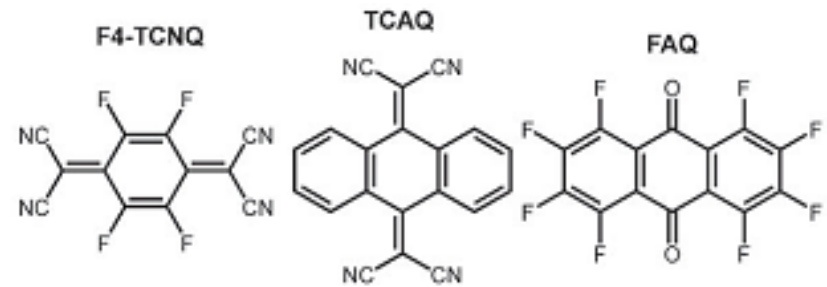
**The shift can be tuned using different molecules or controlling the density of the molecules on the metal surface**



## Tuning of the work function by means of molecular layers:

- ✓ Small molecules
- ✓ Self Assembled

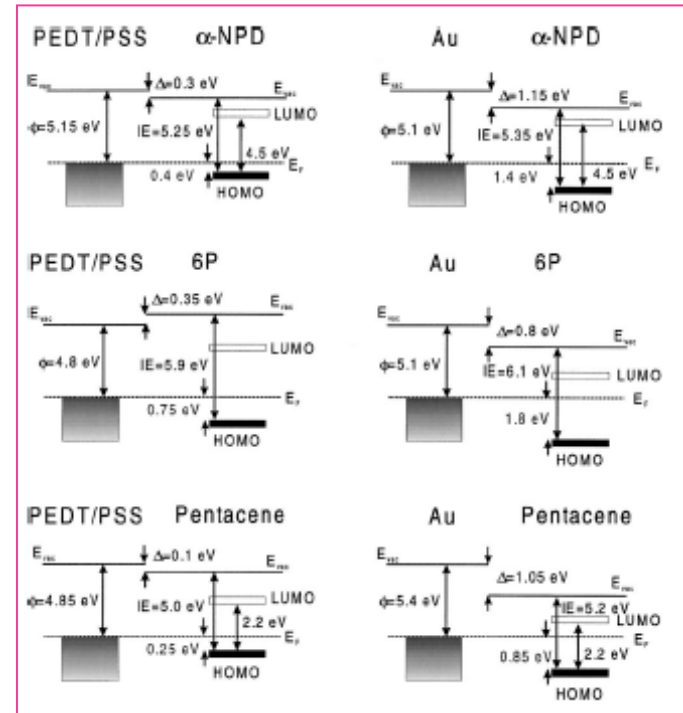
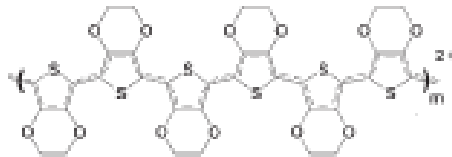
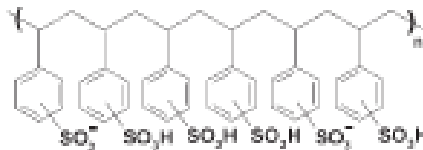
Monolayers (SAM)



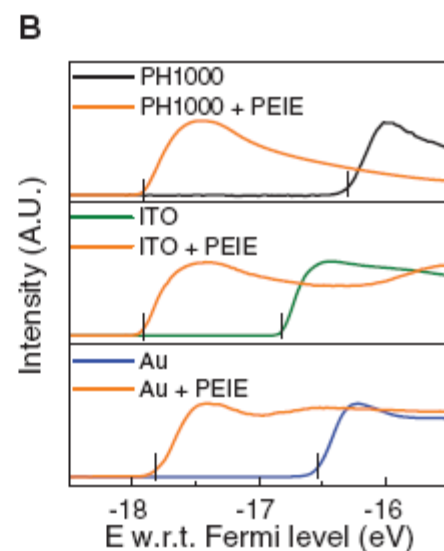
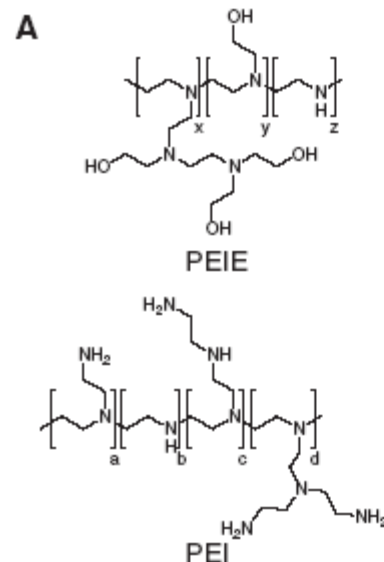
# Conductive polymer/organic semiconductor interface

In a conductive polymer the contribution of surface dipoles to the work function is poor, due to disorder

Push back effect not significant, typically Schottky-Mott is valid ( $S=1$ )



PEDOT:PSS vs Au  
Similar WF but different HIB



Work function (eV)

Electrodes	Kelvin probe in air			UPS		
	Pristine	With PEIE	With PEI	Pristine	With PEIE	With PEI
<b>Metal oxides</b>						
ITO	4.62 ± 0.06	3.60 ± 0.06	3.50 ± 0.06	4.40	3.30	3.27
	5.16 ± 0.06*	3.60 ± 0.06*	—	5.00*	3.30*	—
ZnO	4.26 ± 0.06	3.28 ± 0.06	3.10 ± 0.06	3.96	3.55	3.17
FTO	4.68 ± 0.06	3.80 ± 0.06	3.60 ± 0.06	—	—	—
<b>Metals</b>						
Au	5.10 ± 0.10	3.90 ± 0.06	3.94 ± 0.06	4.70	3.40	—
Ag	4.60 ± 0.06	3.70 ± 0.06	3.60 ± 0.06	—	—	—
Al	3.40 ± 0.06	2.75 ± 0.06	—	—	—	—
PEDOT:PSS	4.90 ± 0.06	3.58 ± 0.06	3.88 ± 0.06	4.95	3.32	3.16
Graphene	4.60 ± 0.06	3.80 ± 0.10	—	—	—	—

\*Substrate was treated with an O<sub>2</sub> plasma for 2 min prior to measurements or polymer modifier deposition.

# Employment of small molecules to intentionally change the metal work function

## Example PEIE

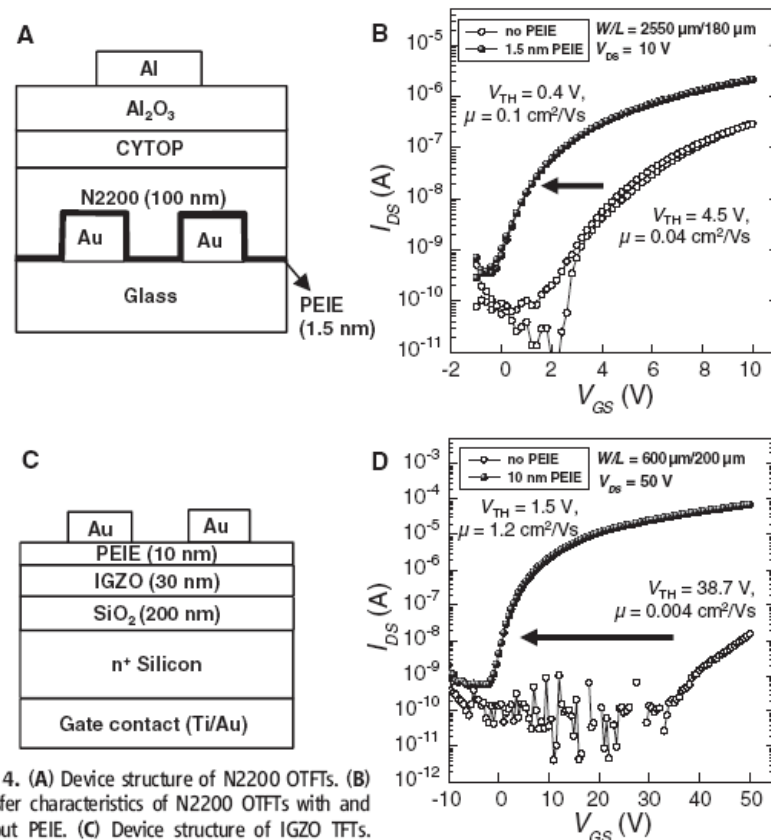
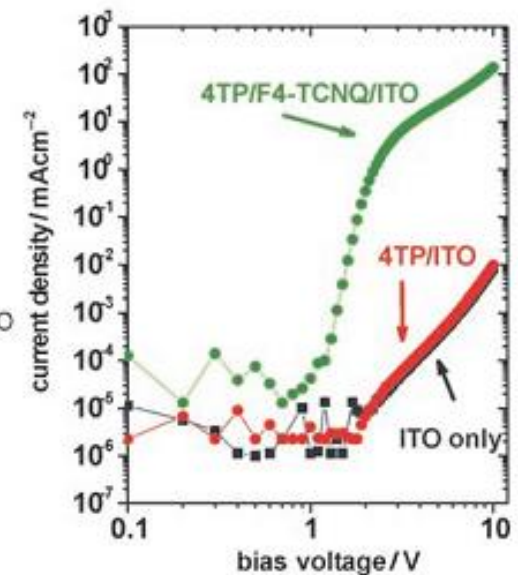
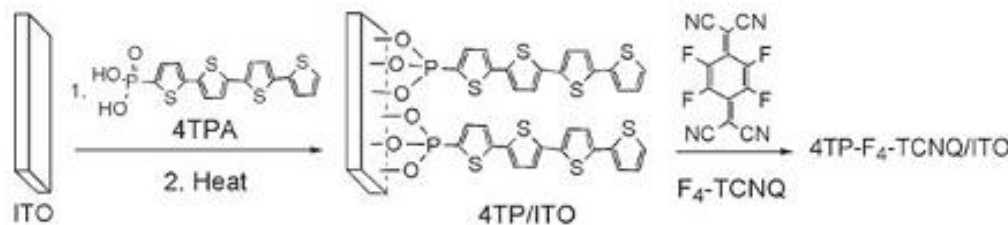


Fig. 4. (A) Device structure of N2200 OTFTs. (B) Transfer characteristics of N2200 OTFTs with and without PEIE. (C) Device structure of IGZO OTFTs. (D) Transfer characteristics of IGZO OTFTs with and without PEIE. CYTOP (CTL-809M) is a perfluorinated polymer purchased from Asahi Glass.

- Comparison between two diodes ITO/4TPA/ITO with and without F4-TCNQ
- In the second case a dramatic increase of the current, due to better charge injection, can be observed





L'argento non viene generalmente considerato come metallo per la fabbricazione di elettrodi source e drain, perché ha una funzione lavoro di circa 4.7 eV

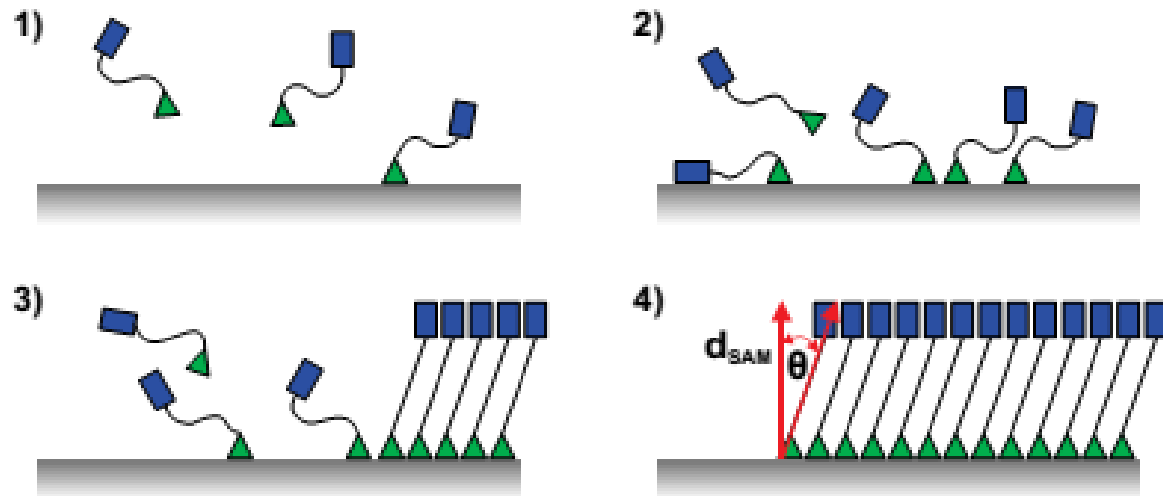
Non si interfaccia bene con la maggior parte dei semiconduttori di tipo p, e neanche con quelli di tipo n

È facile però fare degli inchiostri conduttivi con nanoparticelle d'argento

È possibile modificare la sua funzione lavoro?

**Uso di Self Assembled Monolayers (SAMs)**

## Formation and growth of SAMs



Il gruppo SH del tiolo fa sì che si leghi covalentemente al metallo

L'anello aromatico ne modifica la funzione lavoro!

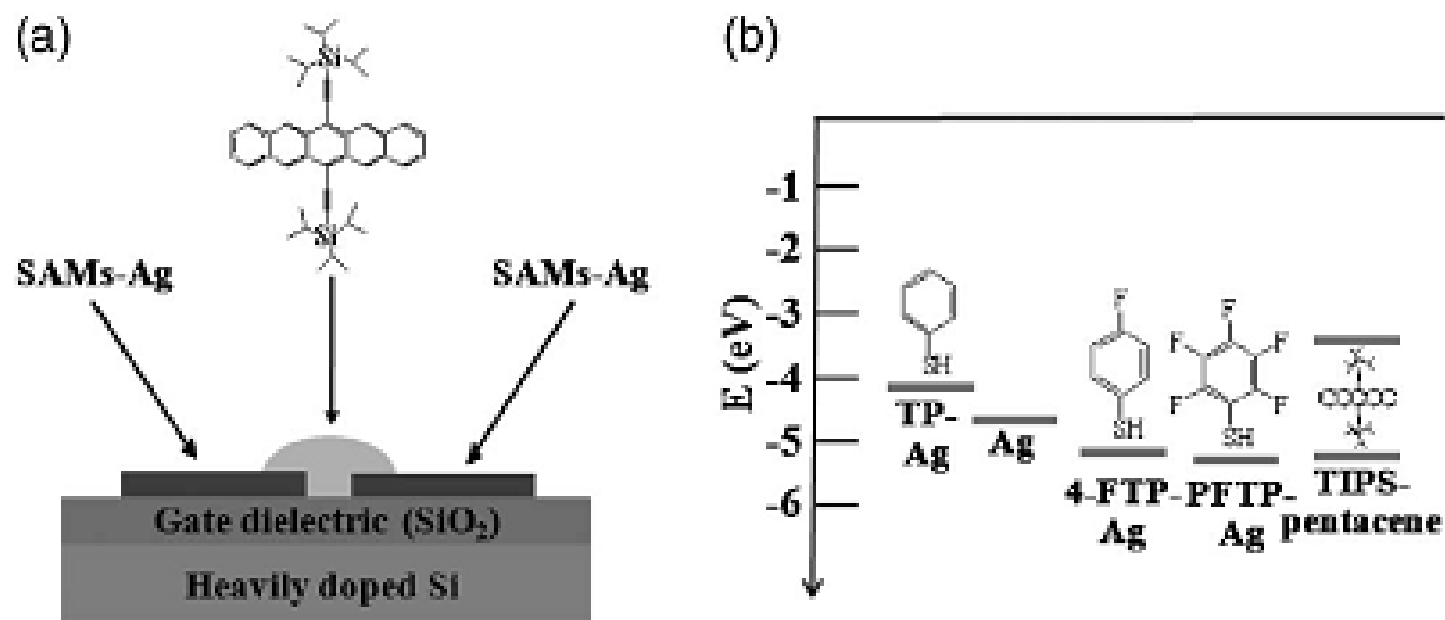
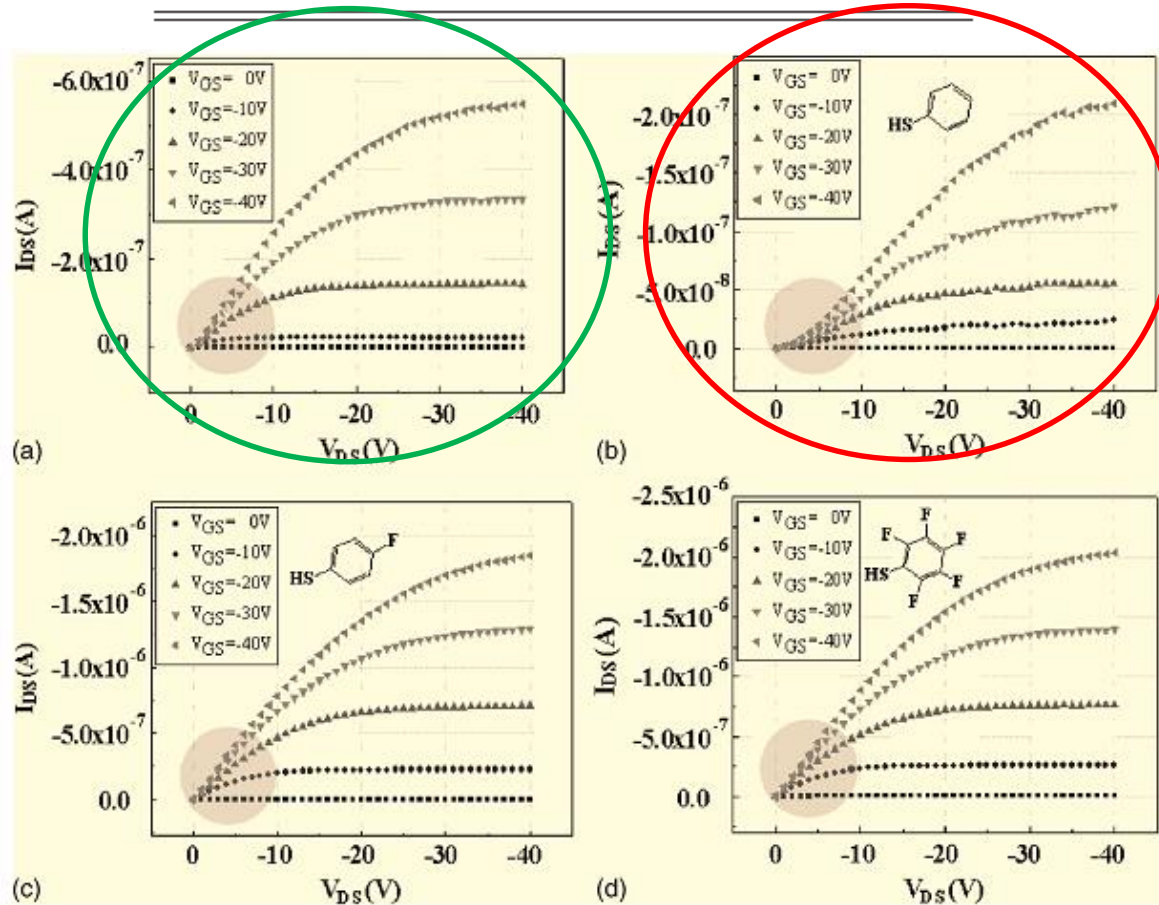


FIG. 1. (a) Bottom contact OTFT with TIPS-pentacene active layer. (b) Energy level diagrams of TP-Ag, pristine Ag, 4-FTP-Ag, PFTP-Ag electrode, and TIPS-pentacene.

TABLE I. Overview of the electrical properties of the bottom contact TIPS-pentacene OTFT devices ( $L=30 \mu\text{m}$ ,  $W=60 \mu\text{m}$ ) with various electrodes: TP-Ag, Ag, 4-FTP-Ag, PFTP-Ag electrode.

Sample	$\Phi_{\text{meas}}$ (eV)	Mobility ( $\text{cm}^2 \text{V s}$ )	on off ratio	$V_T$ (V)	$S$ (V decades)
TP-Ag	4.14	0.02	$10^4$	1.0	2.4
Ag	4.70	0.045	$10^4$	1.7	1.3
4-FTP-Ag	5.21	0.15	$10^5$	3.3	1.1
PFTP-Ag	5.35	0.17	$10^5$	3.1	1.1



TP  
Rs elevata

4-FTP  
Iniezione migliore

PFTP  
Iniezione migliore

# Non idealities

- **Insulator/semiconductor interface**

charge trapping

bias stress  $\rightarrow$   $V_t$  shift

hysteresis

Charge conduction takes place in the first monolayer, therefore the interface with the gate dielectric plays a crucial role in device performances:

- **physical:**

**Structural defects → charge carriers scattering**  
**semiconductor morphology → mobility and charge trapping**

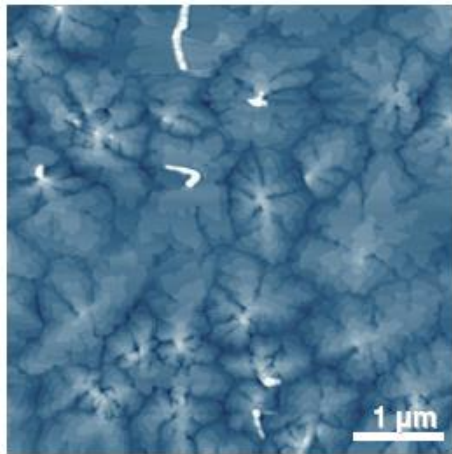
- **Chemicals:**

Charge trapping

Threshold voltage Shift (surface potential induced by chemical groups at the interface)

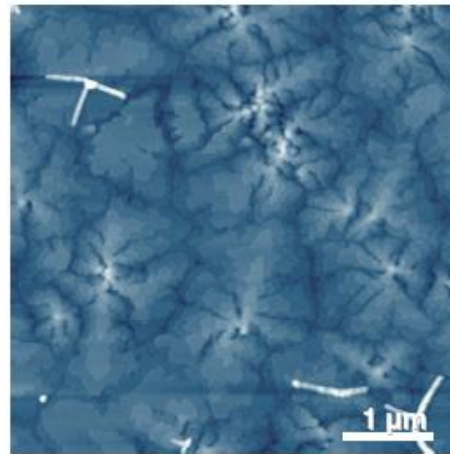
In bottom gate structures the insulator is also the substrate where the organic film is grown → determines the properties of the channel

- Surface energy
- Idrophobic – Idrofilic
- Surface roughness



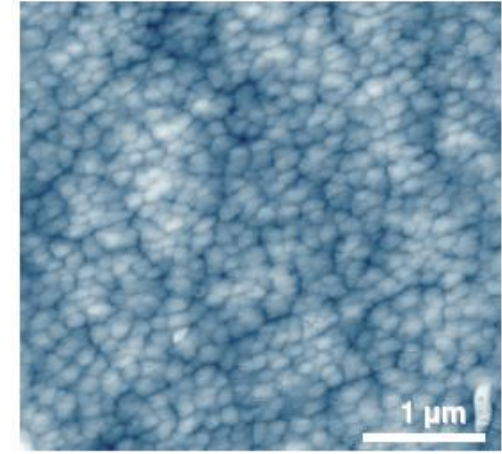
Pentacene su Mica

RMSR=0.2 nm



Pentacene su SiO<sub>2</sub>

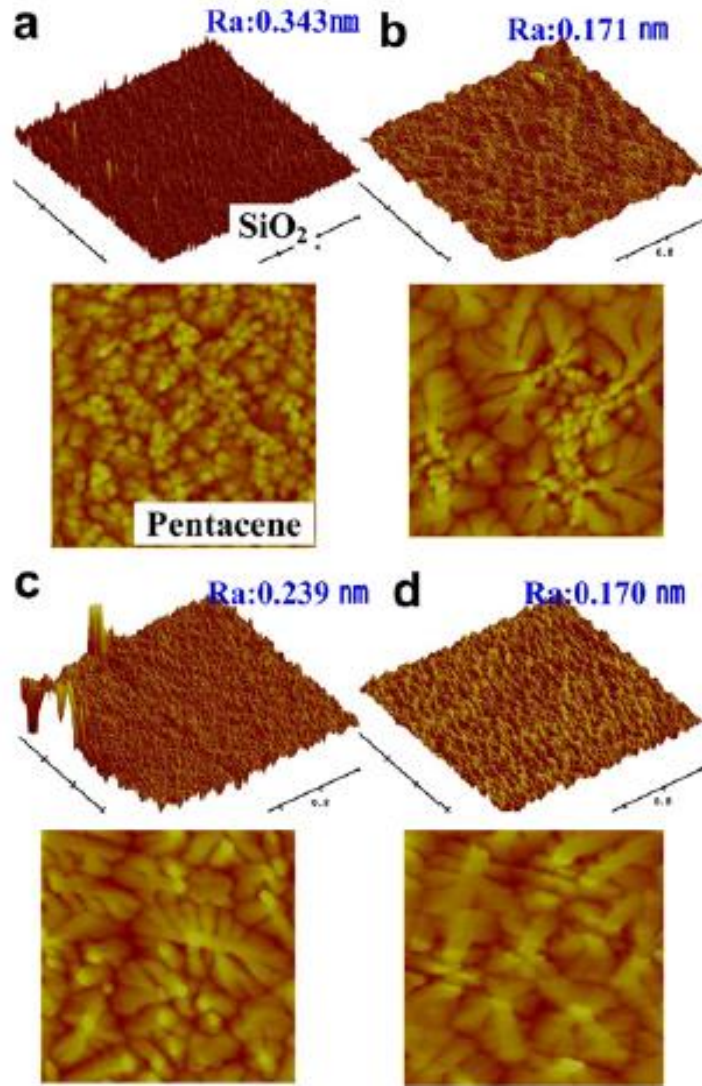
RMSR=0.2 nm



Pentacene su Mylar

RMSR=2 nm

# Surface modifications



Surface treatment	Mobility (cm <sup>2</sup> /V s)	$I_{on}/I_{off}$	$I_{off}$ (A)	Vt (V)	SS (V/dec)
O <sub>2</sub> plasma	0.353	$\sim 10^4$	$\sim 10^{-8}$	4.1	3.1
Ar beam	0.126	$\sim 10^8$	$\sim 10^{-11}$	-7.6	0.6
Reference	0.05	$\sim 10^6$	$\sim 10^{-10}$	-8.1	1.3

- **Argon ion treated**

increase of mobility and also of Ion/Ioff

- **O2 plasma treatment**

increase of mobility

degradation of Ion/Ioff → Ioff increases due to dangling bonds

Fig. 4. (a) AFM images of SiO<sub>2</sub> (1 μm × 1 μm) and pentacene (5 μm × 5 μm) of non-treated substrate as reference. (b) After O<sub>2</sub> plasma (RF 100 W, ICP 50 W, 30 s) treatment. (c) After Ar ion beam (25 eV, 60 s) treatment. (d) After Ar ion beam (300 eV, 60 s) treatment.



# Charge trapping in the bulk

## Charge Trapped Limited Current

Traps need to be filled in order to have free carriers

Mobility is given by the ratio between free charges  $n_f$  and the total concentration of charges carries  $n_{tot}$

$$\theta = \frac{n_f}{n_{tot}}$$

Considering the intrinsic mobility of the semiconductor  $\mu_0$  the effective mobility in a FET is given by:

$$\mu_{FET} = \mu_0 \cdot \theta$$

# Insulator/semiconductor interface

Interfacial states can create charge trapping

They could be given by:

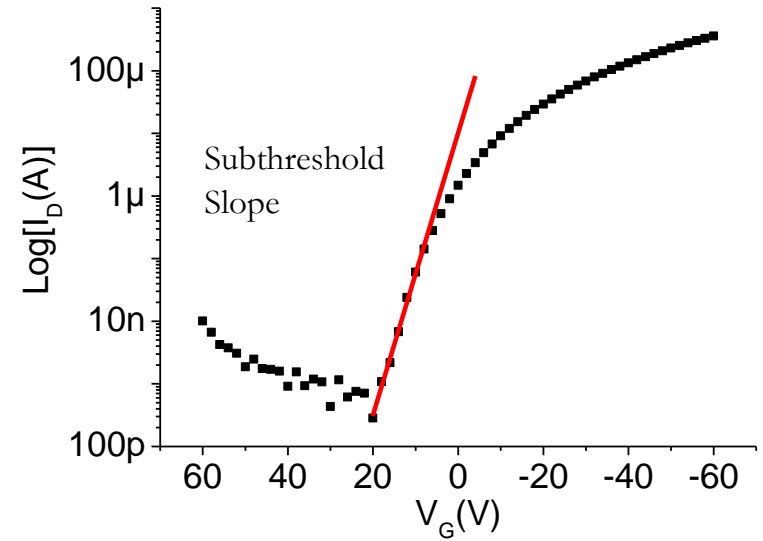
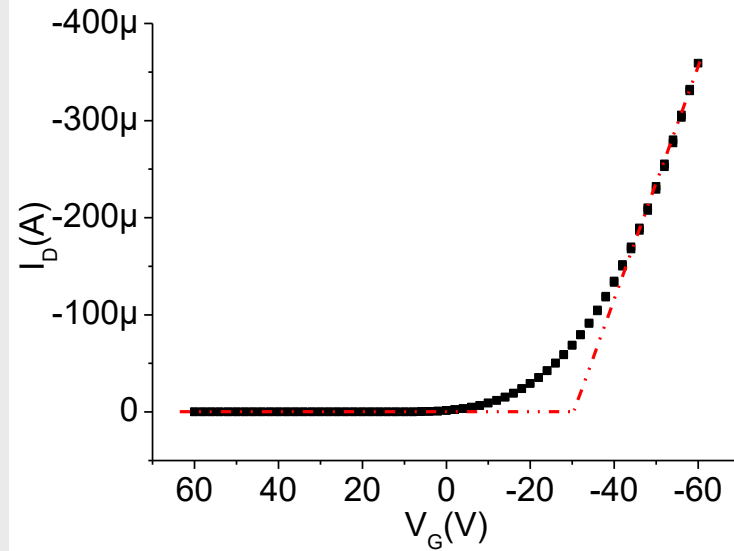
- Organic semiconductor growth
- Chemical interactions

The number of interfacial traps can be estimated using the following expression, considering bulk traps independent on the interfacial ones:

$$N_{SS}^{\max} = \left[ \frac{S \cdot \log(e)}{kT/q} - 1 \right] \frac{C_i}{q}$$

$$S = \left[ \frac{d \log(I_d)}{dV_g} \right]^{-1}$$

# Subthreshold slope



$$N_{SS}^{\max} = \left[ \frac{S \cdot \log(e)}{kT/q} - 1 \right] \frac{C_i}{q}$$

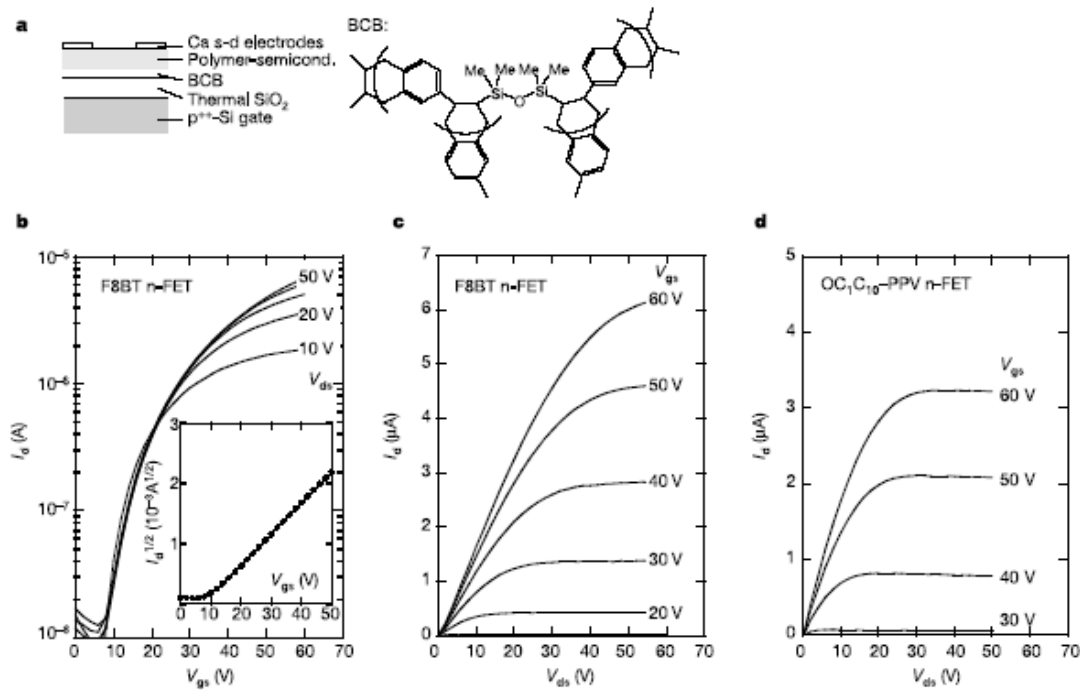
# Fattori di non idealità

## Insulator/semiconductor interface

- **Chimicals:**  
**Charge trapping**  
**Threshold voltage Shift**

# OH functional groups

OH groups attract electrons and trap them  $\rightarrow$   $V_{tn}$  increases, therefore n-type conduction is inhibited



Non polar insulators have no OH groups  $\rightarrow$  n-type conduction

# OH functional groups

## Solutions:

- Non polar solvents
- Insulator passivation:
  - ✓ SAMs (HDMS) deposition
  - ✓ Thin molecular layers deposition, for instance a p-type material

# C60 Single Layer

A) C<sub>60</sub> 20 nm



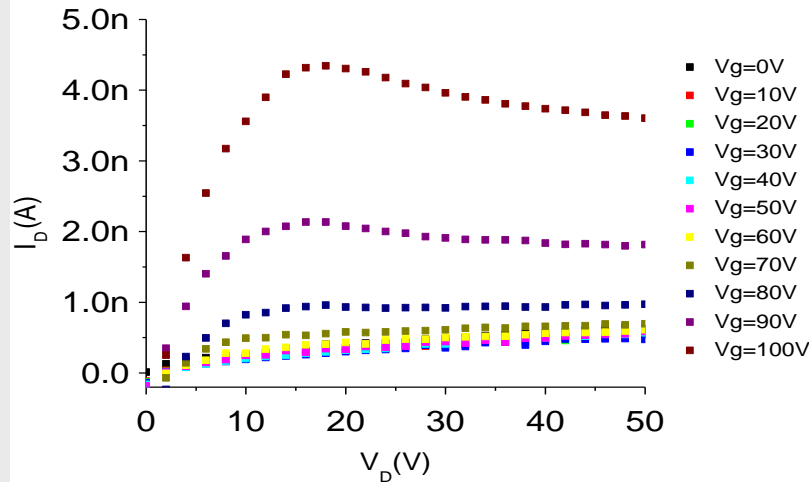
**At first**, all-organic top-contact OFETs were fabricated by employing a single C60 layer as semiconductor. However, no n-type behavior was obtained in such configuration.

## **Explanations :**

- Rather large electron injection barrier at the PEDOT:PSS/C60 interface, which was estimated to be ca. 1.5 eV under ultrahigh-vacuum conditions
- Poor structural and morphological quality of the C60 layer on bare Mylar®

# Pentacene/C60 double layer: n-type

## B) C60 20nm on 3 nm pentacene buffer layer

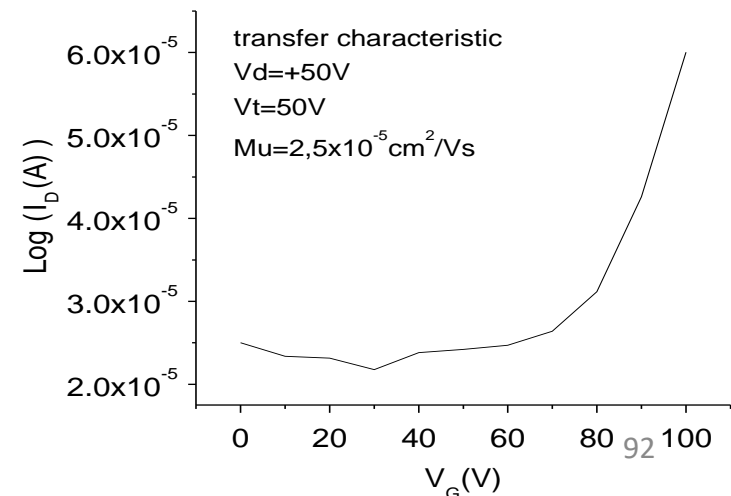


Nevertheless, despite the presence of the 3 nm pentacene layer, **no p-type conduction** was observed.

Island growth on rough substrates such as Mylar® → no closed layer over the entire gate dielectric surface to be formed at this low nominal thickness.

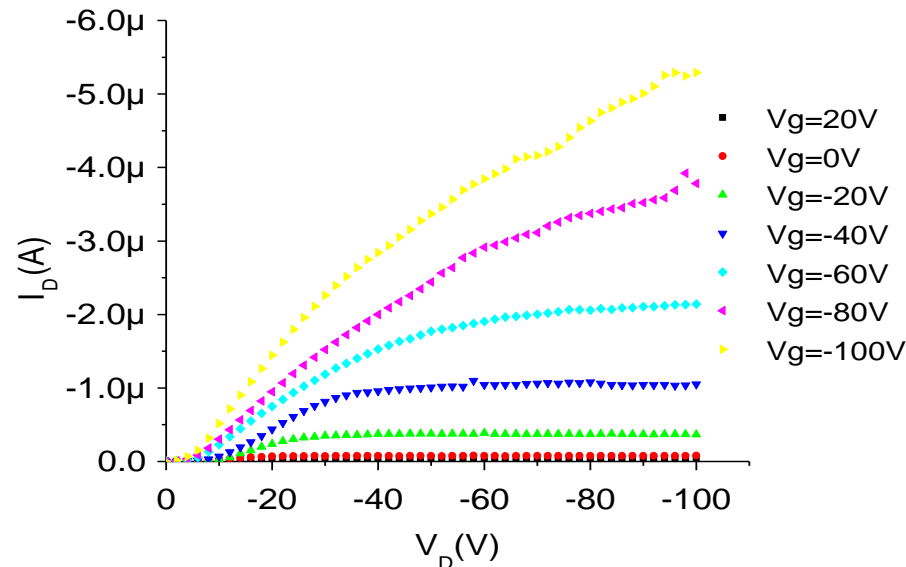


Using a **pentacene buffer layer of 3 nm** nominal thickness, despite the possibly high electron injection barrier (estimated to be ca. 1.9 eV), we found evidence for a n-type conduction, and the electron mobility was *ca.*  $4 \times 10^{-5} \text{ cm}^2/\text{Vs}$ .



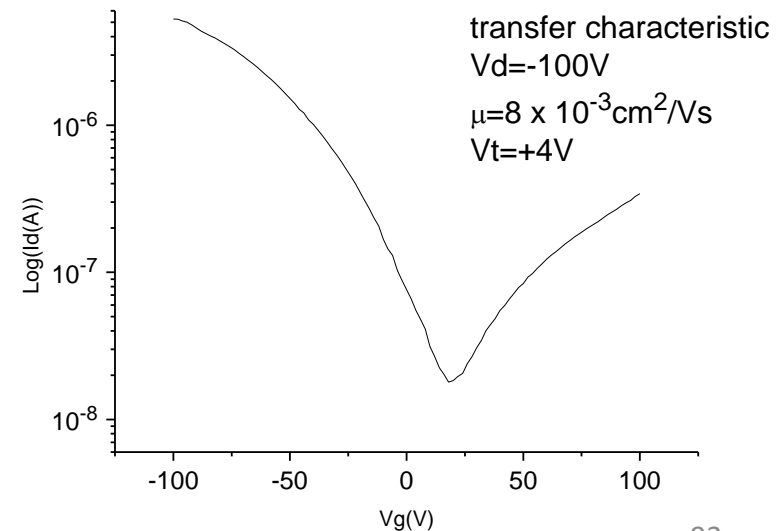


# Ambipolar top contact: p-type

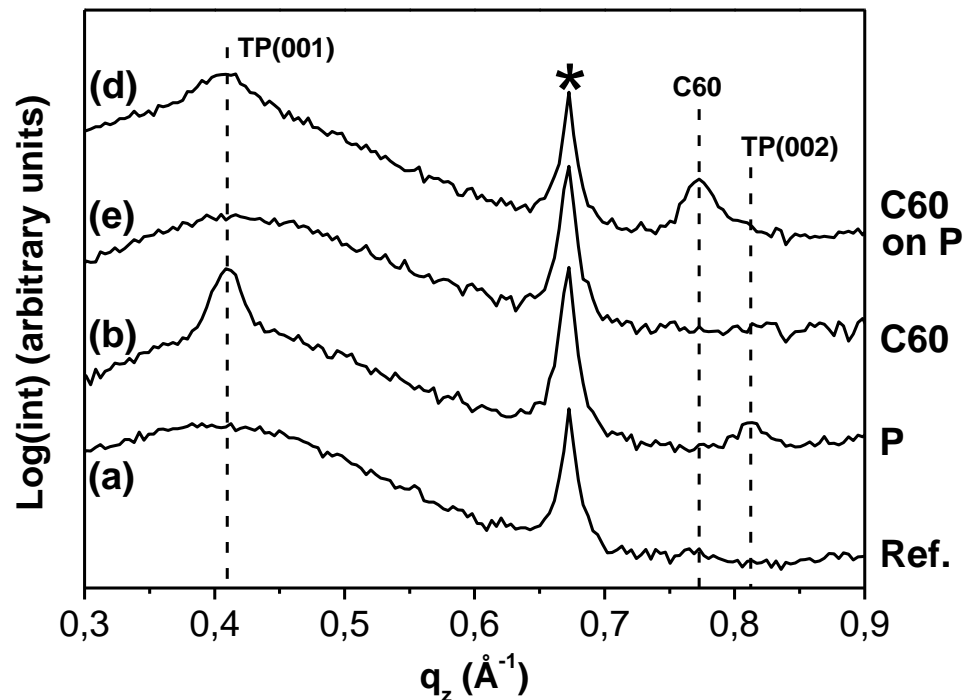


Increasing the **pentacene buffer layer thickness to 10nm** we obtained ambipolar behaviour.

The pentacene layer is thick enough to form a complete monolayer at the interface with the gate dielectric and also p-type conduction can be measured.

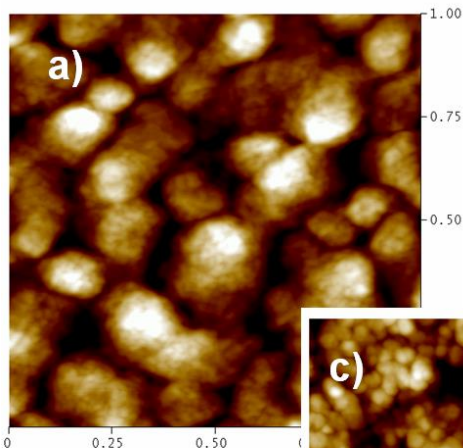


# XRD Analysis

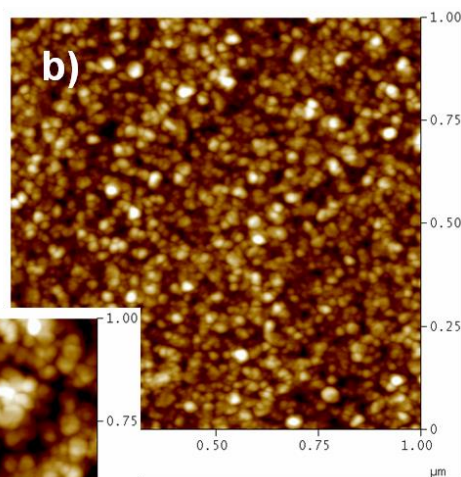


**XRD:** 60 nm thick film of C60 deposited directly on Mylar® does not show any Bragg peaks, in contrast to the film of equal nominal thickness deposited on a 10 nm thick pentacene pre-coating. We find a peak at  $q_z=0.7720 \text{ \AA}^{-1}$  (lattice spacing  $d=0.814\text{nm}$ ) that can be assigned to the (111) reflection of cubic C60 polymorphs as well as to the (002) reflection of hexagonally grown C60.

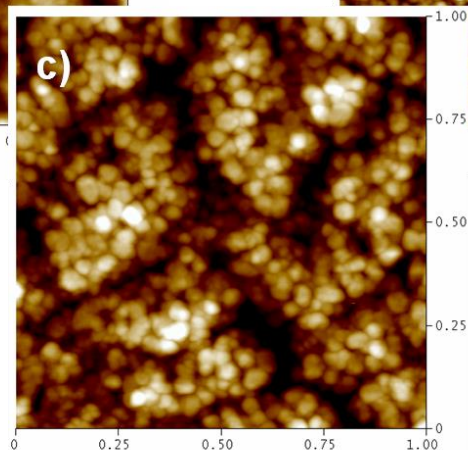
# Morphological characterization



Pent. on bare Mylar®



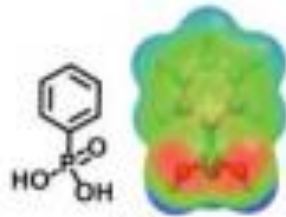
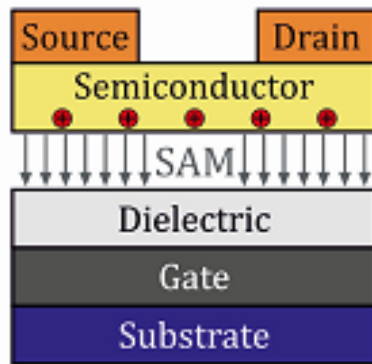
C<sub>60</sub> on bare Mylar®



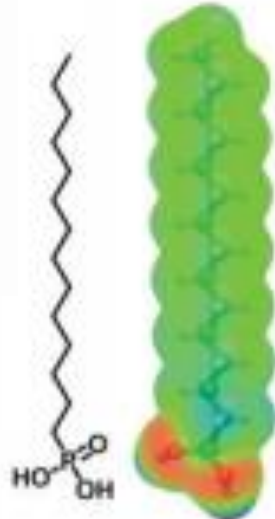
C<sub>60</sub> on 10 nm pent. buffer layer on Mylar®

**AFM:** The C<sub>60</sub> morphology on bare Mylar® is characterized by a granular structure with grain diameters  $< 30\text{nm}$ . We can clearly notice that the nucleation of C<sub>60</sub> grains on top of the underlying pentacene islands leads to significant increase in the average grain size. Together with our finding of crystalline C<sub>60</sub> growth from XRD, this explains the increase of the electron mobility we observed in the OFETs characteristics.

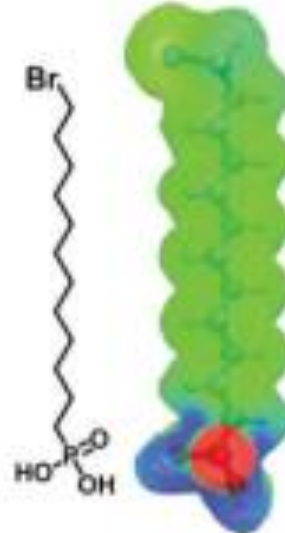
# Dipoles at the insulator/semiconductor interface



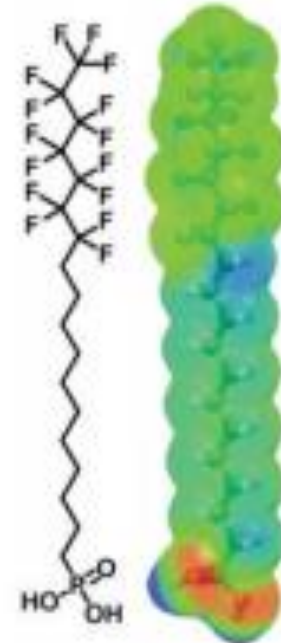
Phenyl



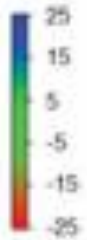
C<sub>14</sub>



BrC<sub>12</sub>



F<sub>15</sub>C<sub>18</sub>





1 IA												18 VIIIA																							
1	1,0079 -1 1,1											2	4,0026 0																						
1	<b>H</b> Idrogeno											18	<b>He</b> Elio																						
2	6,941 +1	4	9,0122 +2											10	20,179 0																				
2	<b>Li</b> Litio	<b>Be</b> Berillio											6	12,011 +4 4,2,0,4	8	15,9994 -1	9	18,9984 -1	10	20,179 0															
3	22,9898 +1	12	24,305 +2											5	10,81 +3	7	14,0067 -3	9	0,99109 -1	10	0,9906 -2	11	18,9984 -1												
3	<b>Na</b> Sodio	<b>Mg</b> Magnesio											4	12,011 -4	6	14,0067 -2	8	15,9994 -2	9	18,9984 -2	10	20,179 -2													
4	39,0983 +1	20	40,08 +2	21	44,9559 +3	22	47,9 +3	23	50,9415 +3	24	51,996 +3	25	54,938 +3	26	55,847 +3	27	58,9332 +3	28	58,7 +3	29	63,546 +2	30	65,38 +2	31	69,72 +3	32	72,59 +4	33	74,9216 -3	34	78,96 -2	35	79,904 -1	36	83,8 +2
4	<b>K</b> Potassio	<b>Ca</b> Calcio	<b>Sc</b> Scandio	<b>Ti</b> Titanio	<b>V</b> Vanadio	<b>Cr</b> Cromo	<b>Mn</b> Manganese	<b>Fe</b> Ferro	<b>Co</b> Cobalto	<b>Ni</b> Nikel	<b>Cu</b> Rame	<b>Zn</b> Zinco	<b>Ga</b> Gallio	<b>Ge</b> Germanio	<b>As</b> Arsenico	<b>Se</b> Selenio	<b>Br</b> Bromo	<b>Kr</b> Kripton																	
5	85,4678 +1	38	87,62 +2	39	88,9059 +3	40	91,22 +4	41	92,9064 +5	42	95,94 +6	43	98 +7	44	101,07 +8	45	102,9055 +8	46	106,4 +8	47	107,868 +1	48	112,41 +2	49	114,82 +3	50	118,69 +4	51	121,75 -2	52	127,6 -2	53	126,9045 +1	54	131,3 +2
5	<b>Rb</b> Rubidio	<b>Sr</b> Stronzio	<b>Y</b> Ittrio	<b>Zr</b> Zirconio	<b>Nb</b> Niobio	<b>Mo</b> Molibdeno	<b>Tc</b> Tecnezio	<b>Ru</b> Rutenio	<b>Rh</b> Rodio	<b>Pd</b> Palladio	<b>Ag</b> Argento	<b>Cd</b> Cadmio	<b>In</b> Indio	<b>Sn</b> Stagno	<b>Sb</b> Antimonio	<b>Te</b> Tellurio	<b>I</b> Iodio	<b>Xe</b> Xenon																	
6	132,9054 +1	56	137,33 +2	57	138,9055 +3	72	178,49 +4	73	180,9479 +5	74	183,85 +6	75	186,207 +7	76	190,2 +8	77	192,22 +8	78	195,09 +8	79	196,9665 +3	80	200,59 +2	81	204,37 +3	82	207,2 +4	83	208,9804 +5	84	(209) +4	85	(210) +3	86	(222) +2
6	<b>Cs</b> Cesio	<b>Ba</b> Bario	<b>La</b> Lantanio	<b>Hf</b> Afio	<b>Ta</b> Tantalio	<b>W</b> Tungsteno	<b>Re</b> Renio	<b>Os</b> Osmio	<b>Ir</b> Inridio	<b>Pt</b> Platino	<b>Au</b> Oro	<b>Hg</b> Mercurio	<b>Tl</b> Tallio	<b>Pb</b> Piombo	<b>Bi</b> Bismuto	<b>Po</b> Polonio	<b>At</b> Astatio	<b>Rn</b> Radon																	
7	87 +1	88 +2	89 +3	104 +4	105 +5	106 +6	107 +7	108 +8	109 +8	110 +8	111 +7																								
7	<b>Fr</b> Francio	<b>Ra</b> Radio	<b>Ac</b> Attinio	<b>Rf</b> Rutherfordio	<b>Db</b> Dubnio	<b>Sg</b> Seaborgio	<b>Bh</b> Bohrio	<b>Hs</b> Hassio	<b>Mt</b> Meitnerio	<b>Ds</b> Darmstadio	<b>Rg</b> Roentgenio																								

**Metalli Alcalini** (Giallo)  
**Metalli Alcalino-Terrosi** (Arancione)  
**Lantanidi** (Viola)  
**Attinidi** (Magenta)

**Elementi di Transizione** (Rosso)  
**Metalloidi / Non Metalli** (Azzurro)  
**Alogeni** (Ciano)  
**Gas Nobili** (Verde)

STATI di AGGREGAZIONE a 20 °C

**SOLIDI** (Nero)  
**LIQUIDI** (Blu)  
**GASSOSI** (Rosso)  
**ARTIFICIALI** (Bianco)

Periodo

Gruppo

Numero Atomico (1), Peso Atomico (1,0079), Numero di Ossidazione (1, -1), Simbolo (**H**), Nome (Idrogeno), Valenza (-1), Densità (g/cm<sup>3</sup>) (0,00008989), Temp. Fusione (°C) (-252, -253), Temp. Ebollizione (°C) (-253)

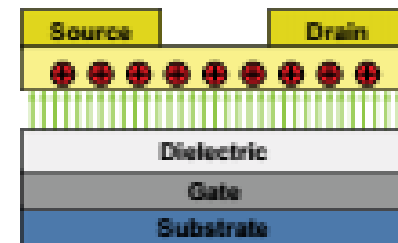
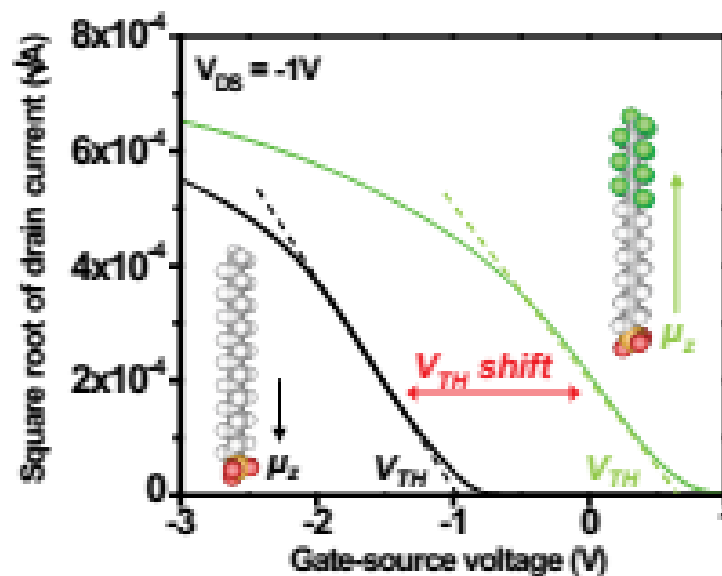
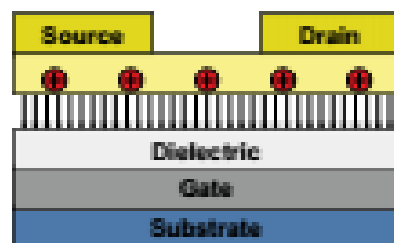
58	140,12	59	140,9077	60	144,24	61	(145)	62	150,4	63	151,96	64	157,25	65	158,9254	66	162,5	67	164,9304	68	167,26	69	168,9342	70	173,04	71	174,967
<b>Ce</b>	<b>Pr</b>	<b>Nd</b>	<b>Pm</b>	<b>Sm</b>	<b>Eu</b>	<b>Gd</b>	<b>Tb</b>	<b>Dy</b>	<b>Ho</b>	<b>Er</b>	<b>Tm</b>	<b>Yb</b>	<b>Lu</b>	Serie dei Lantanidi													
<b>Cerio</b>	<b>Praseodimio</b>	<b>Neodimio</b>	<b>Promezio</b>	<b>Samario</b>	<b>Europio</b>	<b>Gadolinio</b>	<b>Terbio</b>	<b>Disprosio</b>	<b>Olmio</b>	<b>Erbio</b>	<b>Tulio</b>	<b>Itterbio</b>	<b>Lutezio</b>														
90	232,0381	91	(209)	92	238,029	93	237,048	94	(244)	95	(243)	96	(247)	97	(247)	98	(251)	99	(252)	100	(257)	101	(258)	102	(259)	103	(260)
<b>Th</b>	<b>Pa</b>	<b>U</b>	<b>Np</b>	<b>Pu</b>	<b>Am</b>	<b>Cm</b>	<b>Bk</b>	<b>Cf</b>	<b>Es</b>	<b>Fm</b>	<b>Md</b>	<b>No</b>	<b>Lr</b>	Serie degli Attinidi													
<b>Torio</b>	<b>Protoattinio</b>	<b>Uranio</b>	<b>Nettunio</b>	<b>Plutonio</b>	<b>Americio</b>	<b>Curio</b>	<b>Berchelio</b>	<b>Californio</b>	<b>Einsteinio</b>	<b>Fermio</b>	<b>Mendelevio</b>	<b>Nobelio</b>	<b>Laurenzio</b>														

# Dipoles at the insulator/semiconductor interface

If the SAM layer is uniform and well ordered, the functional groups can induce a surface potential

Helmholtz

$$V_{SAM} \propto \frac{N\mu_z \cos\theta}{\epsilon_{SAM} \epsilon_0}$$



# Dipoles at the insulator/semiconductor interface

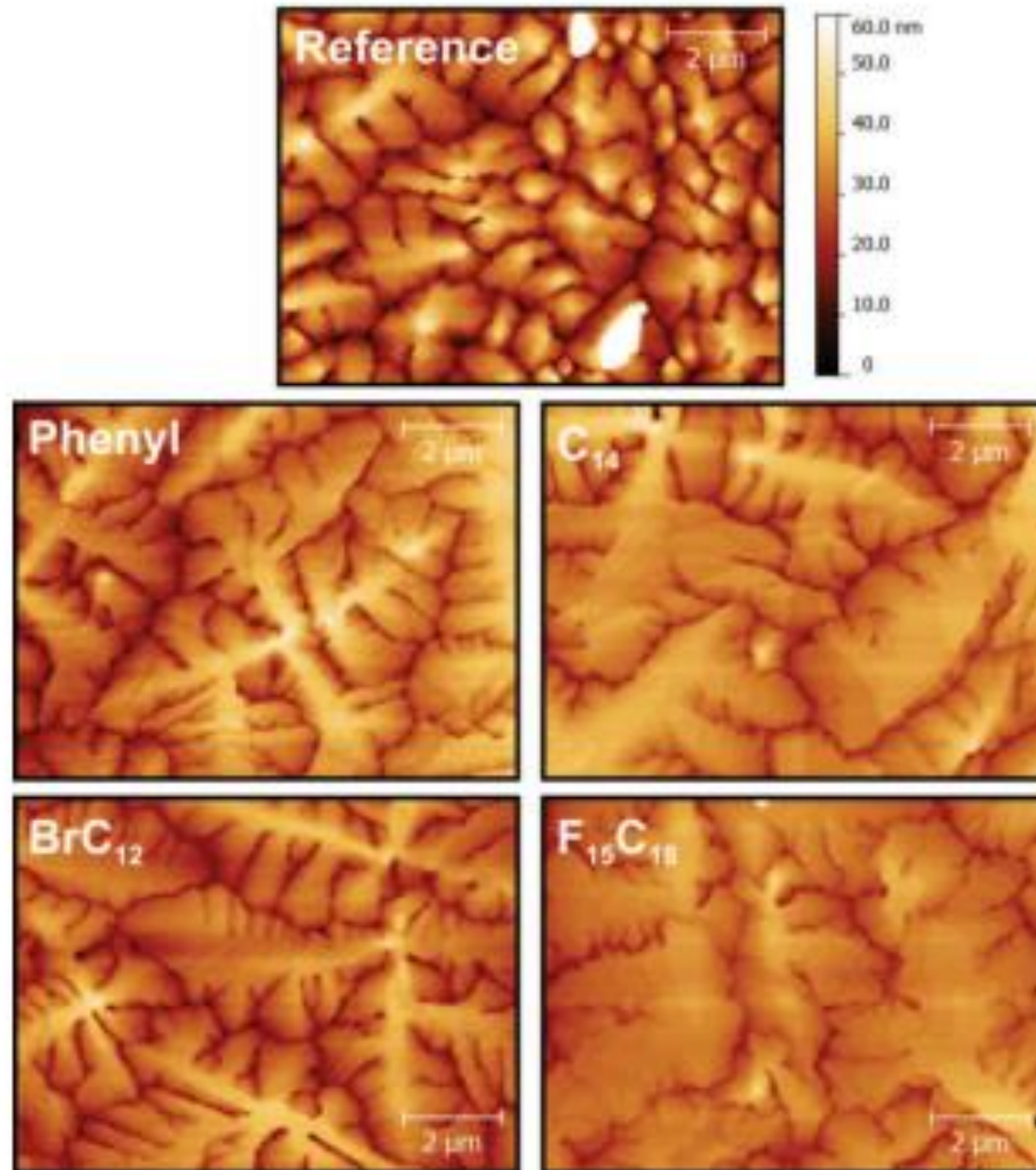
**Table 1: Total dipole moments  $\mu$  and their z-components  $\mu_z$ .**

Molecule	Dipole moment $\mu$ (D)	$\mu_z$ (D)
<b>Phenyl</b>	1.234	0.721
<b>C<sub>14</sub></b>	1.069	0.274
<b>BrC<sub>12</sub></b>	2.106	-0.852
<b>F<sub>15</sub>C<sub>18</sub></b>	2.792	-2.270

**Table 5: Electrostatic potentials calculated according to Equation (13).**

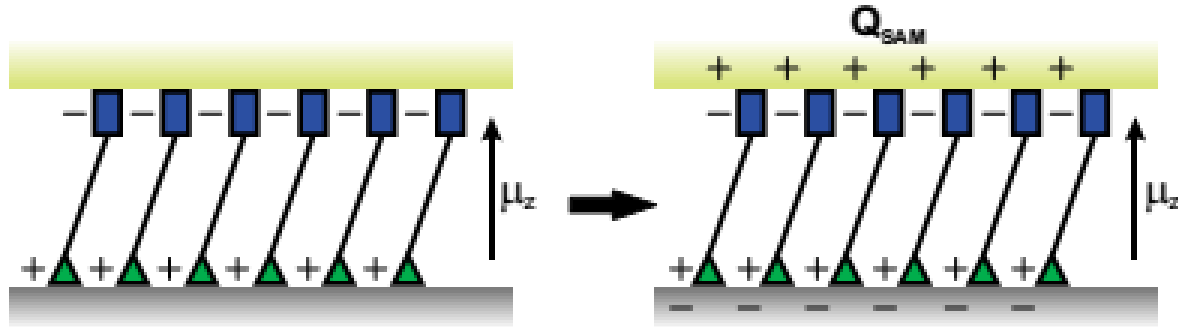
SAM	Phenyl	C <sub>14</sub>	BrC <sub>12</sub>	F <sub>15</sub> C <sub>18</sub>
$\mu_z$ (D)	0.721	0.274	-0.852	-2.270
$V_{SAM, 10\text{ nm}}$ (V)	0.67	0.24	-0.82	-2.30
$V_{SAM, 20\text{ nm}}$ (V)	0.52	0.22	-0.71	-2.33
$V_{SAM, 40\text{ nm}}$ (V)	0.33	0.19	-0.66	-2.44
$V_{SAM, 80\text{ nm}}$ (V)	0.44	0.14	-0.47	-2.25

# Dipoles at the insulator/semiconductor interface





# Dipoles at the insulator/semiconductor interface



**Figure 38: Schematic of charge rearrangement in the proximity of the SAM. The negative dipole moment perpendicular to the surface of the SAM induces mobile holes in semiconductor ( $Q_{SAM}$ ).**

If a vertical field is applied,  $V_{gs}$ , the charges concentration  $Q_{eff}$  accumulated in the semiconductor is proportional to the applied voltage and to the dielectric capacitance  $C_{tot}$ :

$$Q_{eff} = V_{GS} C_{tot}$$

# Dipoles at the insulator/semiconductor interface

$$C_{tot} = \left( \frac{1}{C_{ins}} + \frac{1}{C_{SAM}} \right)^{-1} \quad (23)$$

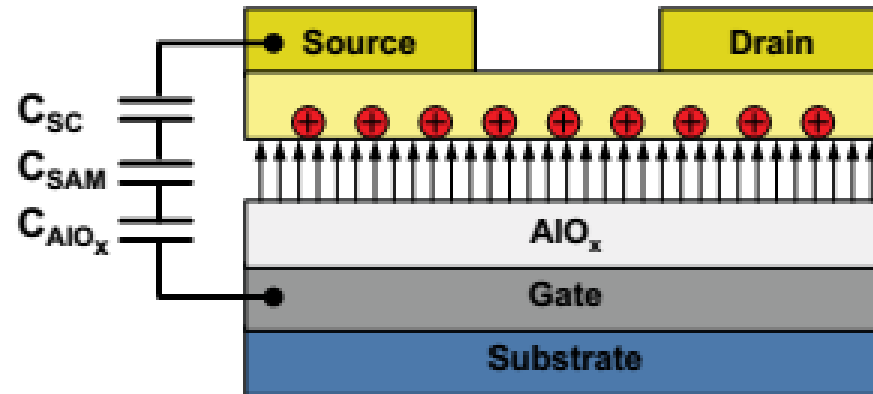


Figure 39: Effect of the electrostatic potential in the OTFT device. Additional mobile holes are induced in the semiconductor.

$$\Delta V_{GS} = V_{SAM} \frac{C_{SAM}}{C_{tot}} = -\Delta V_{th}$$

The sign of  $\Delta V_t$  depends on the dipole moment induced by the (negative, electronegative elements, larger hole accumulation, shift of  $V_t$  towards more positive values and viceversa)

# Dipoles at the insulator/semiconductor interface

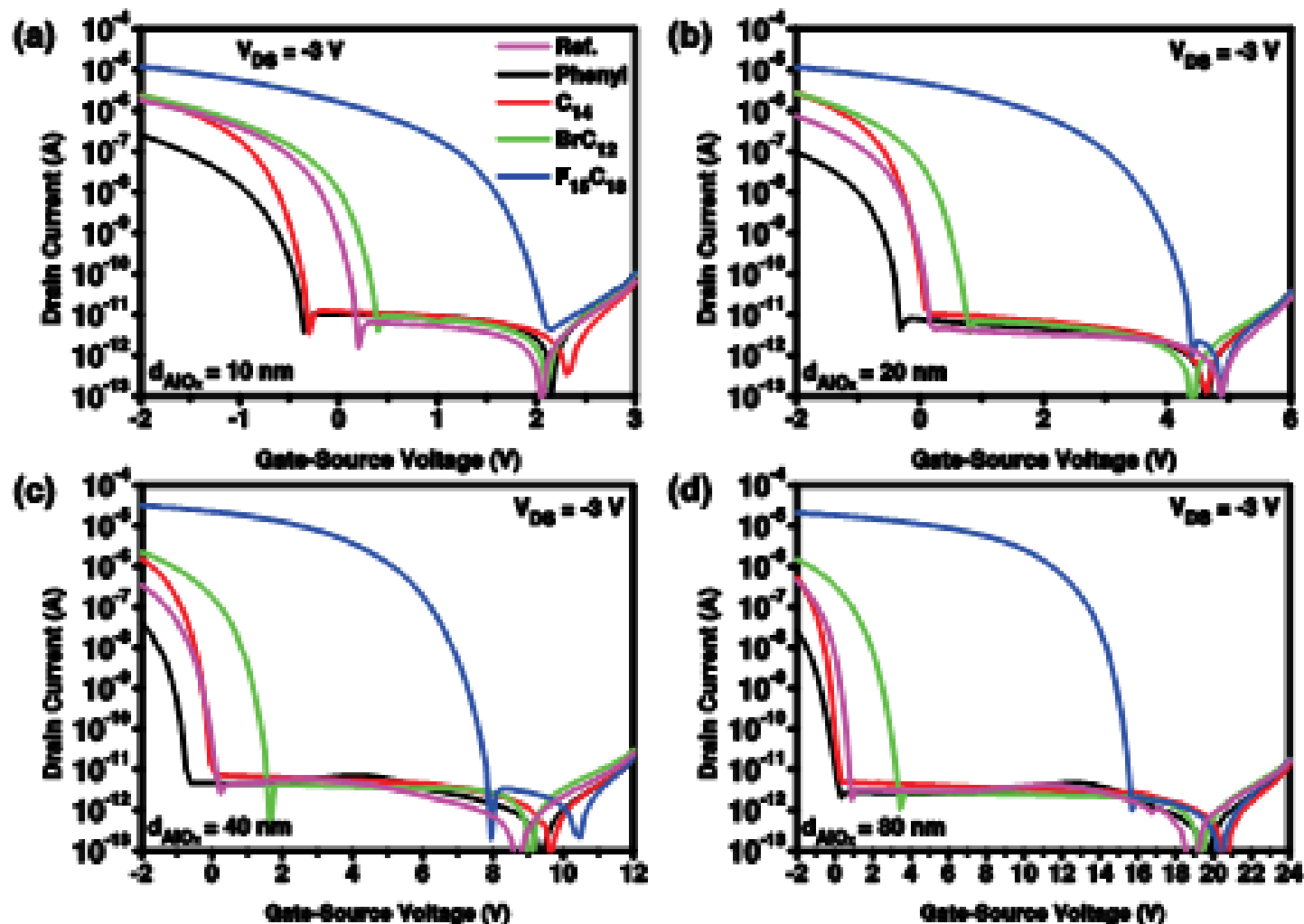
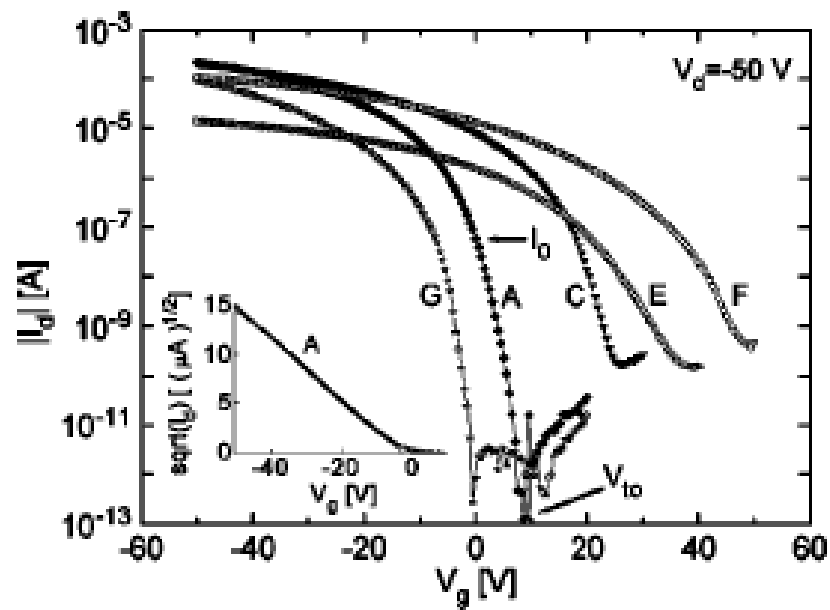
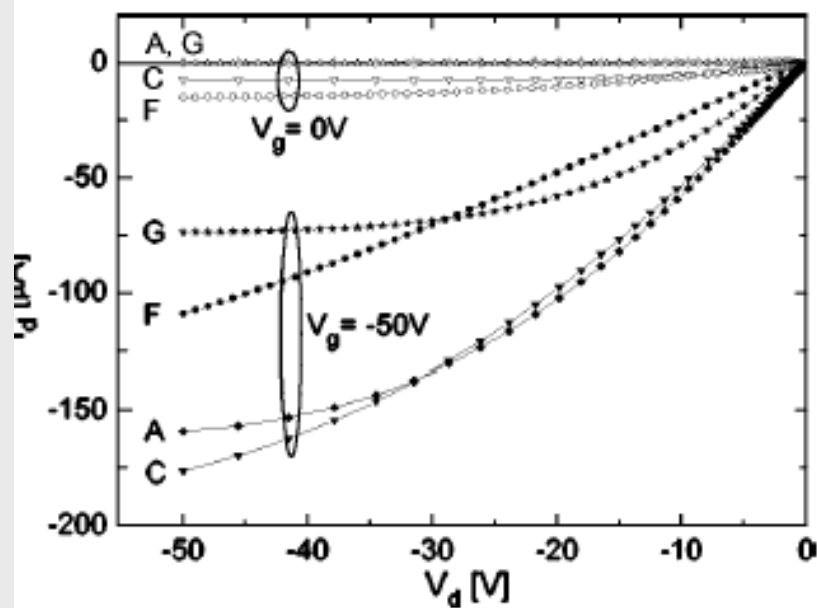
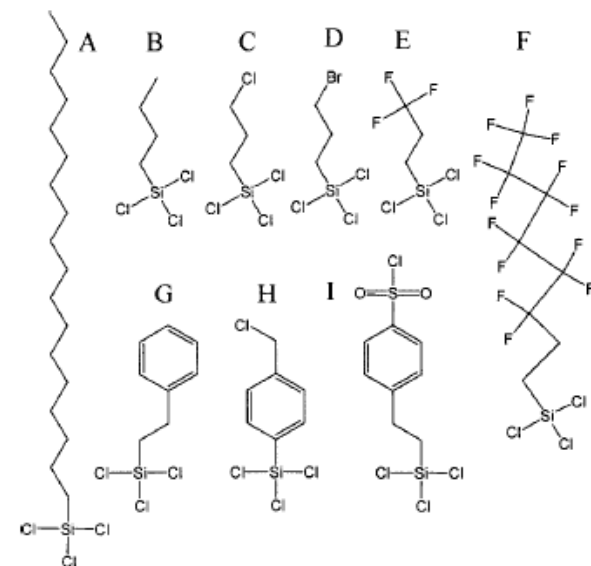
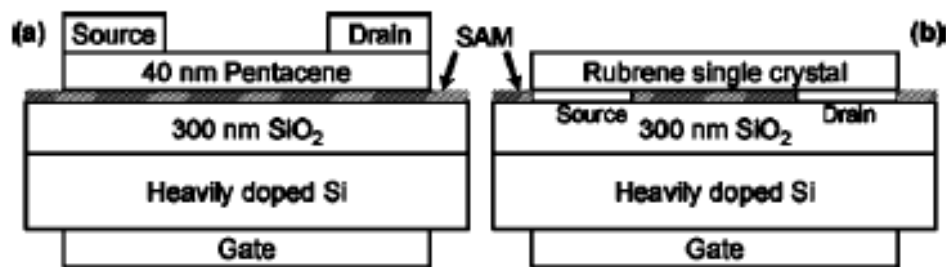


Figure 36: Transfer characteristics for different SAMs and for different ALD-AlO<sub>x</sub> thicknesses: 10 nm (a), 20 nm (b), 40 nm (c) and 80 nm (d).

# Dipoles at the insulator/semiconductor interface



# Dipoles at the insulator/semiconductor interface

	$\Theta$ (deg)	$\mu$ (cm <sup>2</sup> /V s)	$V_i$ (V)	$V_{fo}$ (V)	$S$ (V/dec.)	$ I_0 $ (A)
(A) Octadecyltrichlorosilane	95	0.96(16)	-3.7(1.0)	4.7	0.9	10 <sup>-8</sup>
(B) Butyltrichlorosilane	93	0.61(11)	-4.3(0.5)	4.7	1.1	10 <sup>-8</sup>
(C) 3-Chloropropyltrichlorosilane	75	0.71(09)	1.5(1.8)	16	1.8	10 <sup>-6</sup>
(D) 3-Bromopropyltrichlorosilane	80	0.74(13)	2.8(2.8)	17	2	10 <sup>-6</sup>
(E) Trichloro(3,3,3-trifluoropropyl)silane	91	0.03(0.1)	22.7(5.2)	33	4.9	10 <sup>-7</sup>
(F) 1H,1H,2H,2H-Perfluorooctyl-trichlorosilane	105	0.15(0.2)	26(2.0)	44	4.9	10 <sup>-6</sup>
(G) Phenethyltrichlorosilane	92	0.71(11)	-12.7(1.2)	-1.5	0.9	10 <sup>-12</sup>
(H) 4-(Chloromethyl)phenyltrichlorosilane	88	0.56(12)	-7(1)	4	1.2	10 <sup>-8</sup>
(I) 2-(4-Chlorosulfonylphenyl)ethyltrichlorosilane	90	0.36(05)	25(3)	49	4.4	10 <sup>-5</sup>

**Electronegative functional groups lead to a  $V_T$  variation towards more positive values**

*Pernstich et al. J. Appl. Phys. 96, 11, 2004*

*Jang et al. Appl. Phys. Lett. 90, 132104, 2007*

# Bias stress

# Bias Stress

Se il dispositivo viene sottoposto ad una polarizzazione continua le sue caratteristiche elettriche possono variare nel tempo

Diminuzione della corrente di uscita, indotta da uno shift della tensione di soglia

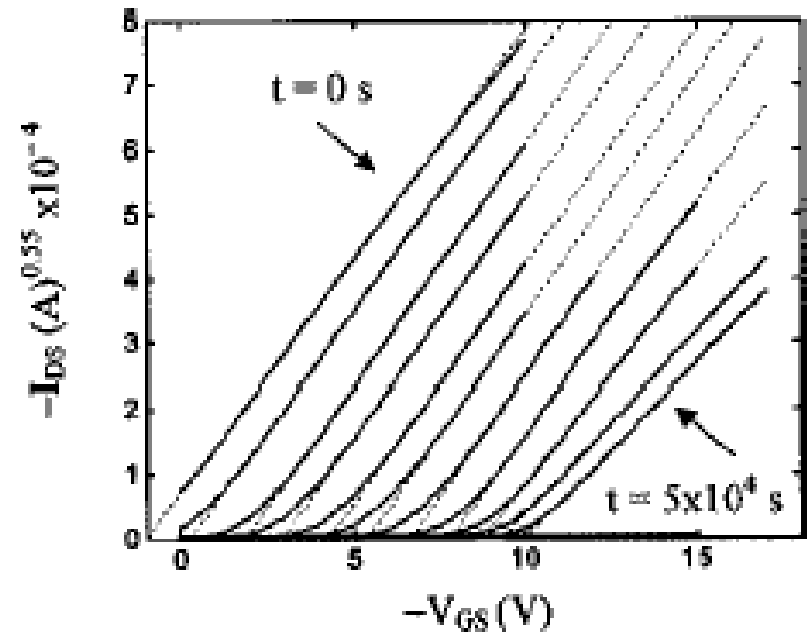
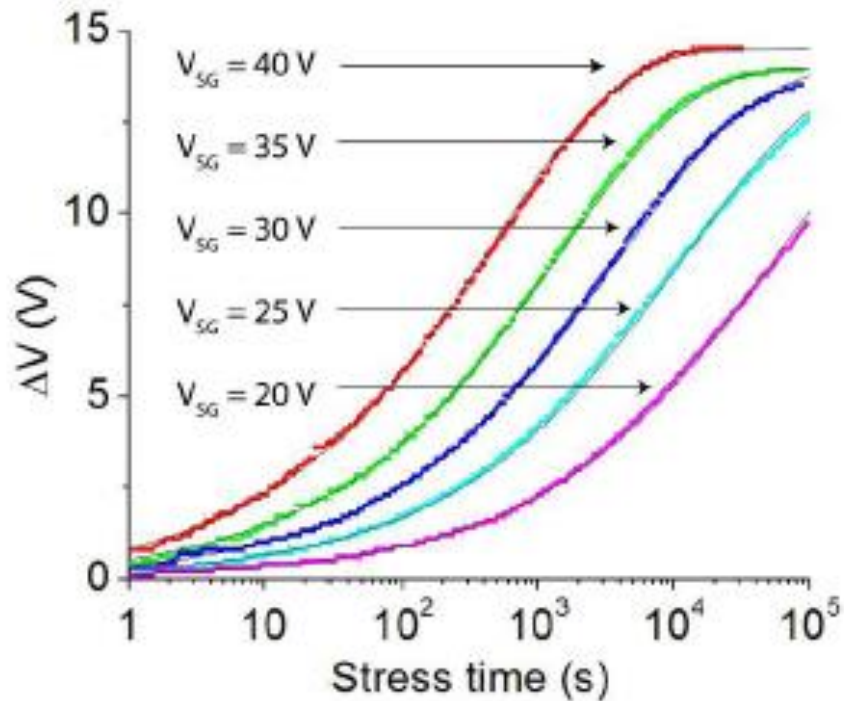
L'elevata concentrazione di stati trappola fa sì che i portatori di carica vengano via via intrappolati e sottratti alla conduzione!

$V_t$  tende a traslare verso valori più elevati in modulo

# Bias Stress

Il fenomeno dipende prevalentemente dalla  $V_{GS}$

Il fenomeno tende a saturare





# Bias Stress

La variazione di  $V_t$  dovuta alla polarizzazione continua è dovuta all'intrappolamento di lacune

Considerando  $p$  la concentrazione di lacune iniziale e  $p_t$  quella di lacune intrappolate

$$\Delta V_{th} = \frac{qp_t}{C_{ins}}$$

Affinchè avvenga intrappolamento deve esserci una lacuna libera, ma anche una trappola vuota, da cui il rate di intrappolamento diventa:

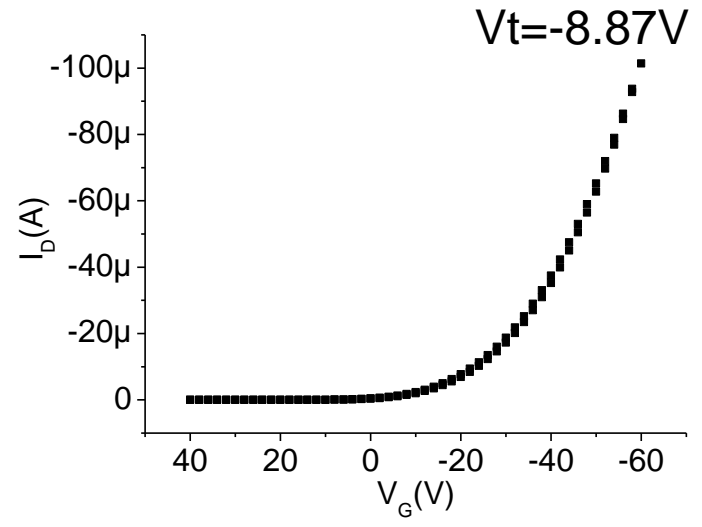
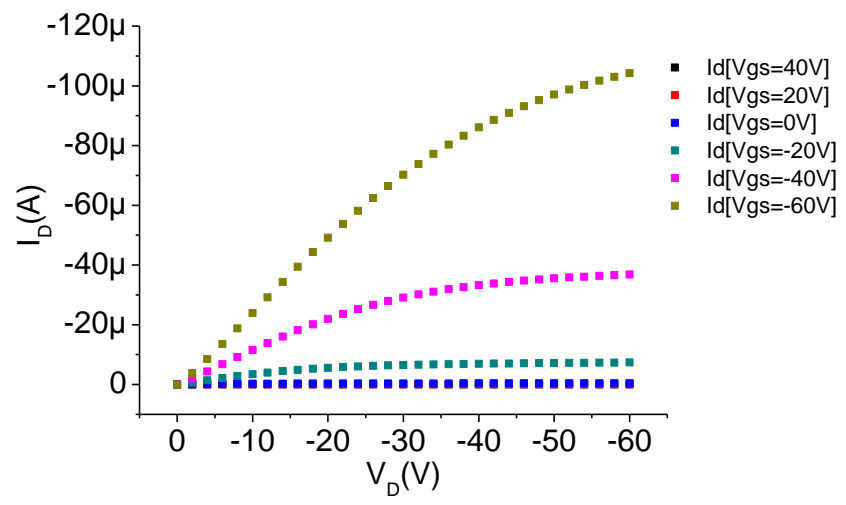
$$\frac{dp_t}{dt} = k(p - p_t)(N_t - p_t) \quad \Delta V_{th}(t) \propto \left( 1 - e^{\left( -\frac{t}{\tau} \right)^\beta} \right)$$

# Bias Stress

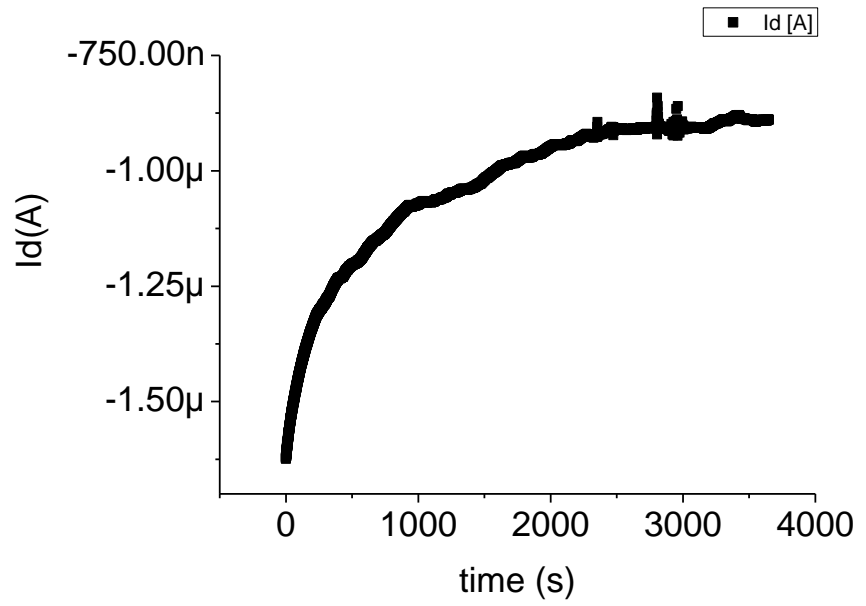
Se nel frattempo non subentrano altri fenomeni parassiti (es.: modifica permanente dello stato attivo → ossidazione del semiconduttore), il fenomeno è reversibile!

- a) Rimuovere la polarizzazione e aspettare che gli stati trappola si svuotino
- b) Applicare una polarizzazione opposta

# Bias Stress – caso 1



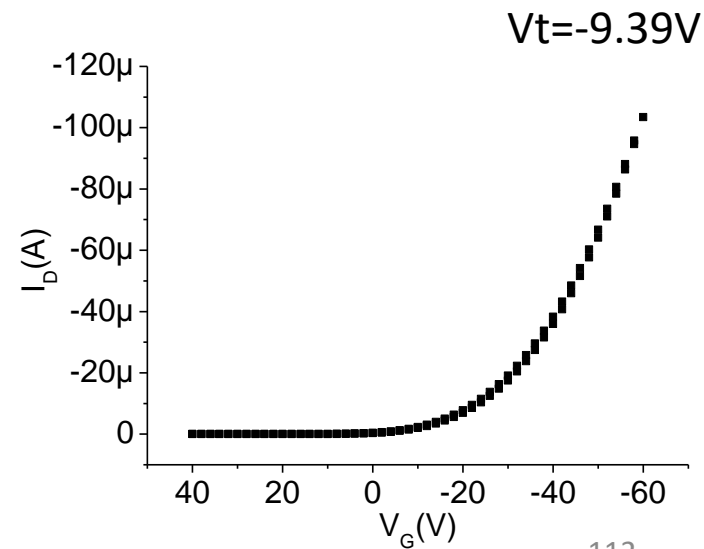
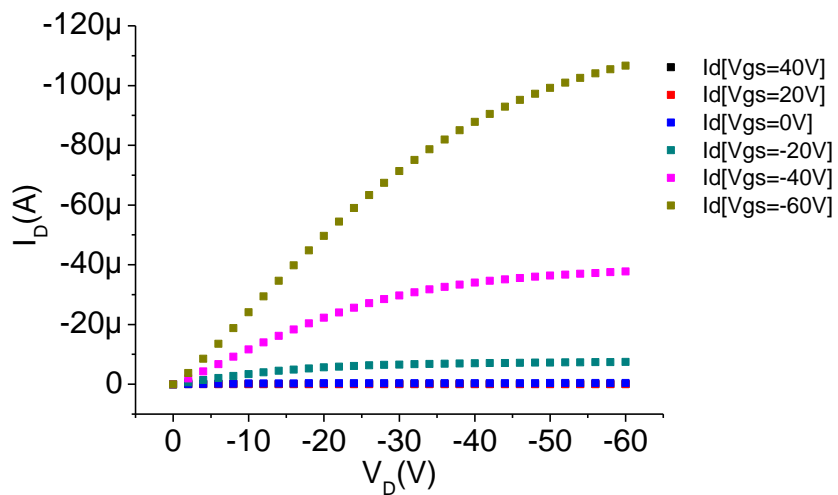
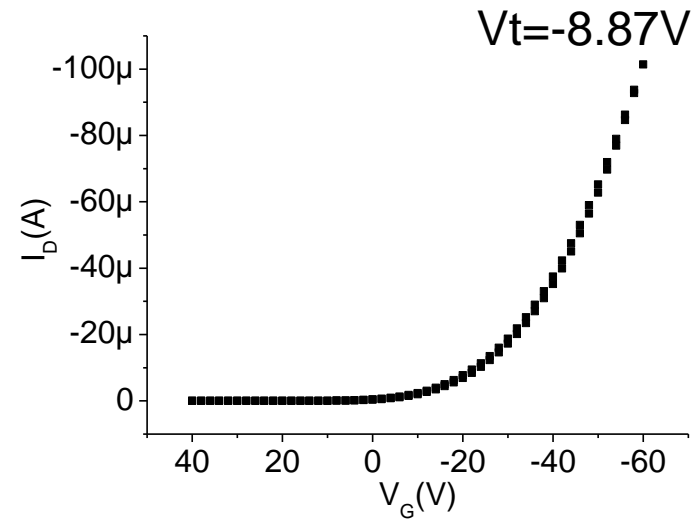
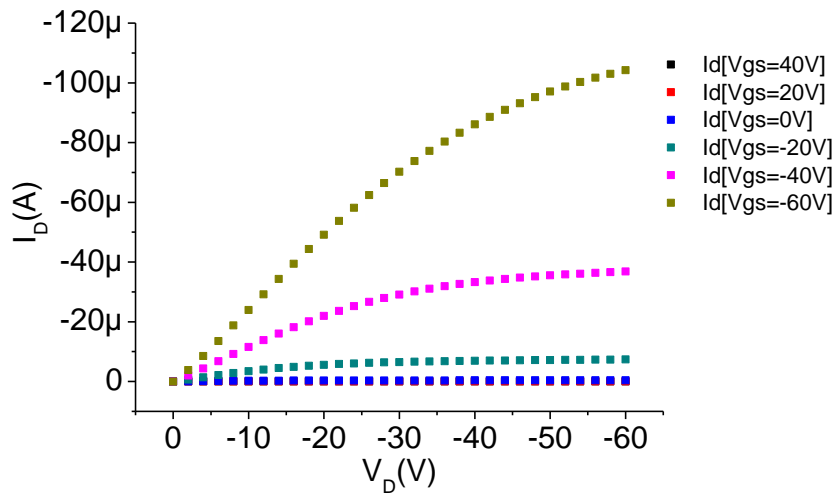
$V_d = -20$   
 $V_g = -10$   
60 min



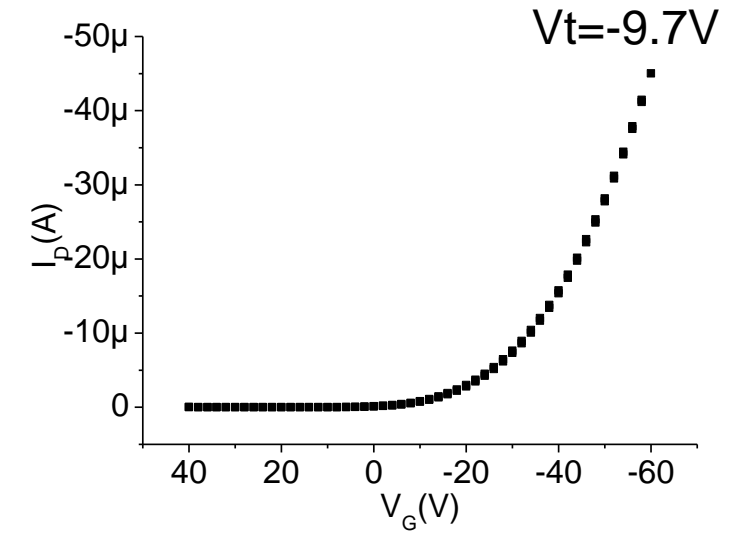
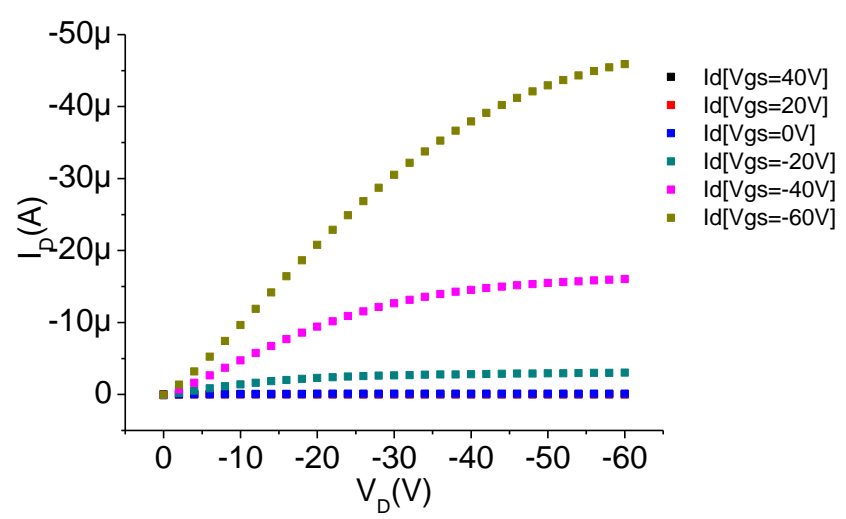
La corrente  
decesce

$V_t$  shift

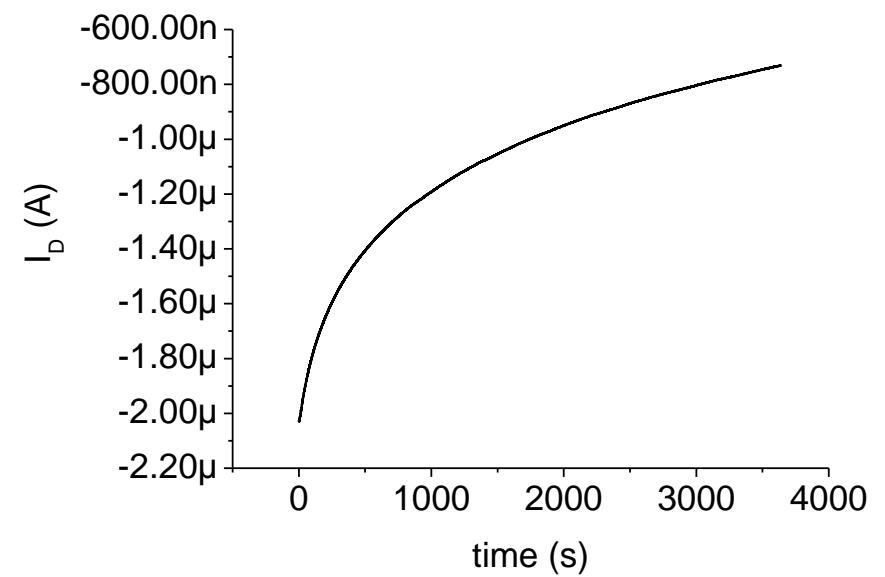
# Bias Stress – caso 1



# Bias Stress – caso 2

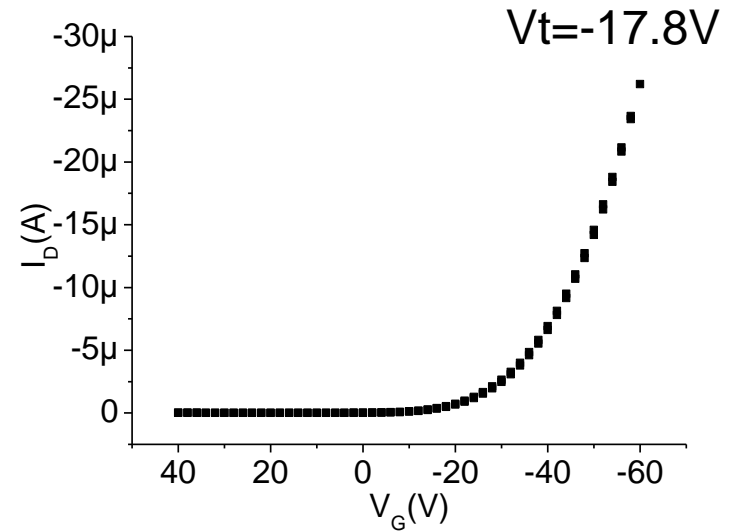
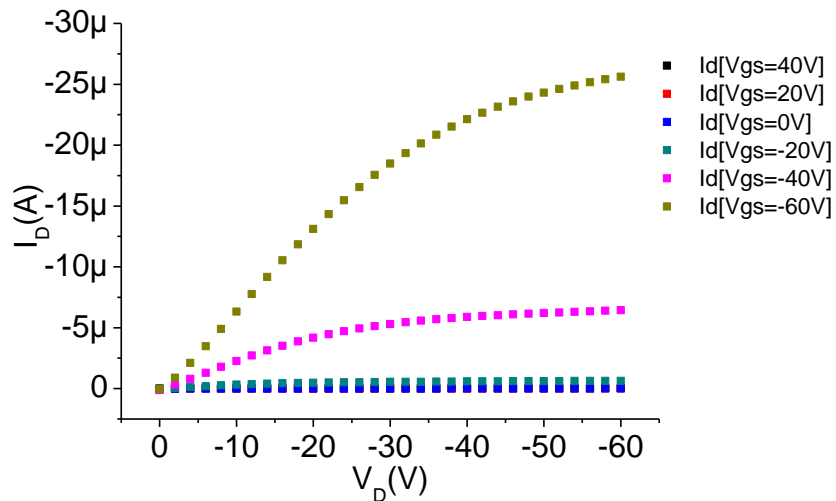


$V_d = -5$   
 $V_g = -40$   
 60 min

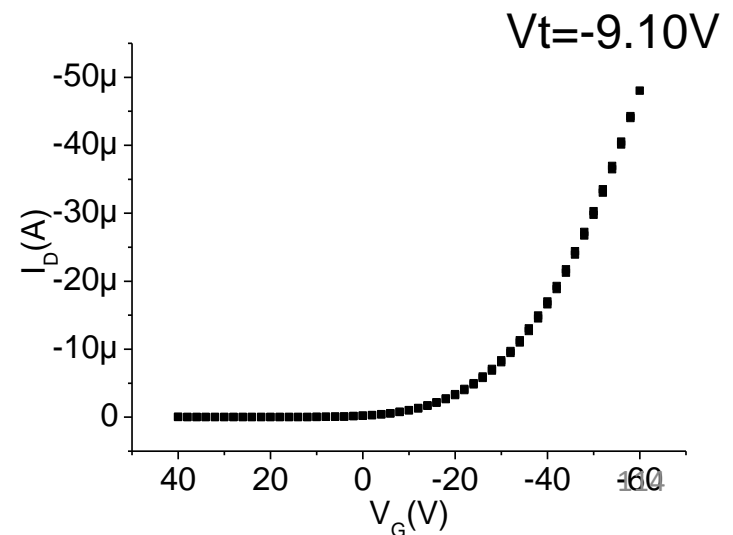
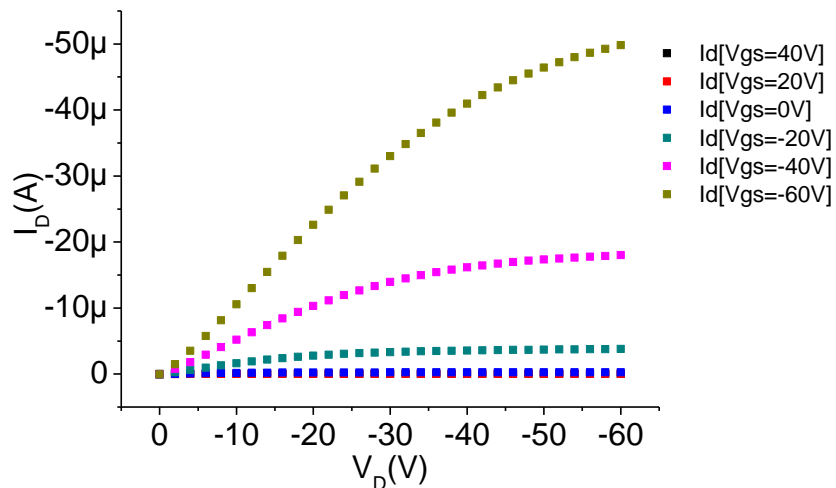


La corrente  
 decresce  
  
 $V_t$  shift

# Bias Stress

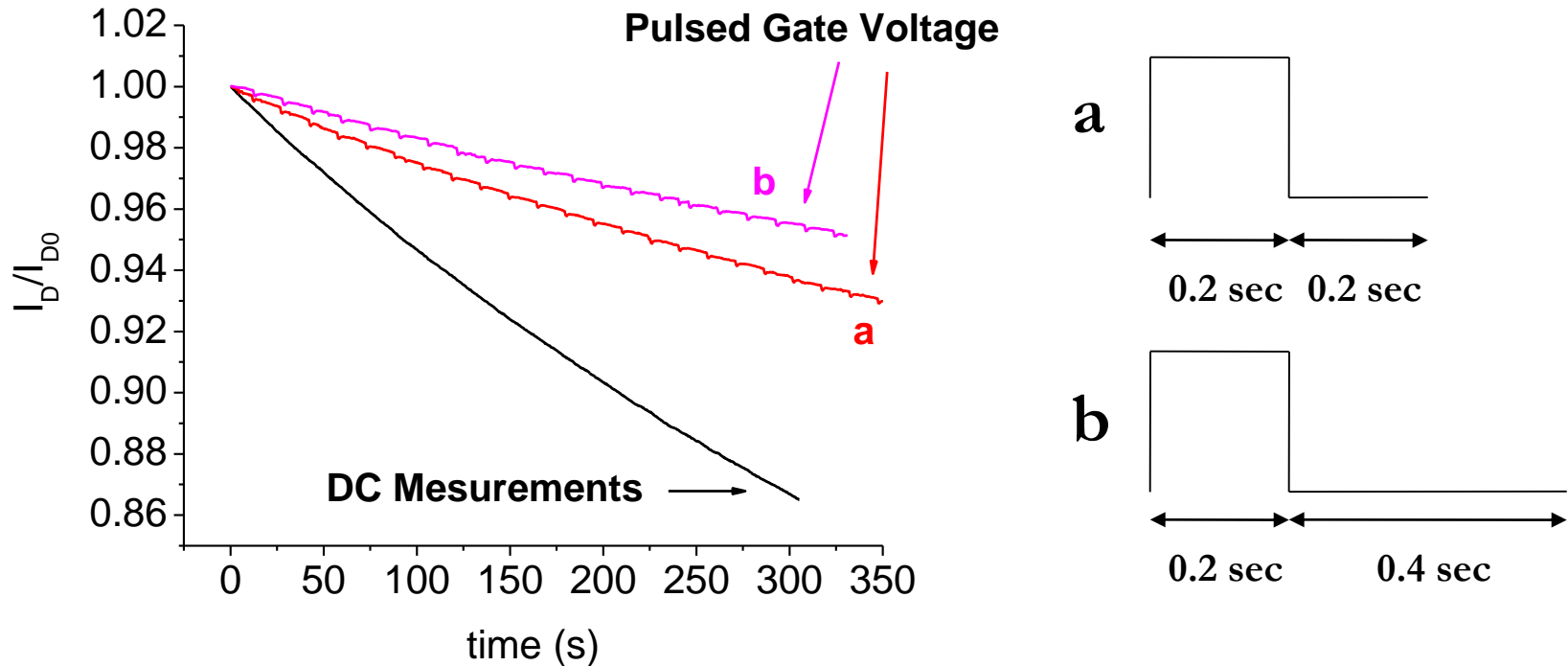


Se applico una polarizzazione positiva al gate ( $V_{GS}=+40V$  per 60 secondi)  $\rightarrow$  detrappolamento!  $V_t$  ritorna al valore iniziale



# Bias Stress

Il fenomeno di bias stress può essere fortemente ridotto applicando una polarizzazione impulsata al gate e settando opportunamente il duty cycle

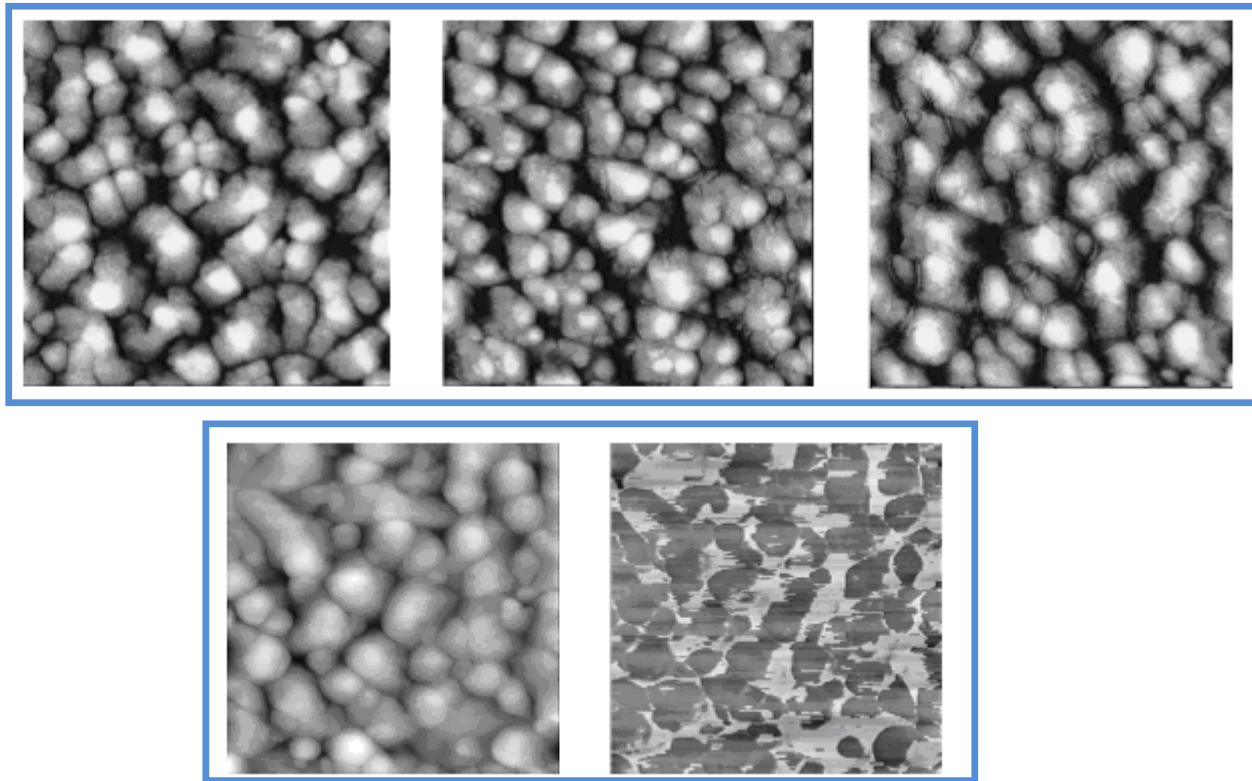


# Degradazione dello strato attivo



# Degradazione dello strato attivo: H<sub>2</sub>O

L'acqua (H<sub>2</sub>O) penetra all'interno dello strato attivo del semiconduttore organico raggiungendo l'interfaccia isolante-semiconduttore, modificando la morfologia del film stesso



**Incremento della densità di trappole ai bordi di grano**

# Degradazione dello strato attivo:H<sub>2</sub>O

Quando il dispositivo si trova nello **stato di “on”**

La maggiore concentrazione di stati trappola vicino al canale porta ad una marcata riduzione della mobilità, e, di conseguenza, della corrente di uscita

Quando il dispositivo si trova nello **stato di “off”**

(il che significa tensione di gate è inferiore alla tensione di soglia), la presenza di un sottile film polare incrementa la conduttività tra source e drain, questo comporta un aumento della corrente di off e un decremento del rapporto  $|I_{on}| / |I_{off}|$

# Degradazione dello strato attivo: O<sub>2</sub>

A causa della sua elettronegatività l'ossigeno attrae elettroni dalle molecole del semiconduttore → accumulo di lacune nel canale!

- *Aumento corrente di off*
- *Shift della tensione di soglia*

## Processo reversibile

Inoltre, può portare ad un processo di ossidazione della molecola


incrementando l'altezza di barriera nel processo di hopping

- *Diminuzione della mobilità*

## Processo irreversibile


# Incapsulamento

- La barriera deve essere sufficientemente robusta da permettere di maneggiare l'OTFT senza provocare danni, nonché proteggerlo da possibili urti, vibrazioni, etc.
- Il processo di deposizione deve essere compatibile con i materiali utilizzati per la realizzazione del dispositivo e in particolare non deve danneggiare lo strato attivo;
- La barriera deve essere flessibile
- Il rate di permeazione dell'acqua (Water Vapor Transmission Rate, WVTR) inferiore a  $10^{-6}$ g/m<sup>2</sup> day
- Il rate di permeazione dell'ossigeno (Oxygen Transmission Rate, OTR) tra  $10^{-5}$  e  $10^{-3}$ cm<sup>3</sup>/m<sup>2</sup> day per essere considerato un buon package
- La barriera deve essere stabile nel tempo.


 Organic semiconductor

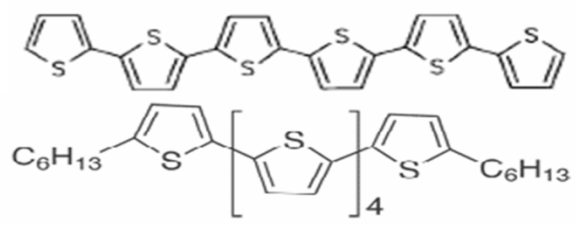
 PEDOT:PSS

 Au

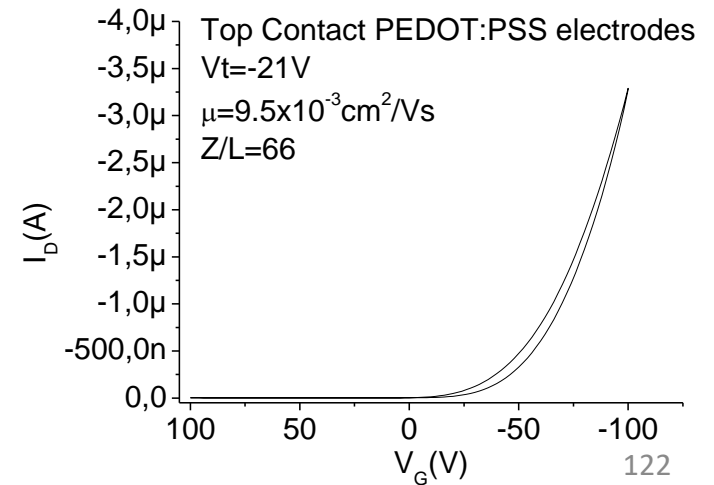
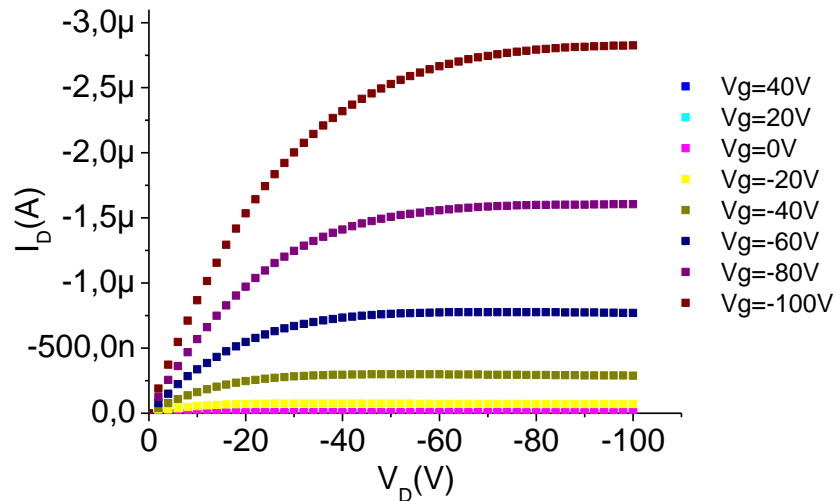
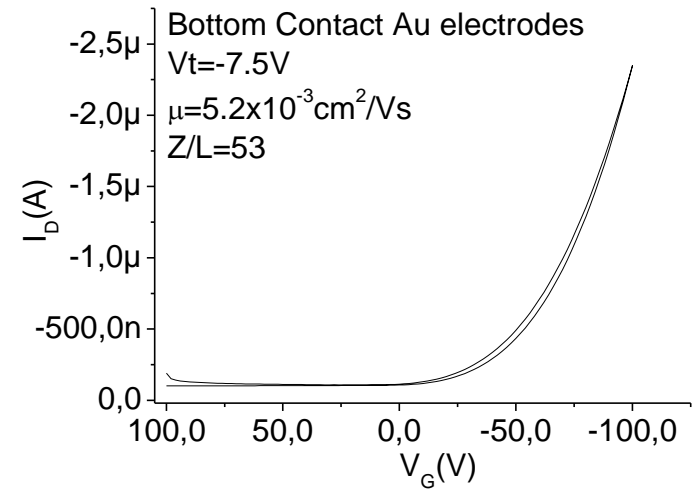
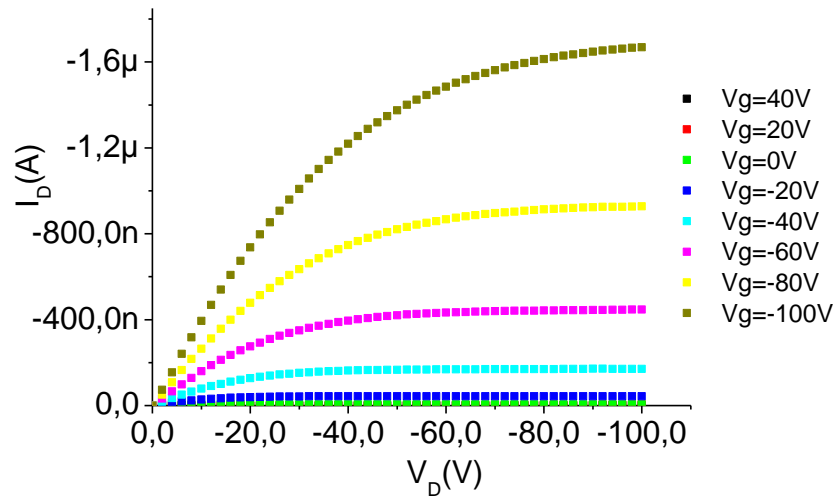
 Mylar®

 SiO<sub>2</sub>

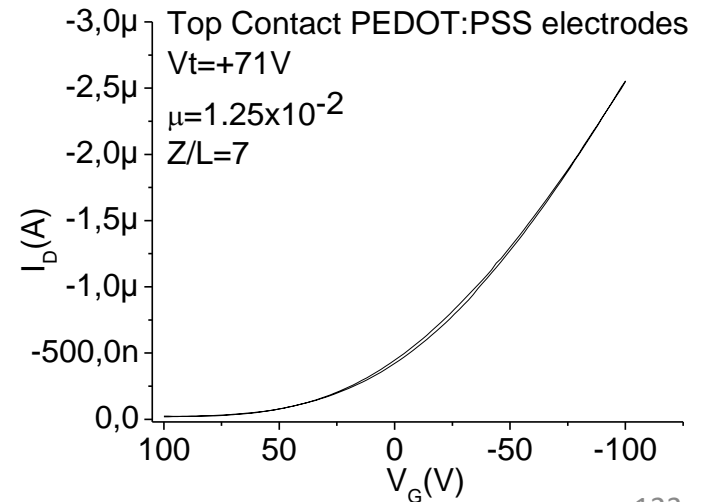
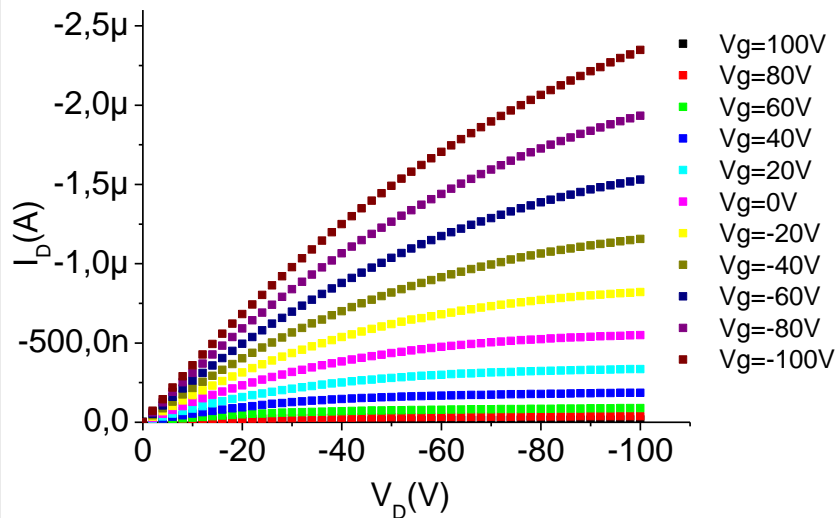
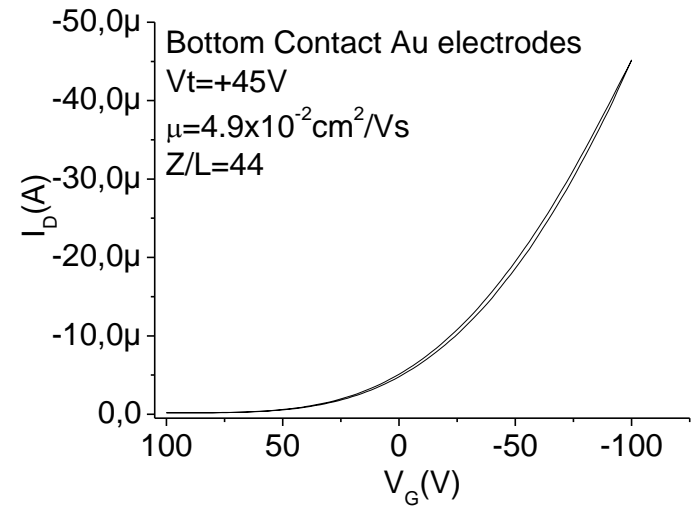
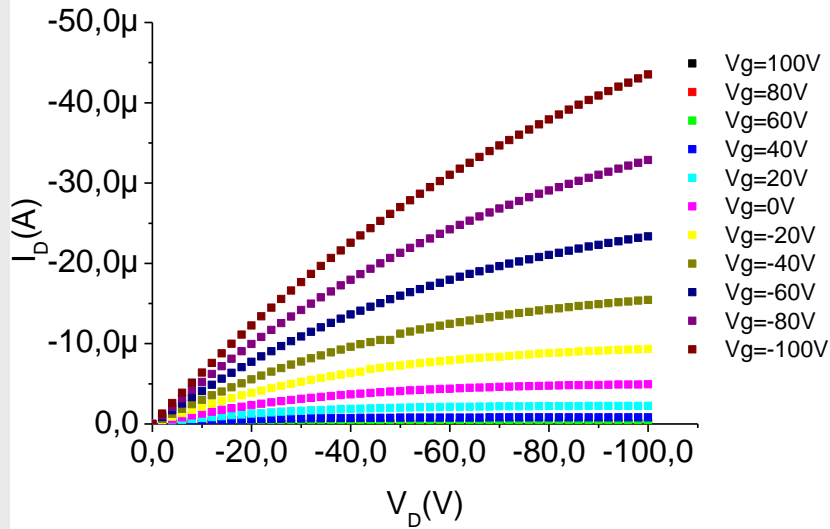
 Silicon (Highly doped)



# 6T OFETs on Mylar

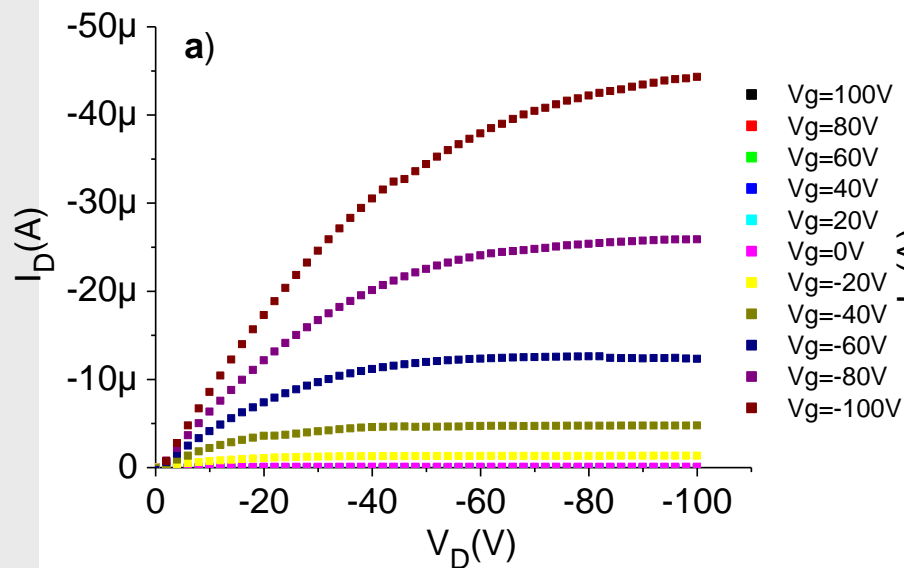


# DH6T OFETs on Mylar

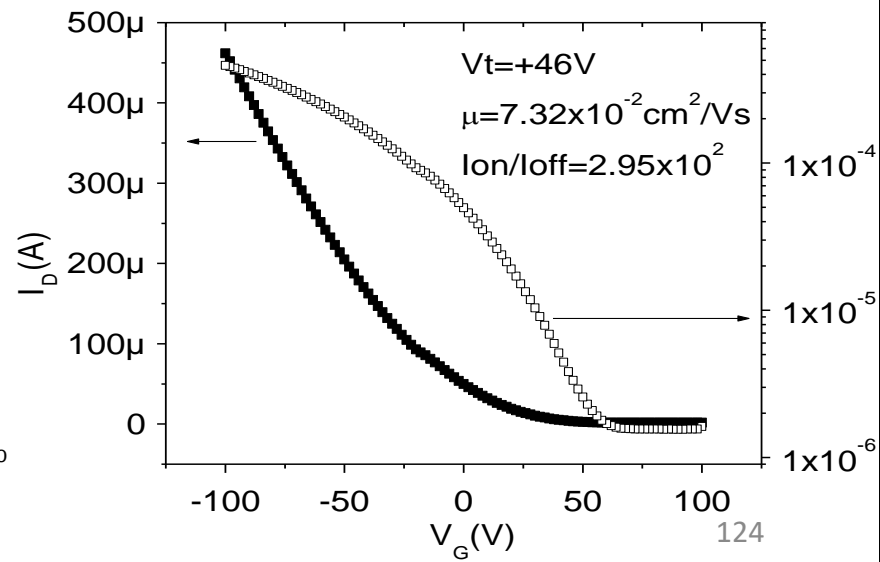
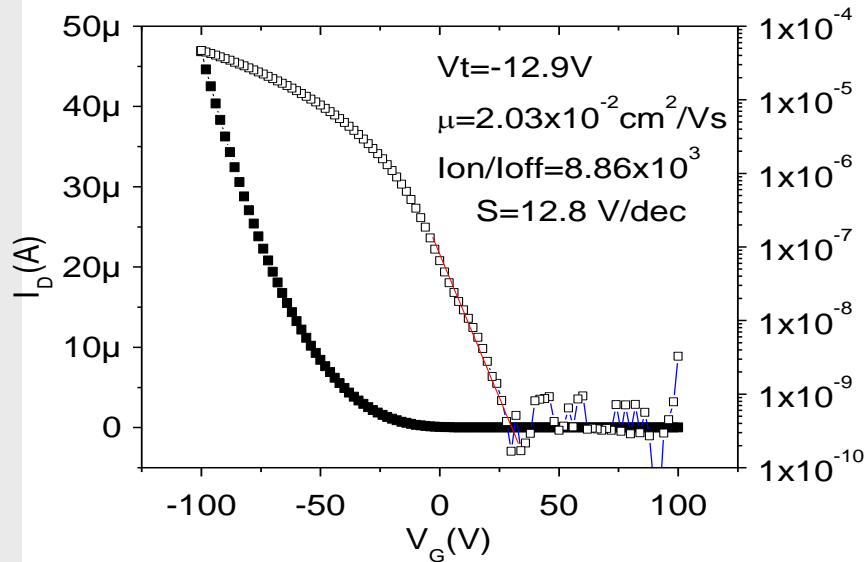
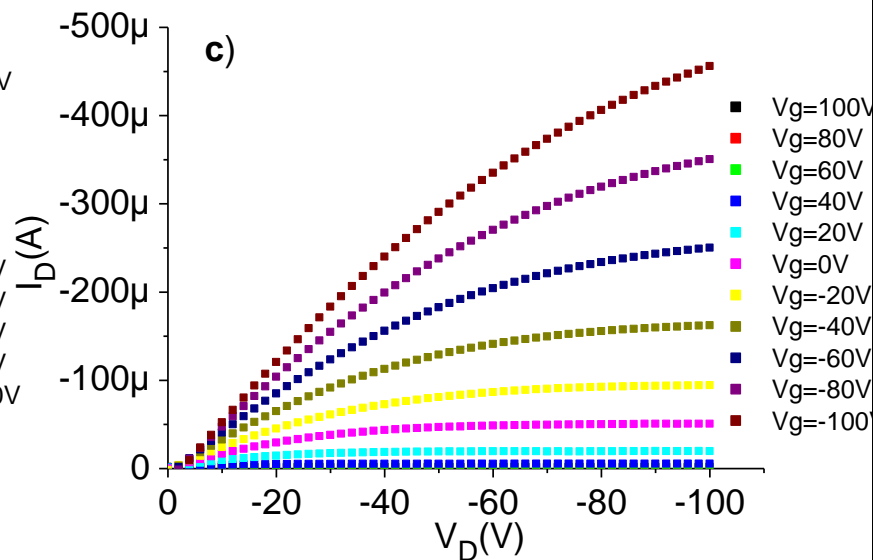


# 6T-DH6T OFETs on Silicon

6T



DH6T





## 6T vs. DH6T: results

Despite their very similar chemical structure, 6T and DH6T semiconductors lead to a very different electrical behaviour.

- Negative threshold voltages for 6T (accumulation device)
- High positive threshold voltages for DH6T (depletion device)
- DH6T devices: higher channel mobility

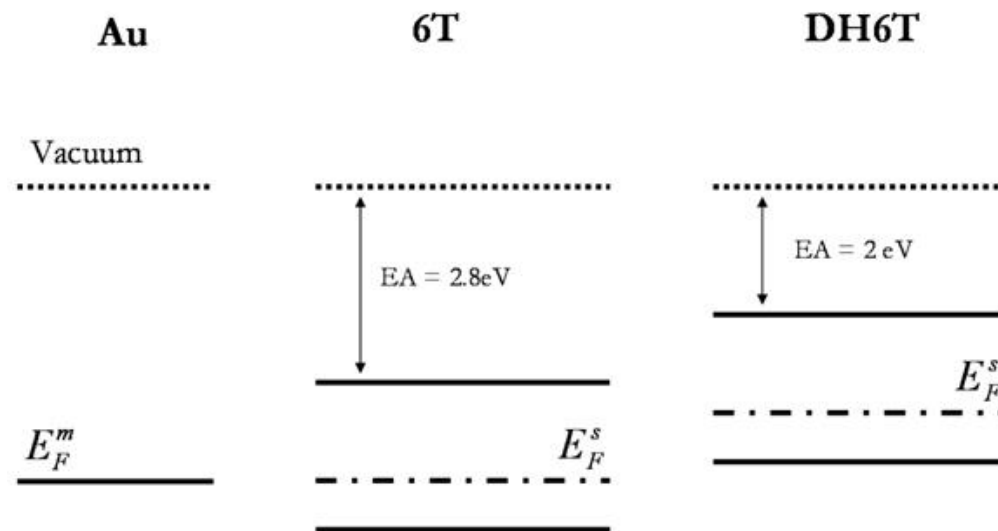
The presence of the alkyl chain as terminal substituents is the only difference between the two materials and has to be responsible for this behaviour.

# Alkyl chain substituents effects

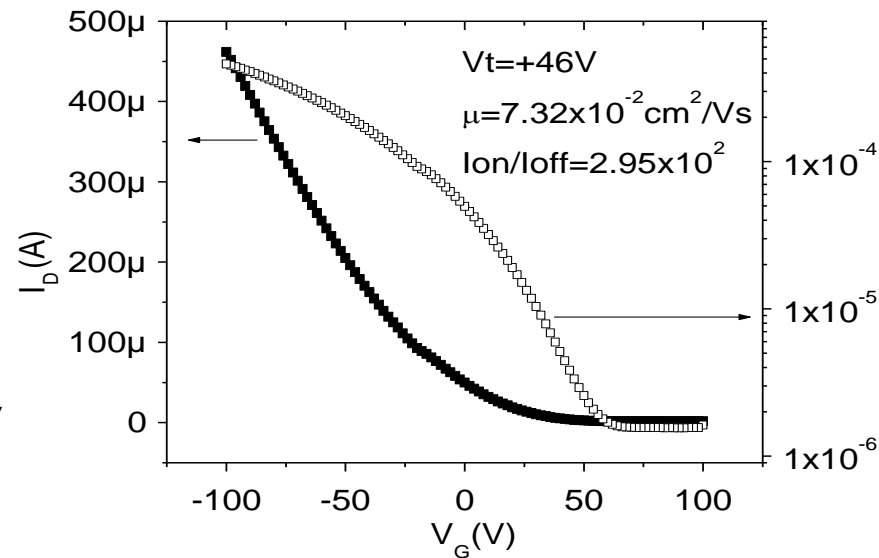
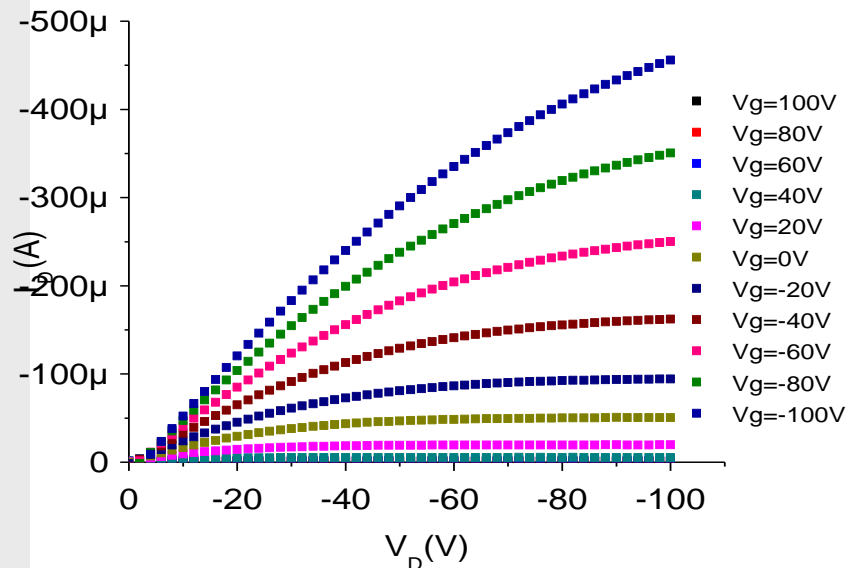
The 0.15 eV lower IE of DH6T results in a **lower hole injection barrier** at the DH6T/electrode interface compared to the 6T/electrode interface.

Consequently, hole injection into the DH6T film is more efficient than for 6T films, enabling a higher hole concentration in the DH6T channel at a certain gate voltage.

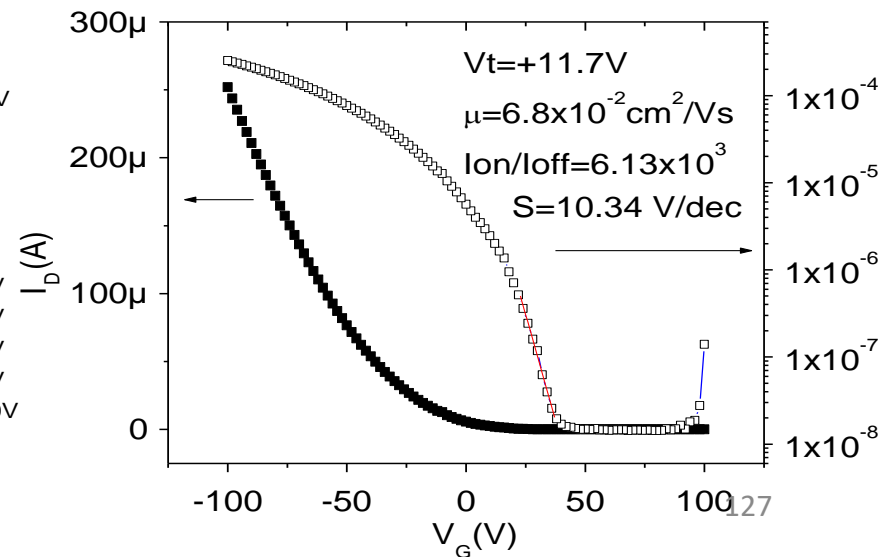
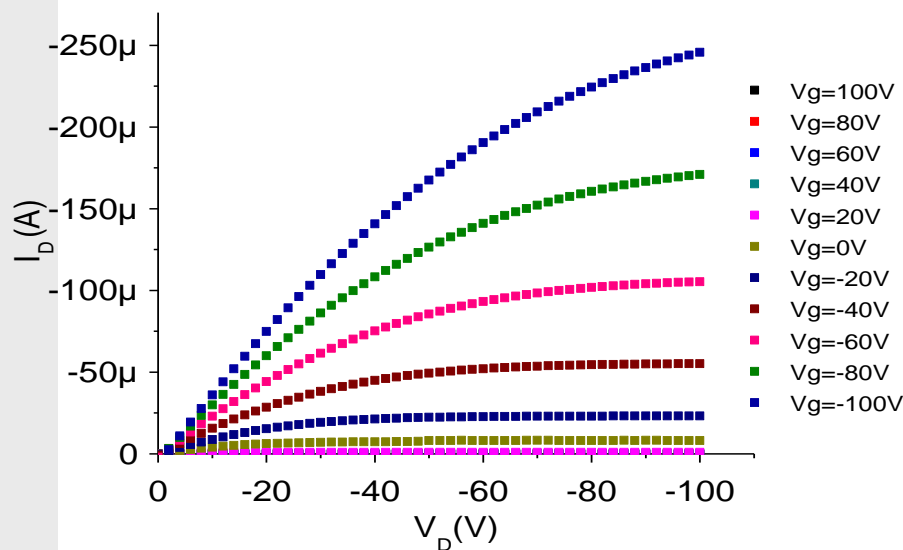
In addition, the lower IE of DH6T implies that **p-type doping by oxygen is more efficient** than for 6T.



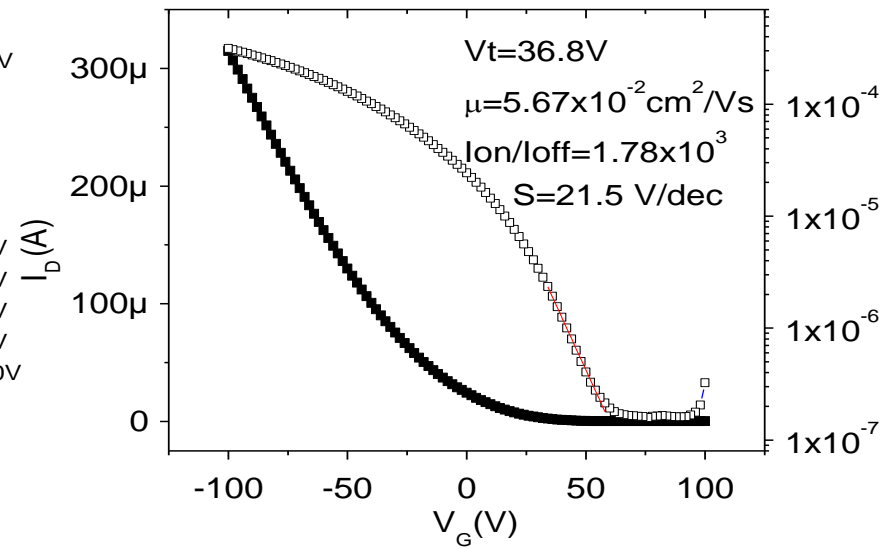
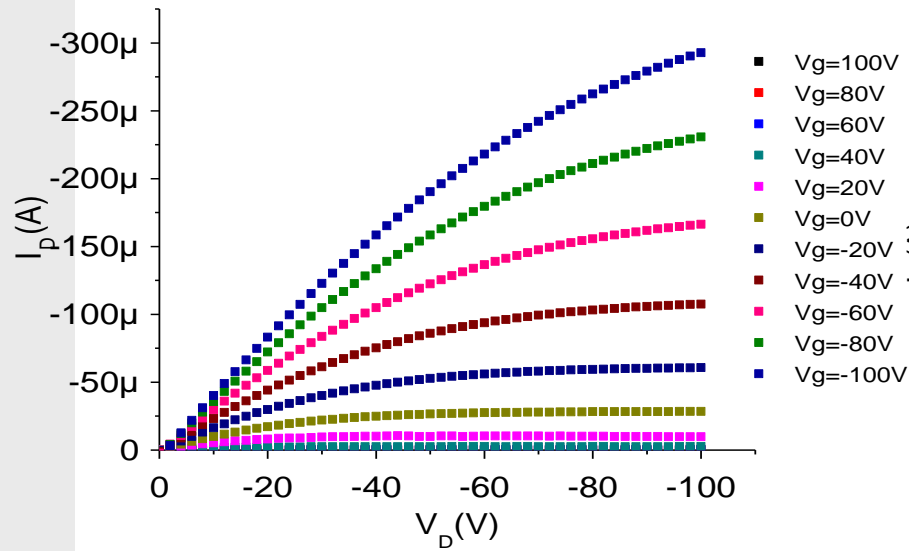
# Oxygen doping process



## Dedoping effect after thermal annealing

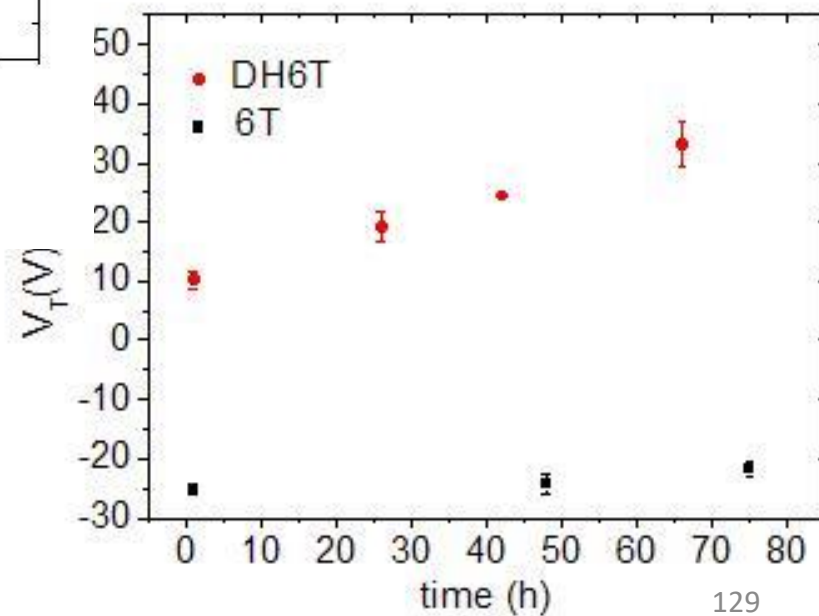
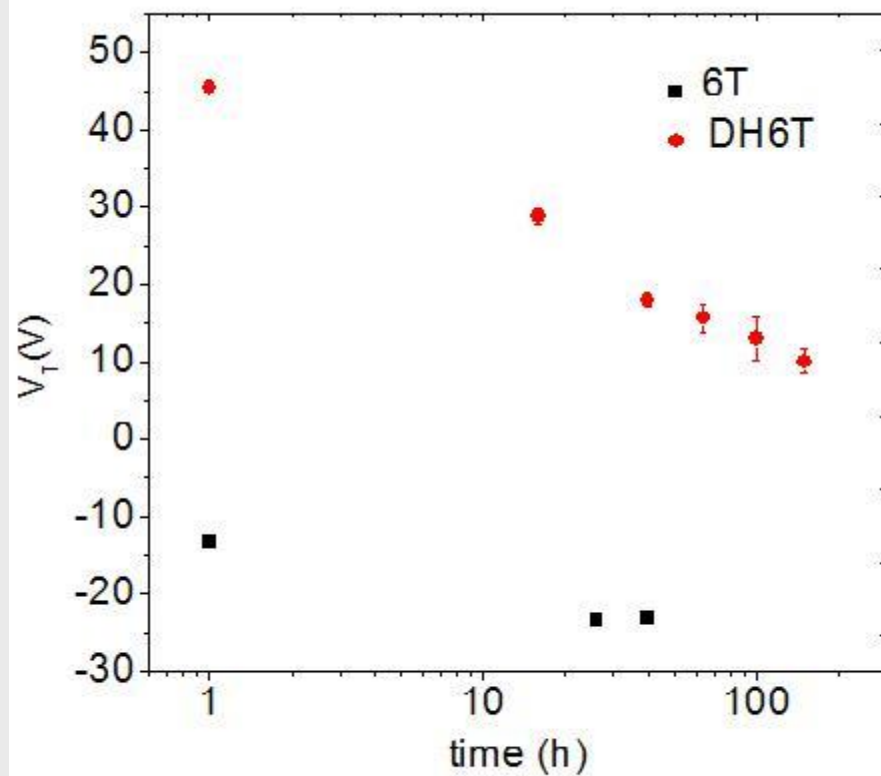


# Oxygen doping process



Redoping effect upon exposure to Air

# Oxygen doping process



# Effects on threshold voltage and mobility

The indirect doping effect is clearly confirmed the experiments reported in the previous slides.

A huge Threshold Voltage shift is visible upon sample annealing in inert gas for both DH6T; moreover, mobility is not significantly affected (within the error bar) and  $I_{off}$  decreases of more of one order of magnitude, again confirming that dedoping is taking place.

Such a Threshold voltage shift was recorded both for 6T and DH6T samples, however, for the latter the voltage shift (as well as the  $I_{off}$  decrease) is much more pronounced and faster, as could be predictable from the lower Ionization Energy of this material.

# Effects on threshold voltage and mobility

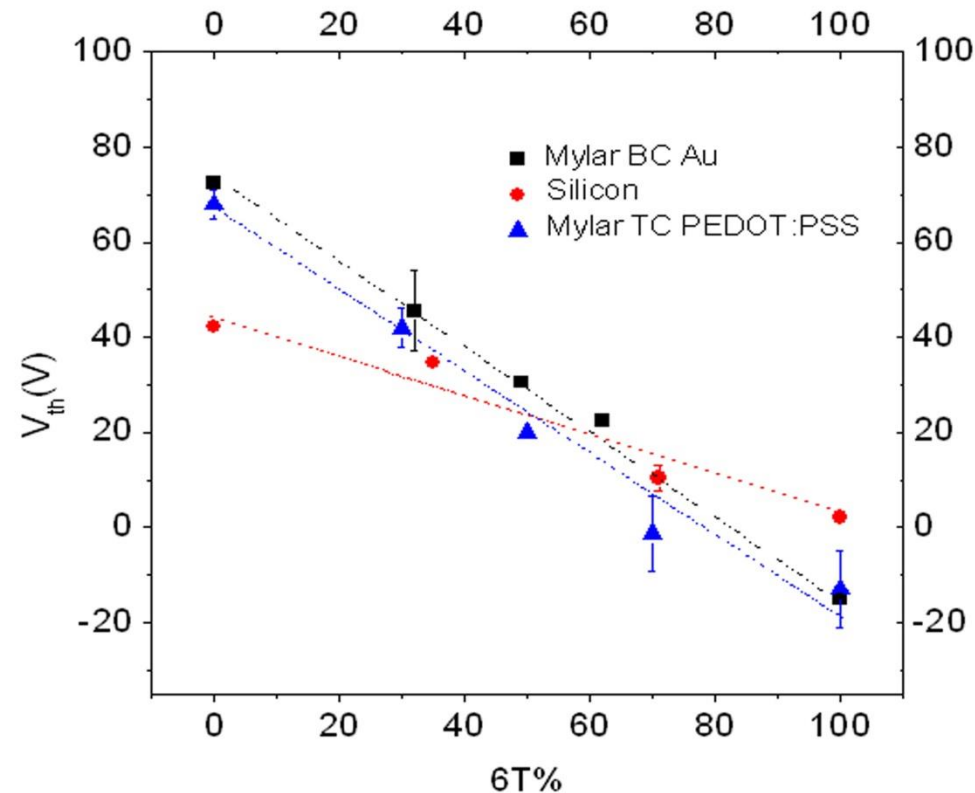
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**What if we co-deposit the two materials?**

# Tuning threshold voltage



$V_T$  varies linearly as function of 6T content within the mixed film



# Degradazione dello strato attivo

In entrambi i casi il processo di diffusione dei contaminanti dipende fortemente dalle caratteristiche morfologiche del film

Le molecole devono poter diffondere attraverso i bordi di grano e raggiungere il canale

Ottimizzazione della morfologia la fine di avere il minor numero possibile di bordi di grano

Alternativa → incapsulamento

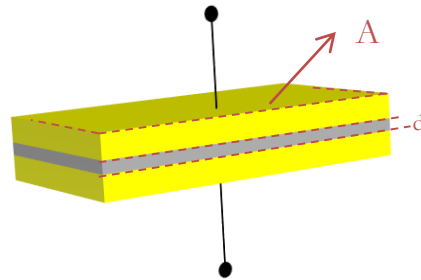
# Low Voltage OFETs

**Piero Cosseddu Ph. D.**

Dept. Of Electrical and Electronic Engineering  
University of Cagliari (Italy)

## Towards low voltage OTFTs

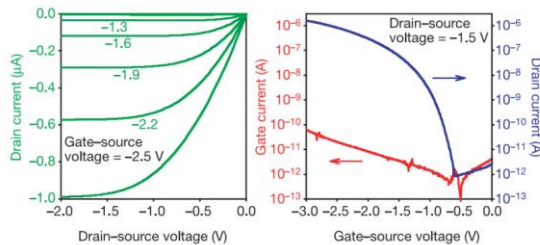
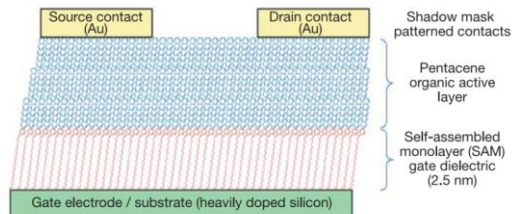
Is it possible to scale down the operational voltages in OTFTs?



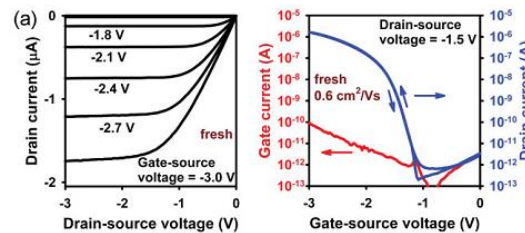
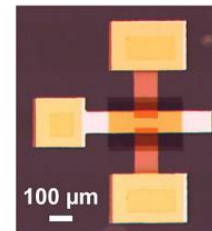
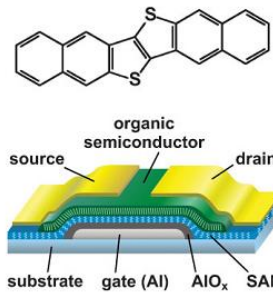
$$C_{ins} = \frac{\epsilon_0 \epsilon_r \uparrow}{d \downarrow} A$$

Increasing gate capacitance is the key factor for realizing low-voltage OFETs

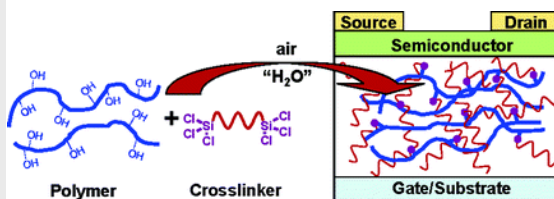
# State of the art – SAMs and Polymers



Halik et al., Nature, 2004, 431

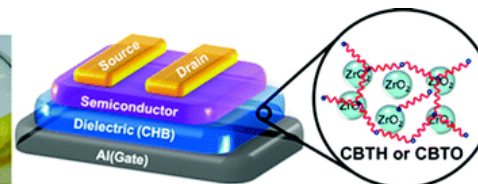
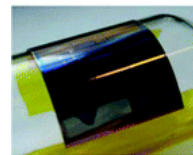


H. Klauk, et al. Nature 445, 745 2007  
 (2007) Zschieschang et al., Adv. Mater. 2010, 22  
 Young-geun Ha, et al. JACS, 2010, 132, 17426



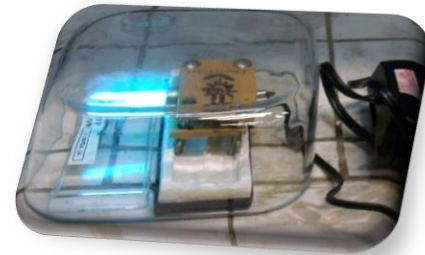
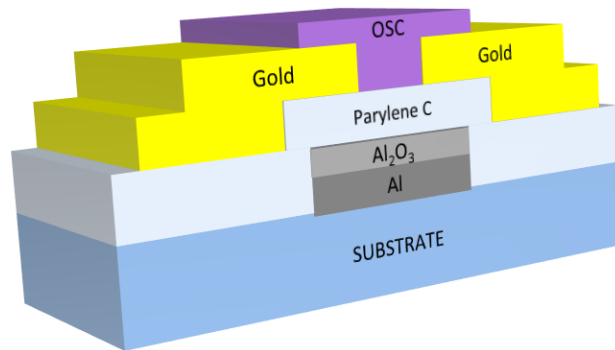
CPB Dielectric

Myung-Han Yoon, H. Yan, A. Facchetti, and T. J. Marks, JACS, 2005, 127, 10388



# Low voltage OTFTs

Bottom gate, bottom contact structure on flexible PET substrate



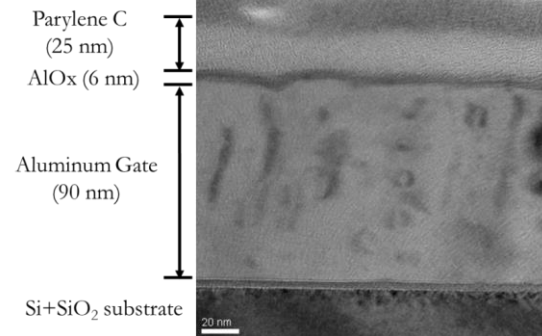
- Gate: Aluminum

- Gate Dielectric:

**AlO<sub>x</sub>** [UV-Ozone treatment at room temperature]

**Parylene C** [deposited by CVD]

[air-stable, robust, biocompatible and resistant to solvents; can be deposited in very thin films]

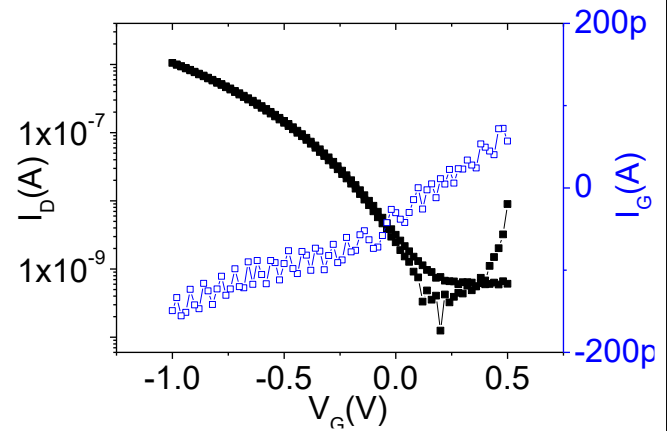
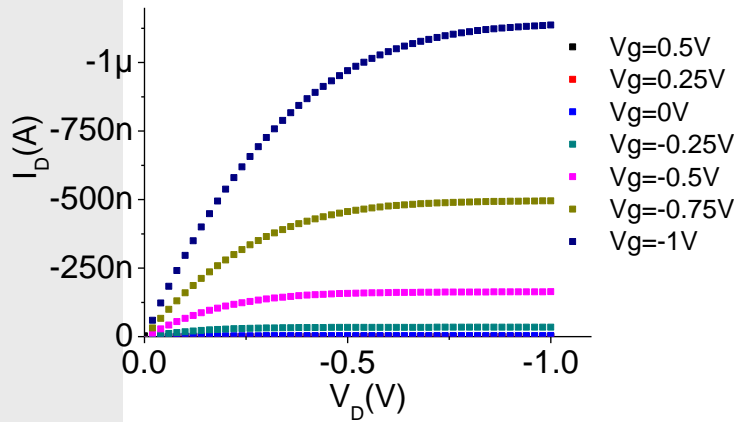


*P. Cosseddu, et al. Appl. Phys. Lett. 100, 093305 (2012)*

# AlOx/Parylene C Double-Layer

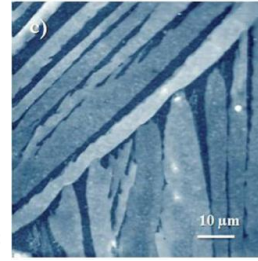
Thermally evaporated pentacene as OS

Insulating Structure	Capacitance [F/cm <sup>2</sup> ]	I <sub>G</sub> [A] J <sub>G</sub> [A/cm <sup>2</sup> ]	V <sub>t</sub> [V]	μ [cm <sup>2</sup> /Vs]	S [mV/dec]	N <sub>t</sub> [cm <sup>-2</sup> eV <sup>-1</sup> ]	OTFTs Yield [%]
AlOx	3.5 E-6	6 E-6 2.9 E-5	-1.2	3.3 E-3	360	1.1 E14	15%
AlOx + 25nm Parylene	1.3 E-7	4 E-10 1.9 E-9	-0.5	6 E-2	350	4 E12	95%



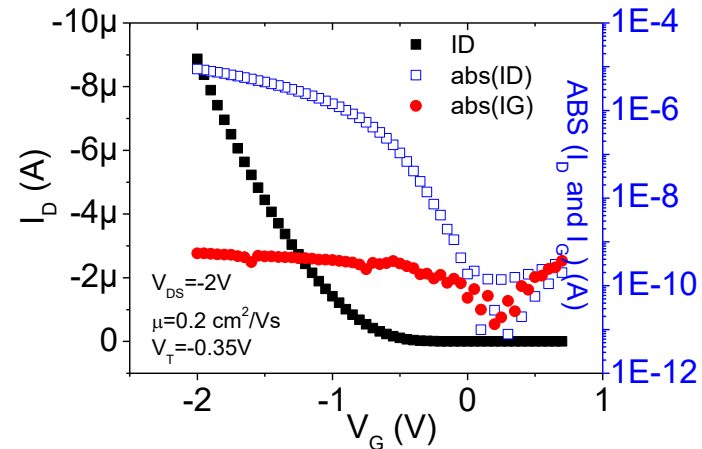
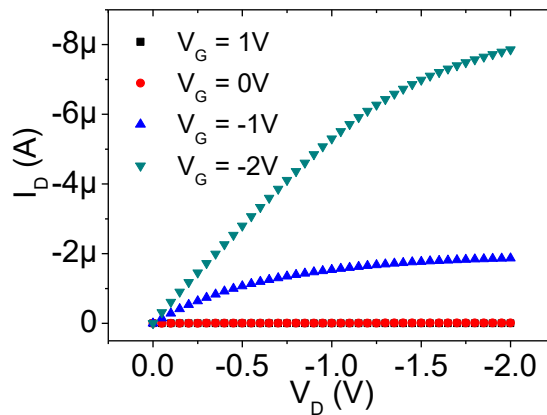
# AlOx/Parylene C Double-Layer

- *High yield*
- *Negligible hysteresis*
- *Very small leakage current*



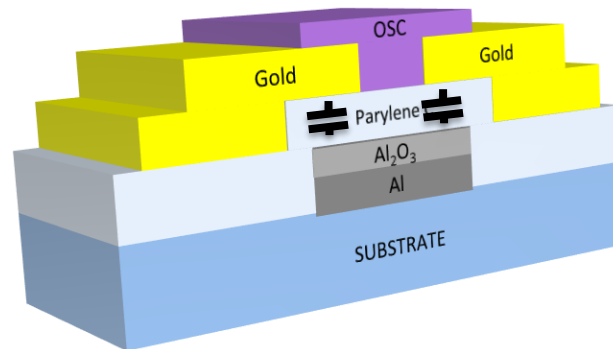
TIPS-Pentacene

Insulating Structure	Capacitance [F/cm <sup>2</sup> ]	I <sub>G</sub> [A] J <sub>G</sub> [A/cm <sup>2</sup> ]	V <sub>t</sub> [V]	μ [cm <sup>2</sup> /Vs]	S [mV/dec]	OTFTs Yield [%]
AlOx + Parylene	1.3 E-7	4 E-10 1.9 E-9	-0.2/-0.4	0.3	150	99%



## High Capacitance issues

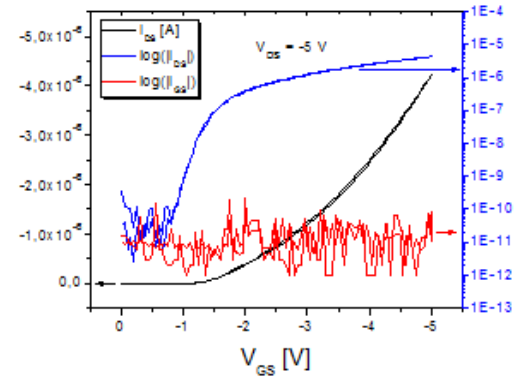
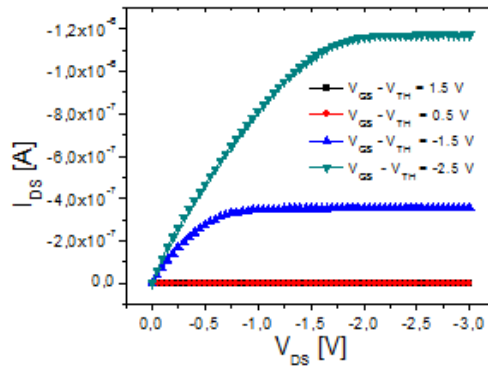
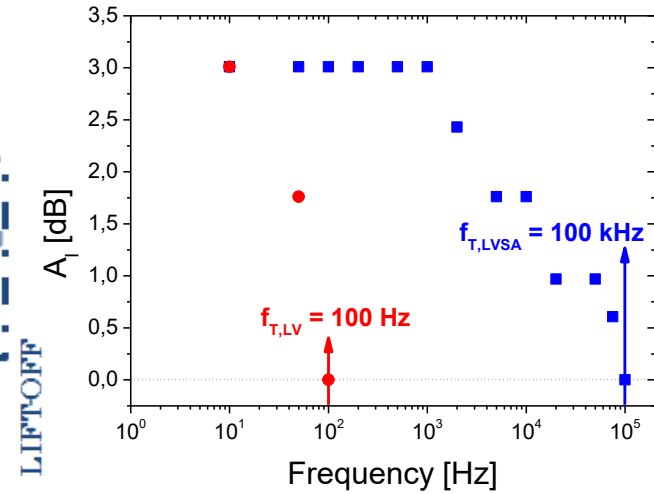
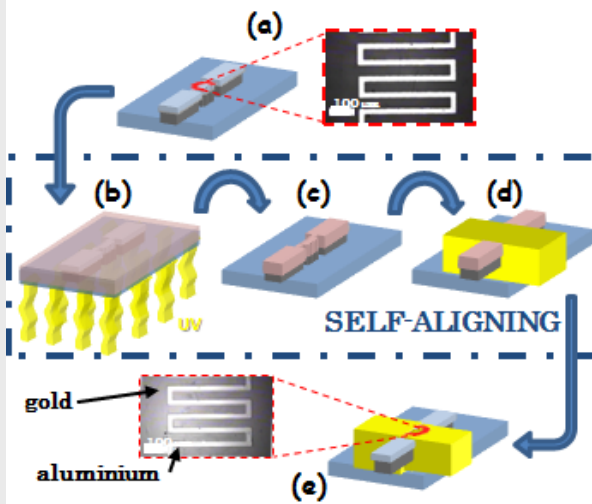
- *High gate dielectric capacitance means high parasitic capacitances*
- *Overlapping between Source, Drain and Gate*



- *How to deal with this?*

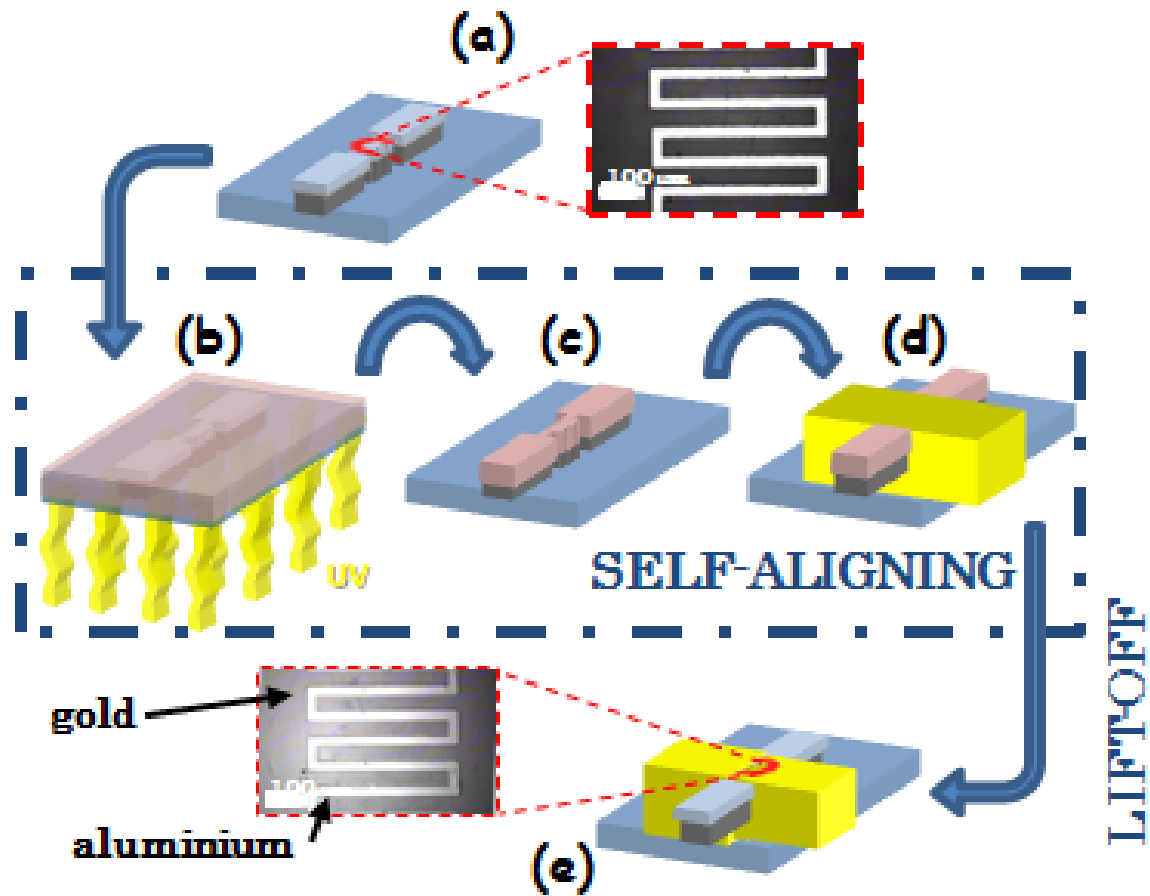


# Self-alignment process

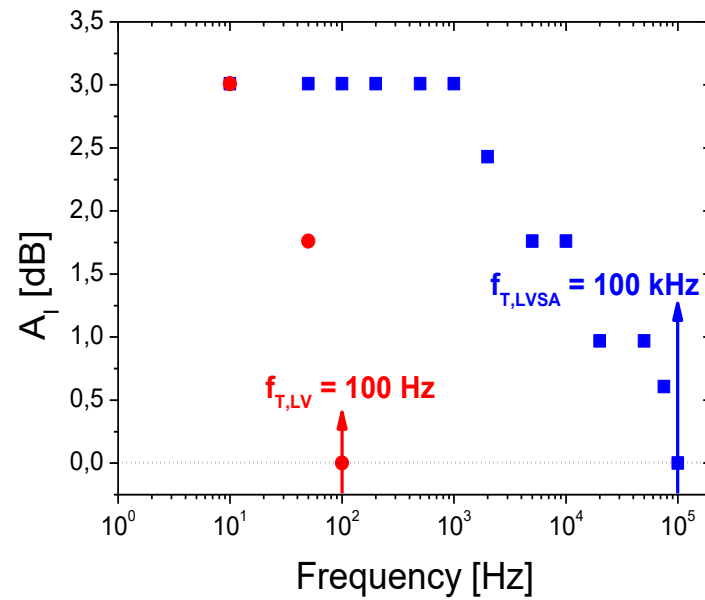


*S. Lai, P. Cosseddu, G.C. Gazzadi, M. Barbaro e A. Bonfiglio, Org. Electr. 14, 754-761 (2013)*

# Self-alignment process

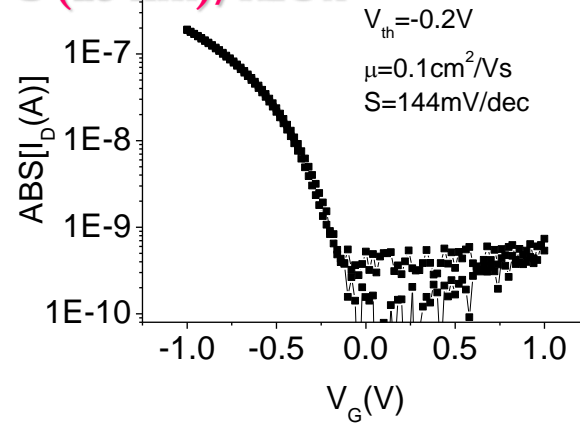
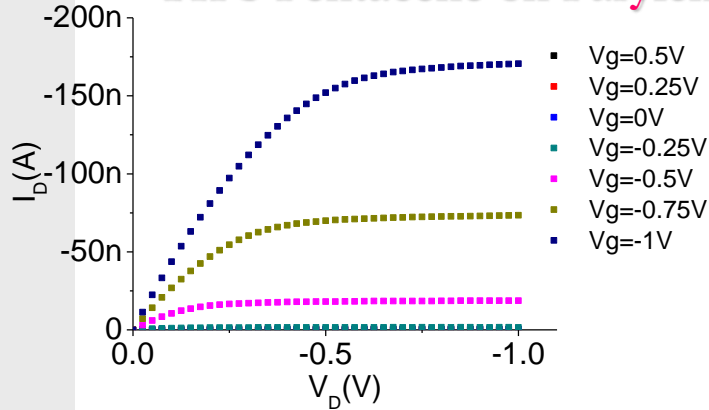


# Self-alignment process

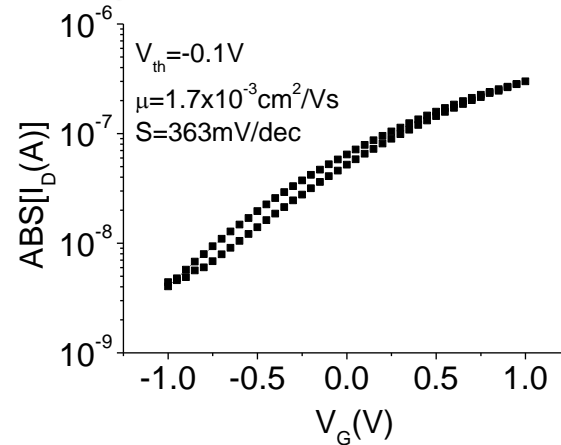
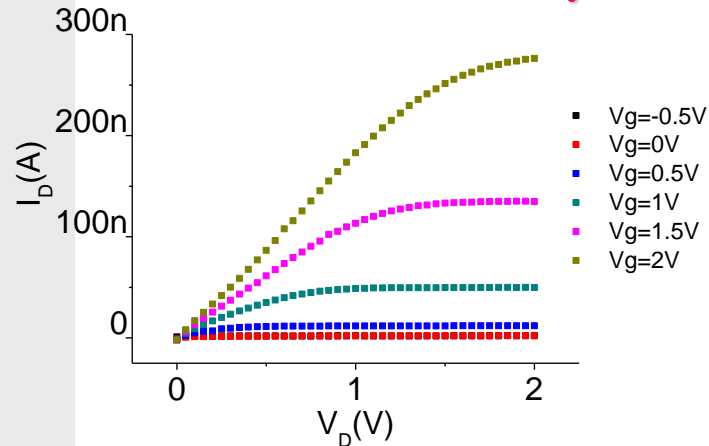


# Low Voltage OFETs: Solution-Processable OSC

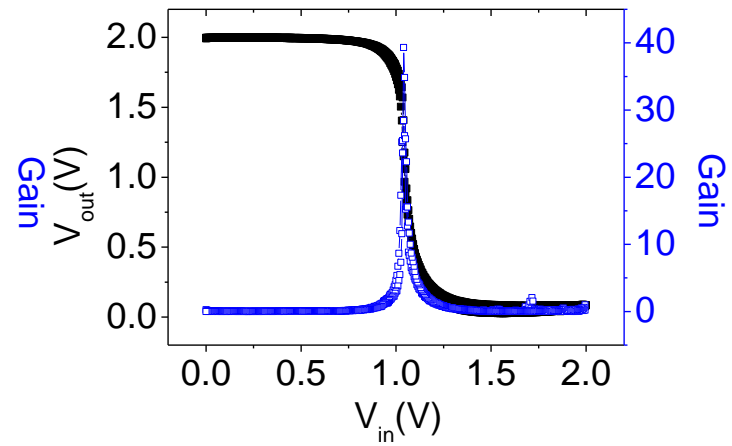
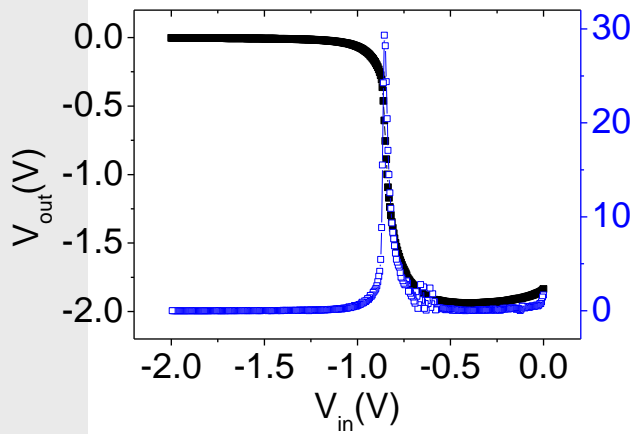
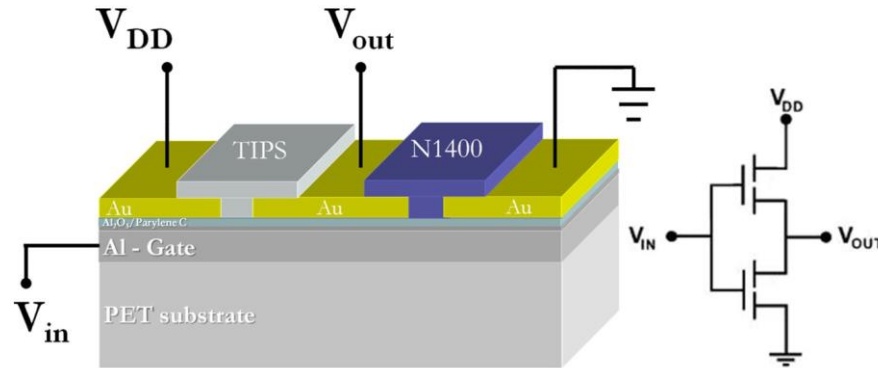
## TIPS Pentacene on Parylene C (25 nm)/AlOx



## N1400 on Parylene C (25 nm)/AlOx



# Low Voltage Complementary inverters



*paper to be submitted*

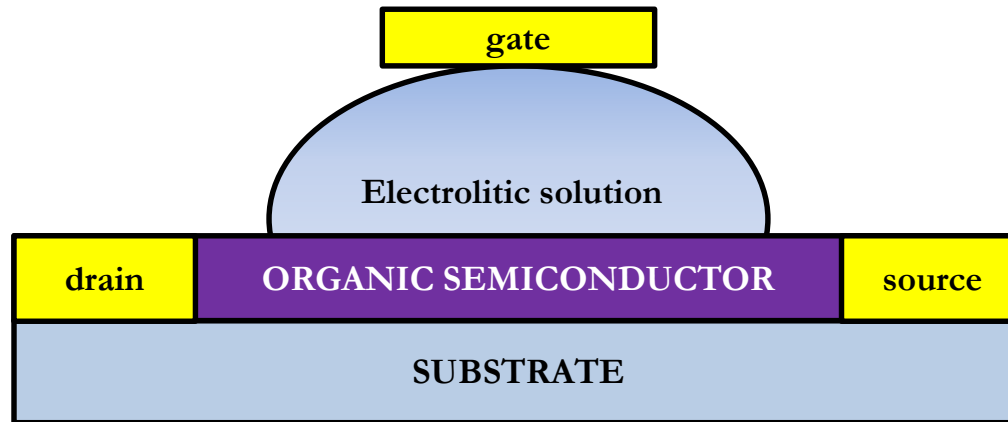
# Electrolyte Gated Organic Field Effect Transistor EGOFET

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Dept. Of Electrical and Electronic Engineering  
University of Cagliari (Italy)

# EGOFET: introduction

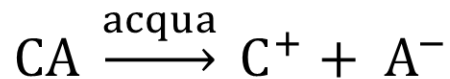
Electrolyte-**G**ated **O**rganic **F**ield-**E**ffect **T**ransistors



An *electrolytic solution* is a system composed by:

- a *solvent* in the liquid phase (generally water);
- a *solute* it can be dissociated in an ionic state

*Strong Electrolytes*: the fully dissociate

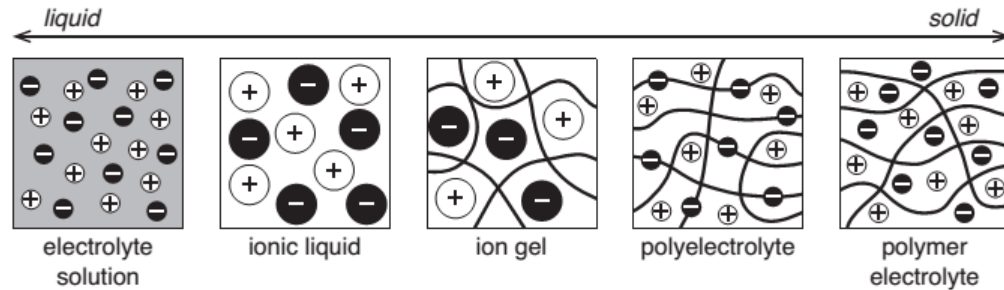


*Weak Electrolytes*: only partial dissociation (reaction at the equilibrium)





# Electrolyte



**Figure 3.1** Schematic illustrations of different types of electrolytes, ordered from left to right by their physical appearance.

- **Electrolytic solutions**
- **Ionic liquids**
- **Ion gels**
- **Polyelectrolytes**
- **Polymer electrolytes**

## Electrolyte

### Electrolytic solutions

**Salt solved in a liquid**, generally a polar solvent

**Acetonitrile**, much more stable it does not give rise to chemical reactions

**Also water is an electrolyte**,  $\text{H}^+$  e  $\text{OH}^-$  ions, very weak electrolite

## Electrolyte

### Ionic liquids

It is a salt in the liquid phase

Melting T below 100°C

Can give rise to **very high conductivity**

Among the most employed electrolytes

## Electrolyte

### Ion gels

The latter examples are not very suitable for the realization of solid state devices, per cui vengono generalmente **trattati** in modo da essere immobilizzati, per esempio **co-polymers to form gels**

Lower concentration of ions, lower conductivity

## Electrolyte

### Polyelectrolytes

**Polymers containing an alectrolitic group in their chain**

Such groups can disassociate in solution

The polymer gets ionized and there will be the counterions in solution

## Electrolyte

### Polymer electrolytes

It is a solid electrolyte!

**Salt distributed in a polymeric matrix**

PEO polyethyleneoxide, the most employed

Very low conductivity, but can be employed for the fabrication of solid state devices

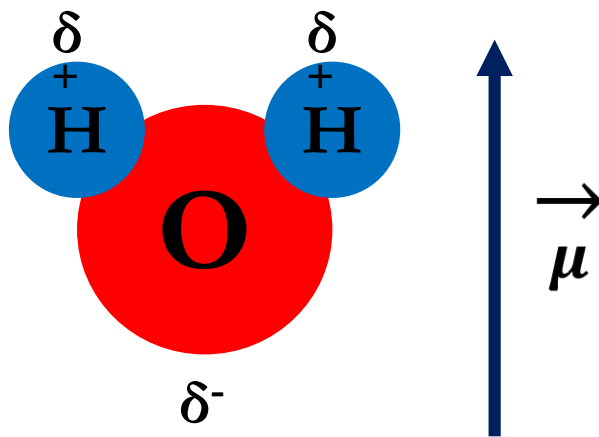
Es. flexible batteries

*Polar molecules:* have a permanent dipole moment due to the different electronegativity of the atoms.

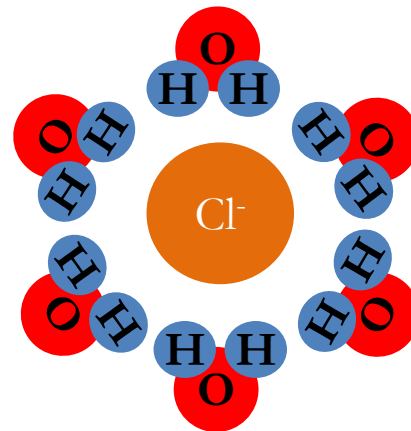
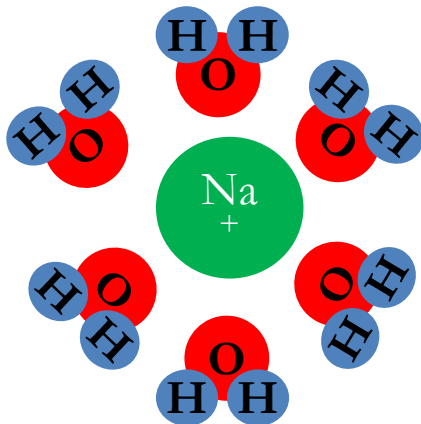
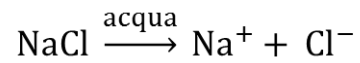
Example: water molecule (Pauling scale)

$$\chi(\text{O}) = 3.44$$

$$\chi(\text{H}) = 2.20$$



*Solvation:* interaction between the ions generated by dissociation and the solvent molecules. Each ion get surrounded by the solvent molecules





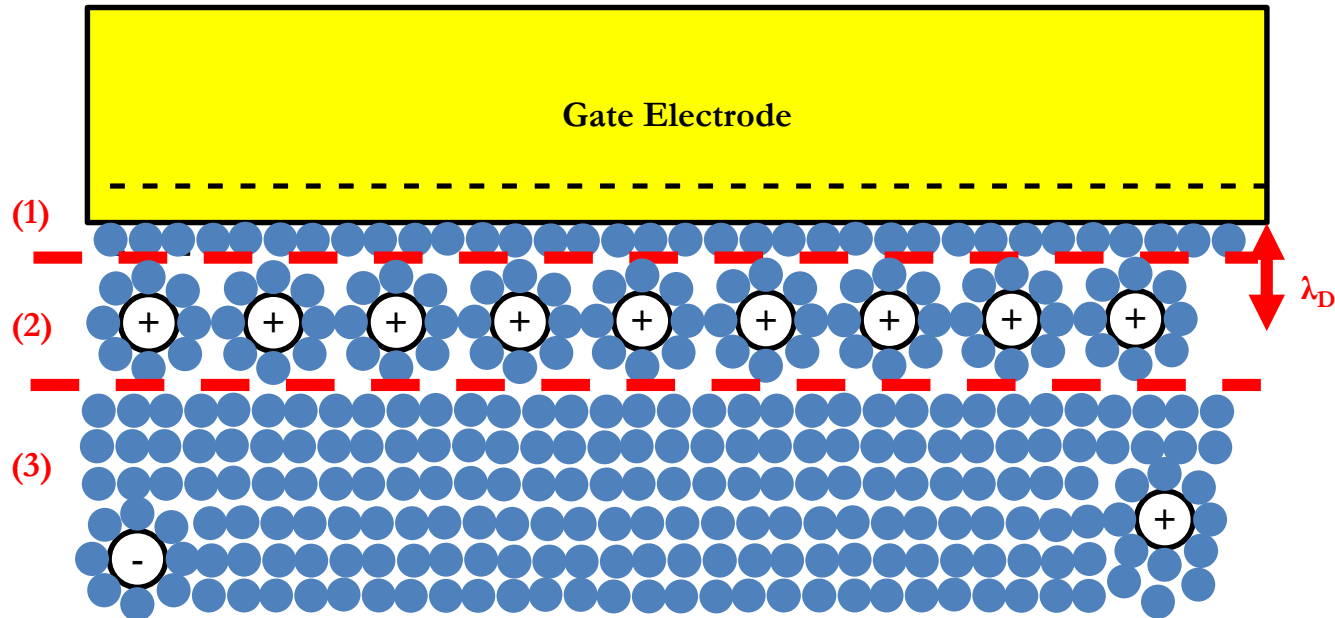
## Electrolyte

Electrolytes are ion conductors and electron insulators

Upon contact with a charged ionblocking electrode, the electric potential difference between the electrode and the electrolyte gives rise to the **formation of a region consisting of two parallel layers of positive and negative charges called the electric double layer (EDL)**

The Helmholtz layer comprises **adsorbed dipole oriented solvent molecules** and **solvated ions**, which are assumed to approach the electrode at a distance limited to the radius of the ion itself and a single shell of solvated ions around each ion

# Electrolytic Capacitance



- (1) Helmholtz layer
- (2) External Helmholtz layer
- (3) «bulk»

$\lambda_D \rightarrow$  Debye length ( $\sim \text{\AA}$ )

## Electrolyte

Thus, the Helmholtz layer and the electrode are **analogous to a parallel plate capacitor** separated by a distance of few Ångströms

**The capacitance of the entire double layer is typically in the order of tens of  $\mu\text{F cm}^{-2}$**

**Very high capacitances lead to low operating voltages**

# Electrolytic Capacitance

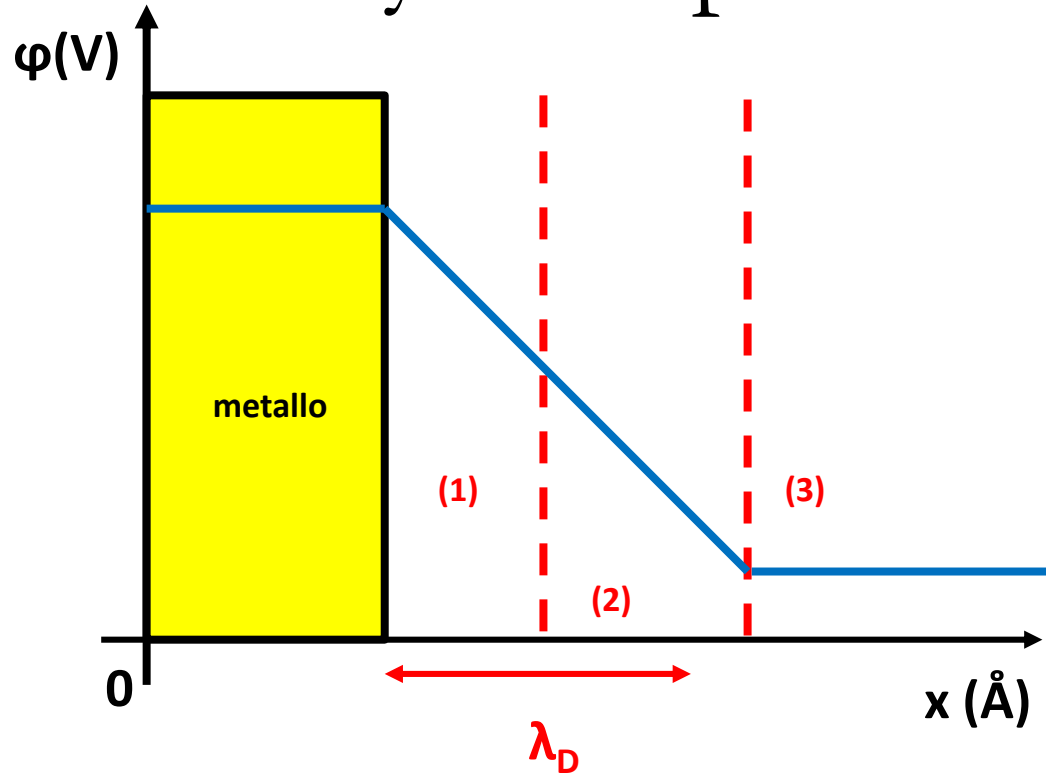
$$\frac{d^2\varphi(x)}{dx^2} = -\frac{\rho(x)}{\varepsilon} \quad \text{Poisson equation}$$

$$q_{dl} = \int_0^{+\infty} \rho(x) dx \quad \text{Double layer charge}$$

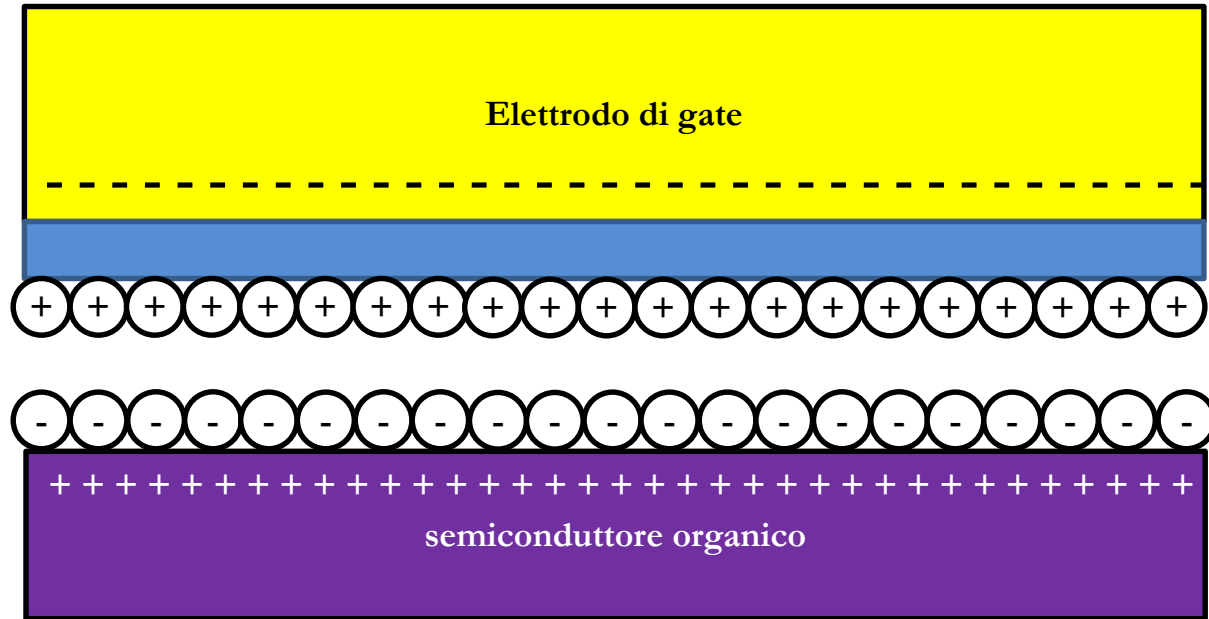
$$C_{dl} \cong \frac{\varepsilon}{\lambda_D} A \quad \text{Double layer capacitance}$$

*EGOFET capacitance is order of magnitude higher than normal OFETs ones ( $10 - 100 \mu\text{F} \cdot \text{cm}^2$  vs  $10 \text{ nF} \cdot \text{cm}^2$ ).*

# Electrolytic Capacitance

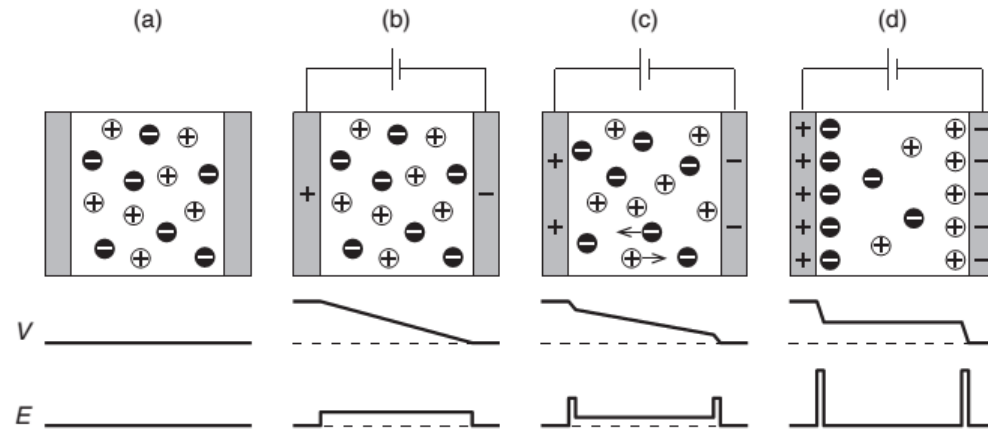


# EGOFET: working principle



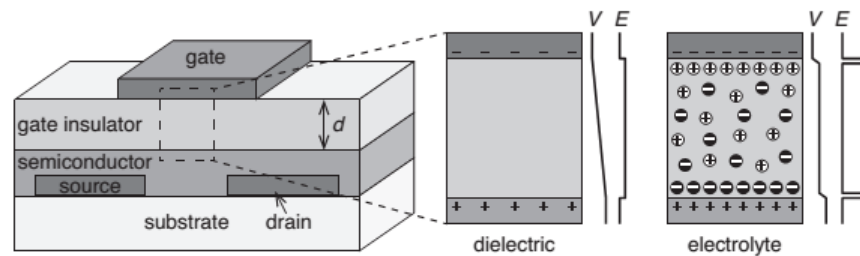
Holes concentration increase at the electrolyte/semiconductor interface.

# EGOFET



**Figure 3.4** Schematic illustrations of the charge distribution, electric potential ( $V$ ) and electric field ( $E$ ) in the electrolyte layer of an electrolytic capacitor during charging. (a) The ions are evenly distributed when no voltage is applied. An applied voltage will induce a redistribution of the charges in the electrolyte. The situation in the electrolyte (b) before, (c) during and (d) after ionic relaxation is shown.

# EGOFET



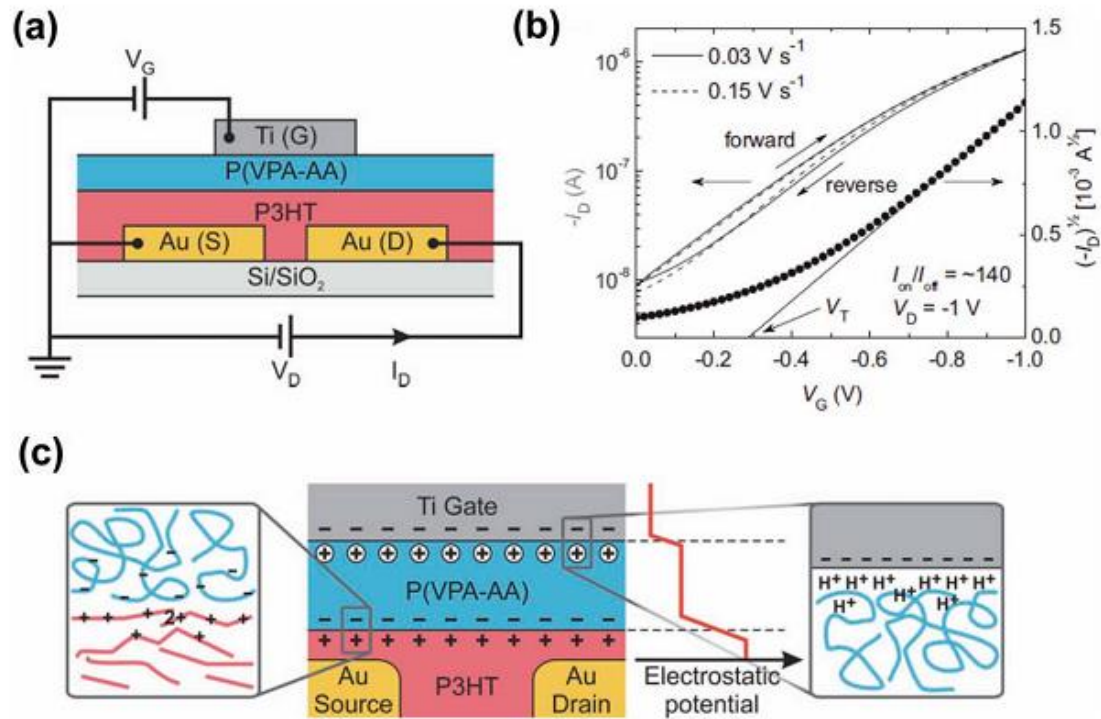
**Figure 4.6** Schematic cross section of an organic thin-film transistor and illustrations of the voltage ( $V$ ) and electric field ( $E$ ) distributions in a dielectric and an electrolytic gate insulator when a negative gate voltage is applied.

In a normal dielectric layer the electric field varied linearly within the film.

In an electrolytic layer the field is much more intense at the interfaces and almost negligible in the bulk.



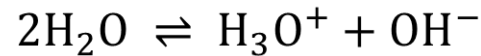
# L'EGOFET



# WGOFET

We do not necessarily need a strong electrolyte, also water can play the game

Water auto-protolysis:

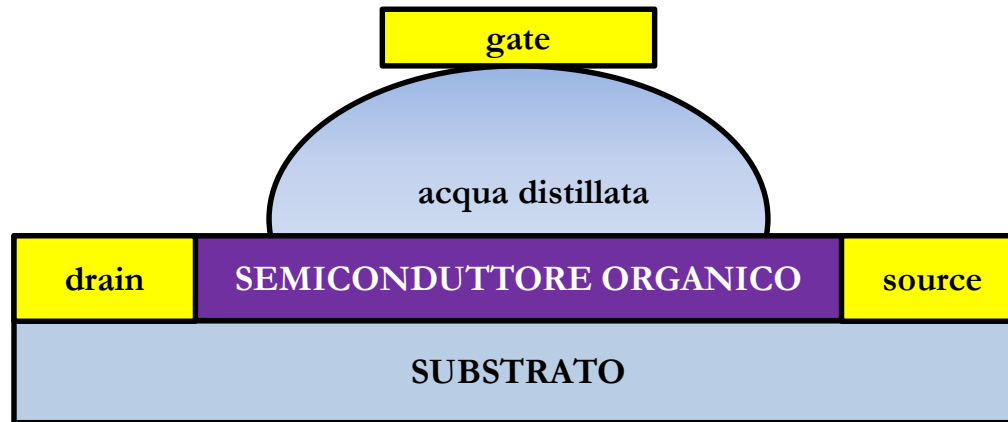


At  $T = 300 \text{ K}$

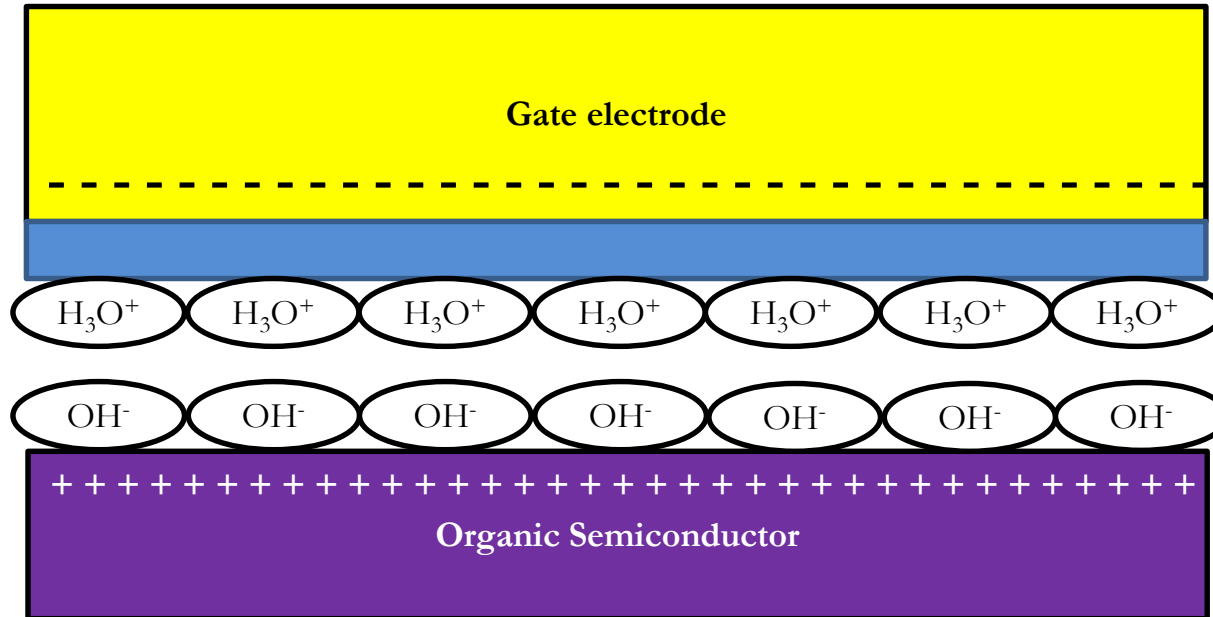
$$[\text{H}_3\text{O}^+] = [\text{OH}^-] = 10^{-7} \text{ M}$$

# WGOFET

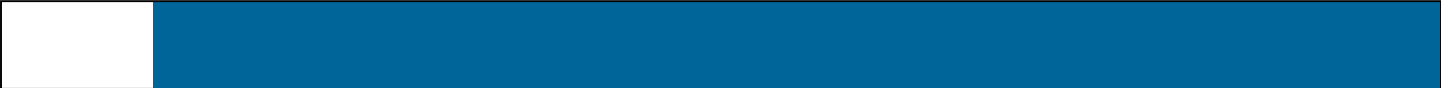
Water – Gated Organic Field-Effect Transistor



# WGOFET



Similarly to normal EGOFET the ions present in water can lead to the formation of the double layer and allow to gate the transistor



# **Organic Electro-Chemical Transistors (OECTs)**

## OECT: Introduction

We can intentionally modify the conductivity of some polymers by electrochemical doping

If a reversible redox process can be established, the polymer can pass from a low conductance state to a high conductance one

This process can be employed for the fabrication of low voltage organic transistors:

### **Organic Electro-Chemical Transistors**

## OECT: Introduction

- Possono essere fabbricati su larga area
- Da fase liquida
- Tecniche a basso costo → Printing
- Materiali a basso costo → all plastic
- Basse tensioni di pilotaggio
- Basse Temperature di processing → substrati plastici
- Effetto elettrocromico → Display
- Se opportunamente modificati → sensing

## OECT: Introduction

OECT work using organic polymers where charge transport is driven by electrons and also ions

Among them → PEDOT:PSS

Reversible redox process

This redox process is actually a doping and dedoping process of the polymer molecule that leads to an increase or decrease of carrier concentration → modulation of the conductivity



# OECT: Introduction

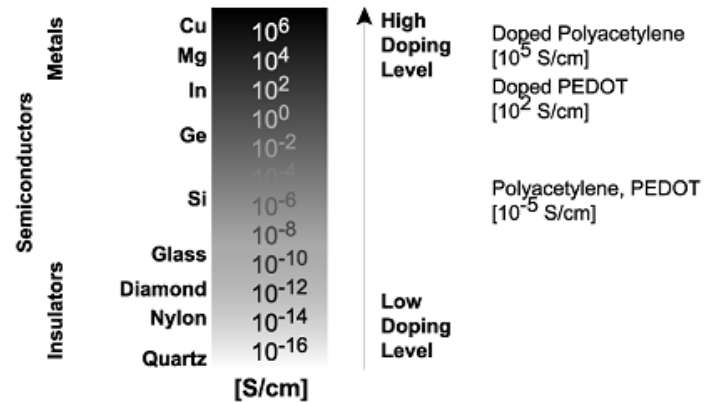


Figure 2. Conductivity levels of polyacetylene and PEDOT. In comparison, conductivity of some other materials is given, from very good insulators to metallic conductors.

## OECT: Introduction

We already talked about doping before:

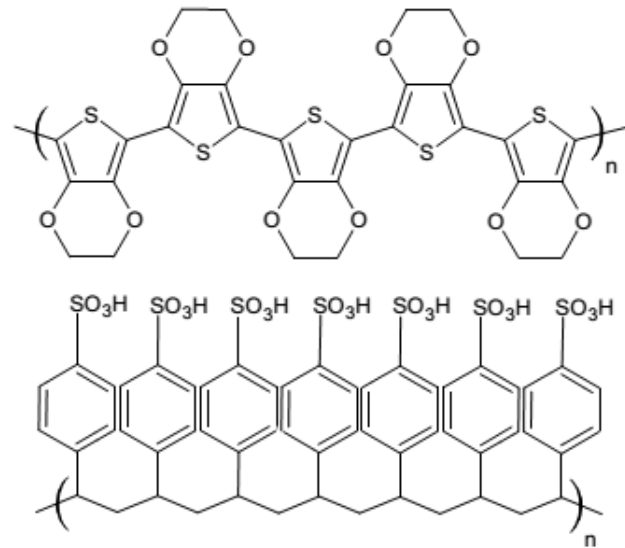
- Chemical doping
- Electrochemical doping
- Photo-induced doping
- Charge injection doping

## Doping in conjugated molecules

Doping can be performed also chemically. For instance, it is possible to intentionally include in the molecule some functional groups which are electro-donors or electron-acceptors

**PEDOT** is an organic semiconductor,

**PSS** allows doping it and significantly increase its conductivity



# Conductive polymers

PEDOT:PSS is formed by two different molecules, PEDOT and PSS

PEDOT is polythiophene conjugated polymer

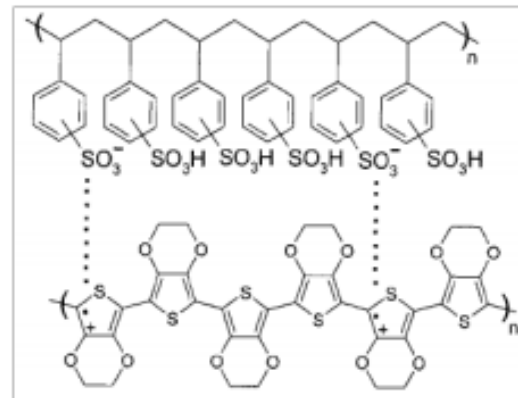
It is a semiconductor, and it is not soluble

PSS is a water soluble electrolyte, it oxidized the PEDOT, removing an electron from its backbone

Therefore, PEDOT is positively charged, whereas PSS is negatively charged

Creation of a polar blend (solution) between the two molecules

PEDOT<sup>+</sup>:PSS<sup>-</sup>



## Conductive polymers

In tohe words, **PSS acts as a dopant**, leading to significantly increase the number of holes in the PEDOT backbone

However PSS is an insulator!

This means that depending on the way the PSS is finally deposited on the film dramatically influences the charge transport within the film

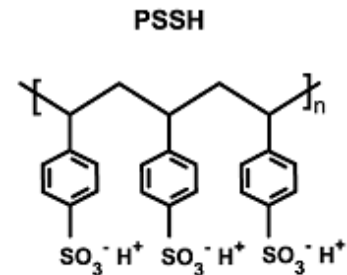
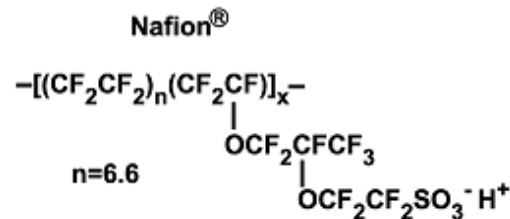
PSS for instance can create insulating islands surrounding the PEDOT molecules, thus not allowing the created charge carrirs to move freely → bad percolation

This issue can be significantly overcome by using post treatment processes, i.e. using some additives and thermal treatment to re-create the film morphology

## L'electrolytes

Different electrolytes can be used both in the solid or liquid phase

- Nafion
- Polys(tyrene sulfonic)acid (PSSH)
- Poly(ethylene oxide) (PEO)
- Poly(vinyl alcohol) (PVA)



# Electrochemical transistor

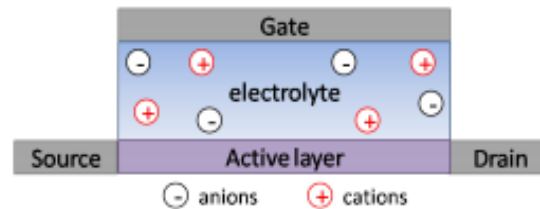
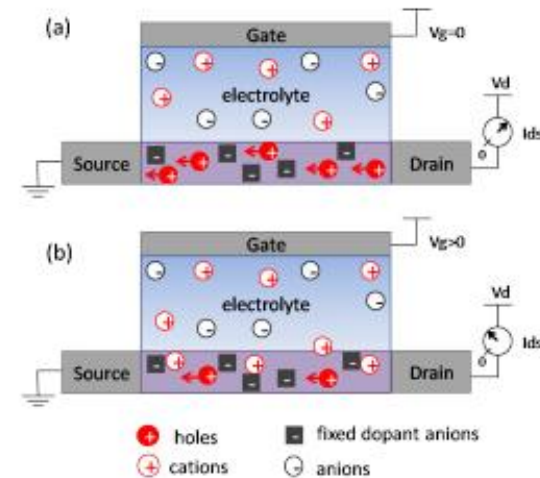


Figure 3.1: Schematic view of an OEET.



If PEDOT:PSS is p-type doped (mobile holes, fixed ions). Let's ground the source electrodes and apply a certain voltage to the drain ( $V_d$ ).

If no gate voltage is applied I'll measure PEDOT:PSS conductivity

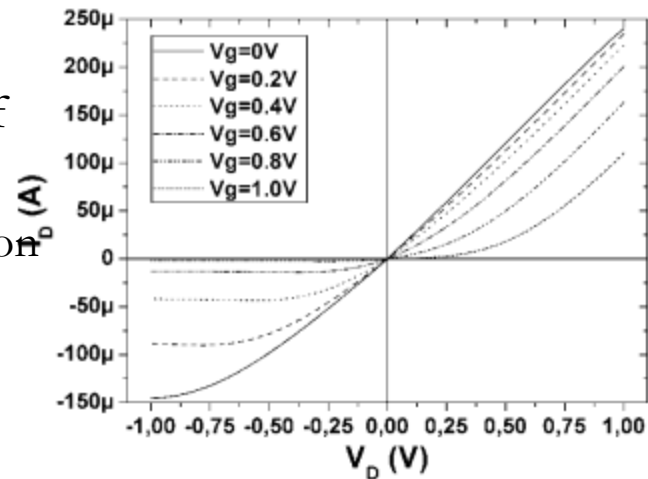
By applying a certain gate voltage I can electrochemically dope/dedope the PEDOT:PSS and modulate its conductivity.

# OECT

When a positive  $V_{gs}$  is applied, the  $M^+$  cations of the electrolyte are pushed into the semiconductor

Such ions will induce a **de-doping (reduction)** therefore → **decrease of the output current**

- Field effect induced by conductivity modulation of the channel
- OECT work in the depletion regime!
- Low working voltages



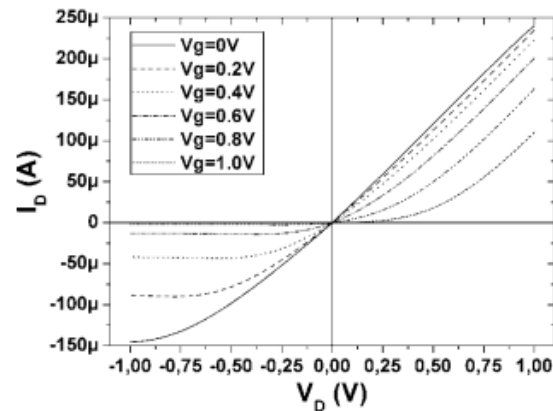


## OECT

when  $V_d < 0$  a portion of the channel can be entirely dedoped, this happens when the concentration of injected cations is equal to the concentration of initial dopants

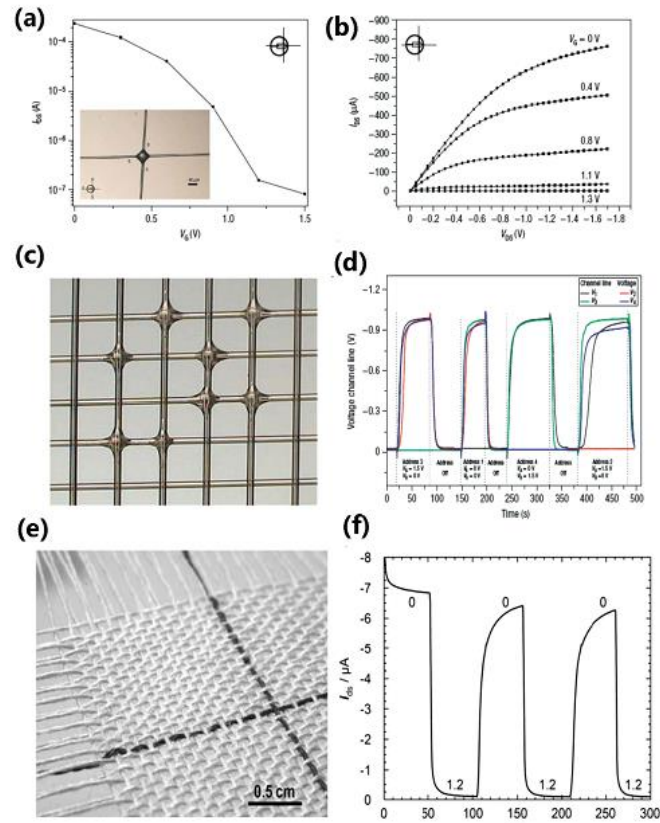
Therefore, if I keep on increasing drain voltage, **current will tend to saturate and the channel pinch off can be reached**

**If gate electrode is ground connected or negatively biased** PEDOT:PSS channel can be doped again and current will increase again



# OECT

## OECT on yarns



## Electrochromic effect

- Doping a polymer means induce polarons into the molecule
- Localized states into the band gap changing the absorbance/emission spectrum of the molecule
- Lower energy absorption can be obtained
- Absorption peak towards higher wavelengths
- The film becomes almost transparent
- Color change!

